

David Mascali, G. Castro, S. Biri, R. Rácz, J. Pálinskás, C. Caliri, L. Celona, L. Neri, P. Romano, G. Torrìsi, and S. Gammino

Electron Density and Temperature measurements
in Electron Cyclotron Resonance Ion Source
plasma by means of X-ray spectroscopy and X-
ray imaging

Outline

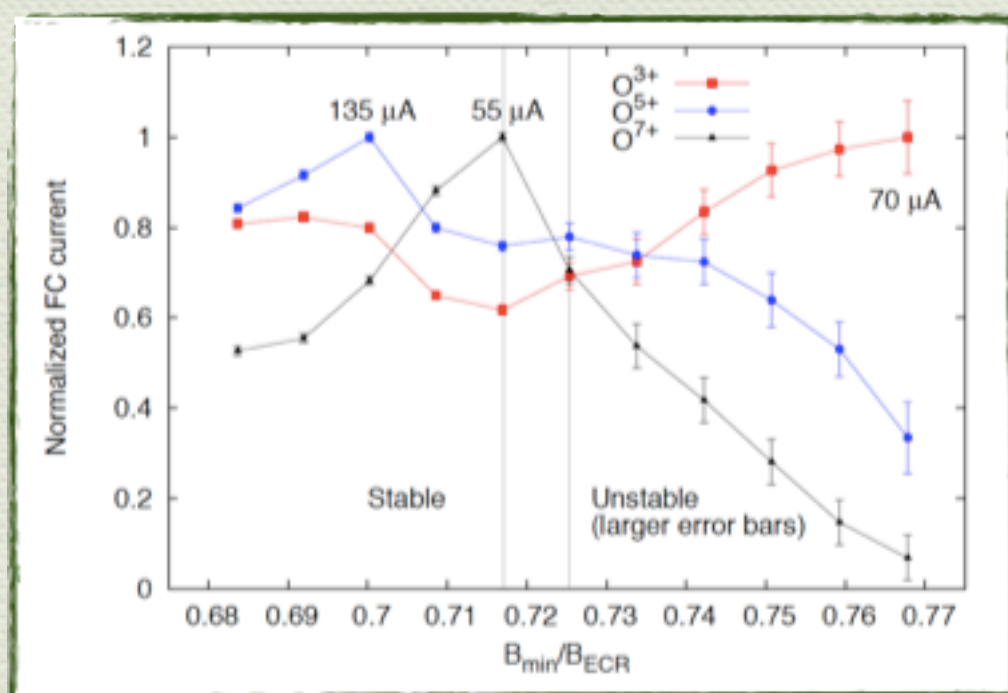
- ◆ Introduction
- ◆ Experimental set-up
- ◆ Volumetric measurements
- ◆ Space-resolved measurements
- ◆ Modeling and discussion

Some questions....

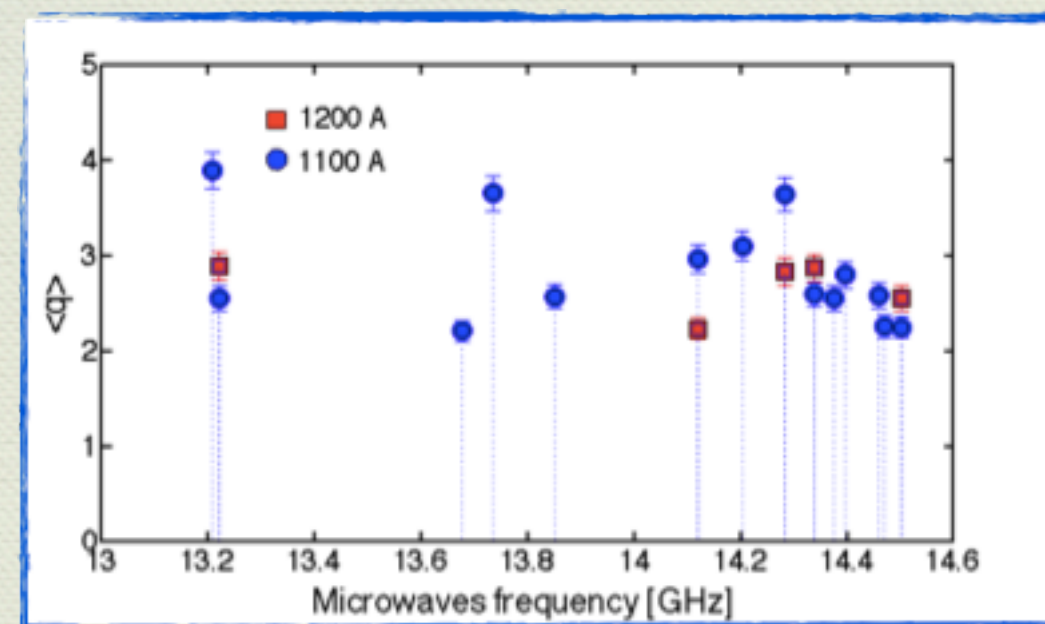
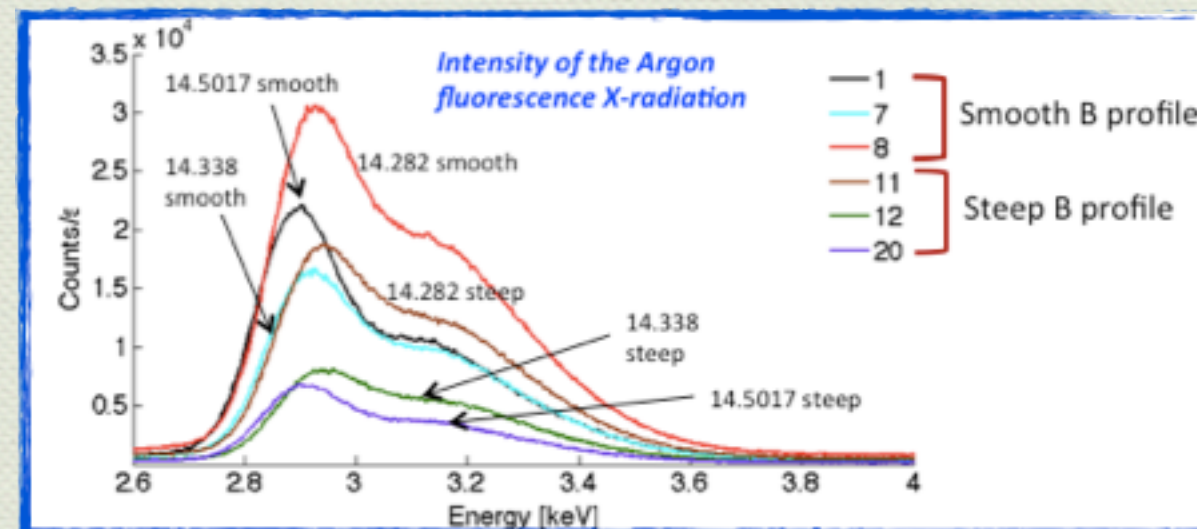
- Does exist an "ECRIS fine structure" with respect to **magnetic field** and **RF frequency tuning**?

D. Mascali et al., Rev. Sci. Instrum. 2014

O. Tarvainen et al. Plasma Sour. Sci. Tech. 2014



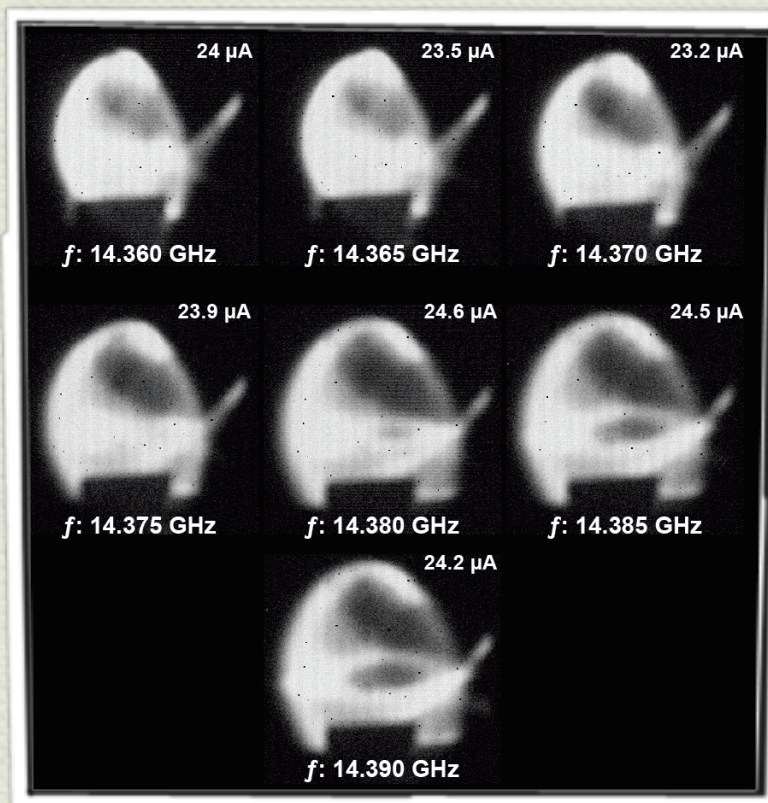
Evidences of plasma instabilities when tuning B



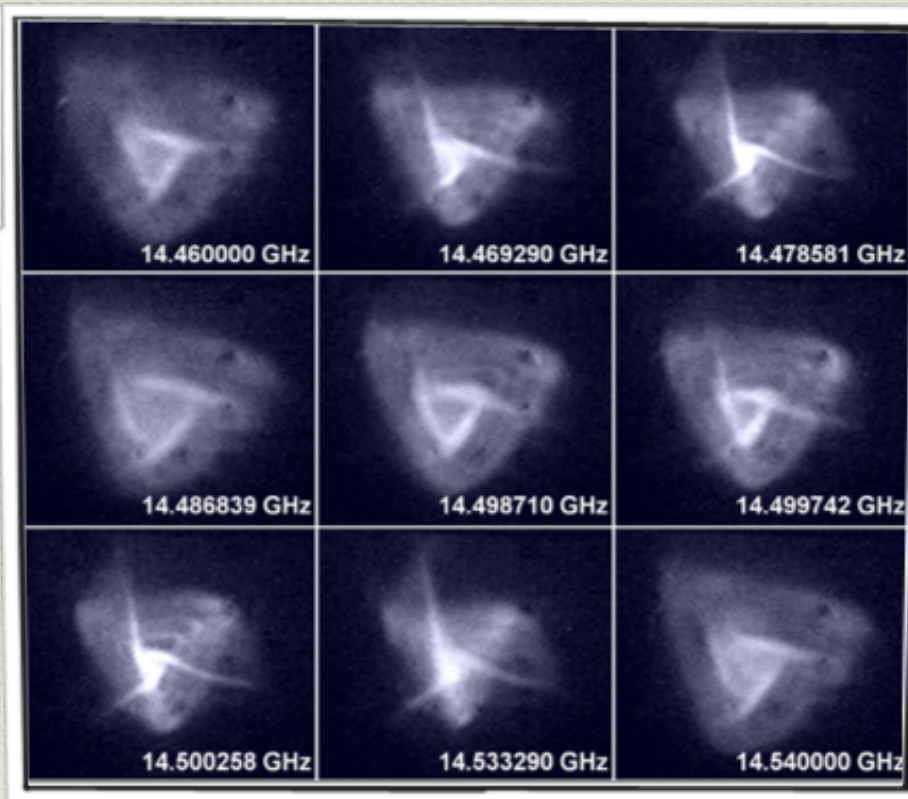
Evidences of strong fluctuations with the RF frequency correlated to X-ray emission

Some questions....

- Does exist an **INTERPLAY** between the **plasma structure** and the **beam shape, brightness, emittance**?

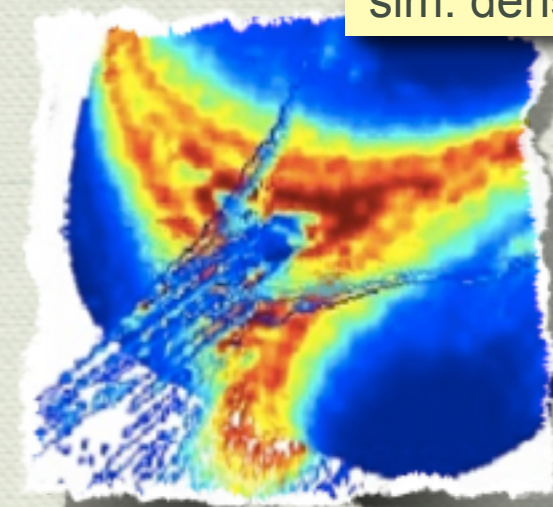


D. Nicolosi et al. This conference

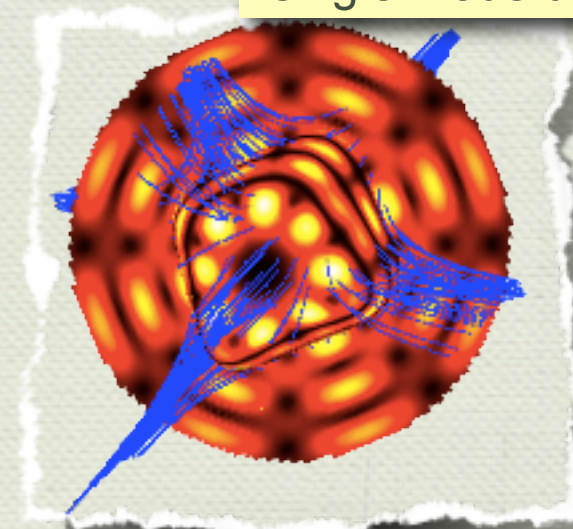


L. Celona et al., Rev. Sci. Instrum. 2008

sim. density

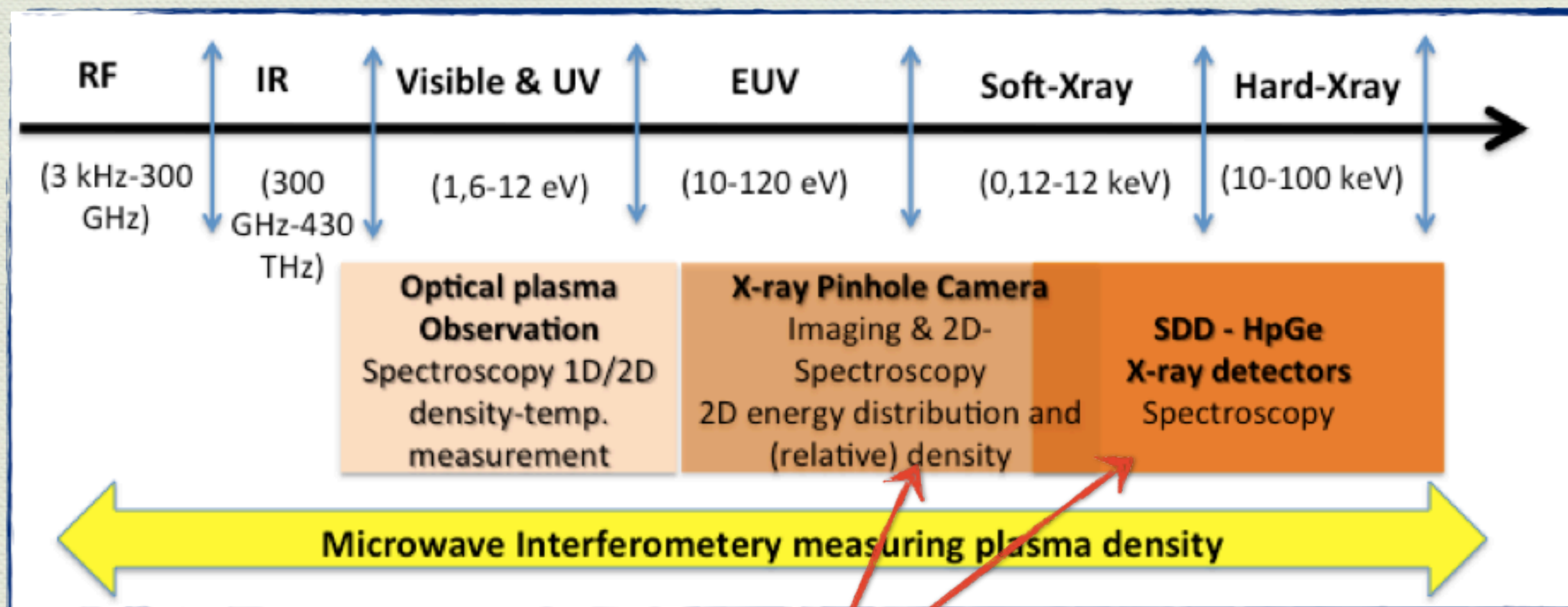


single mode distrib.



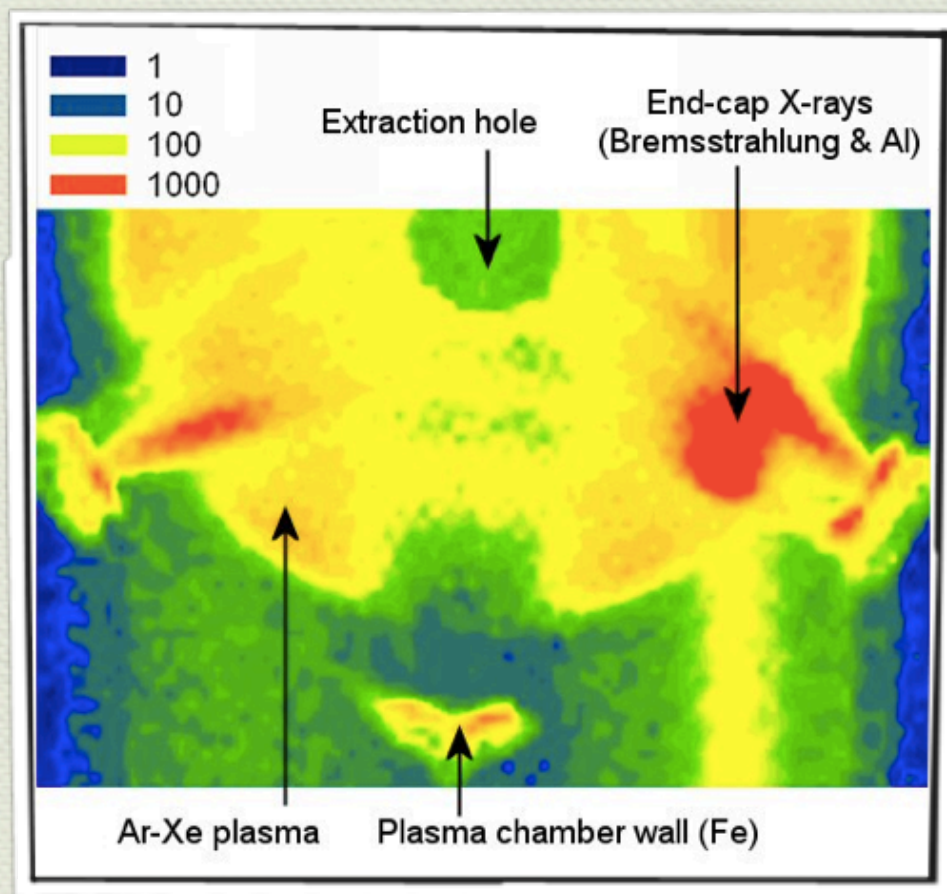
- Does the plasma distribute uniformly?
- Are electrons of **different energy domains** merged each other **or not**?

Non-intrusive plasma diagnostics methods

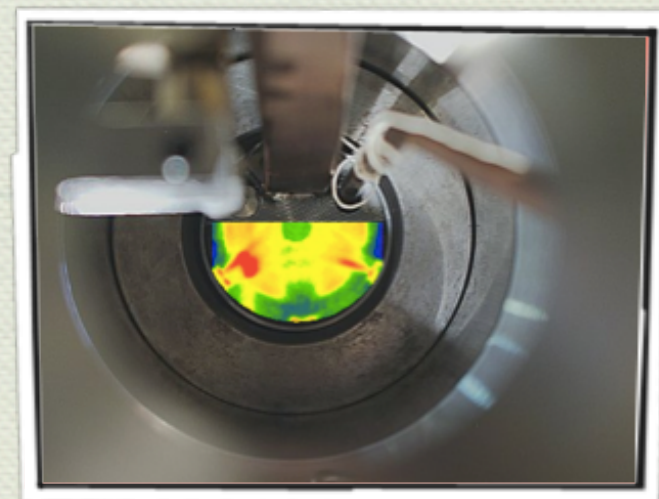


Measuring the plasma density in different energy regimes: density, temperature and plasma structure evaluation under different operative parameters

Exploring plasma structure: pioneering experiment in Atomki-Debrecen (2002-03)



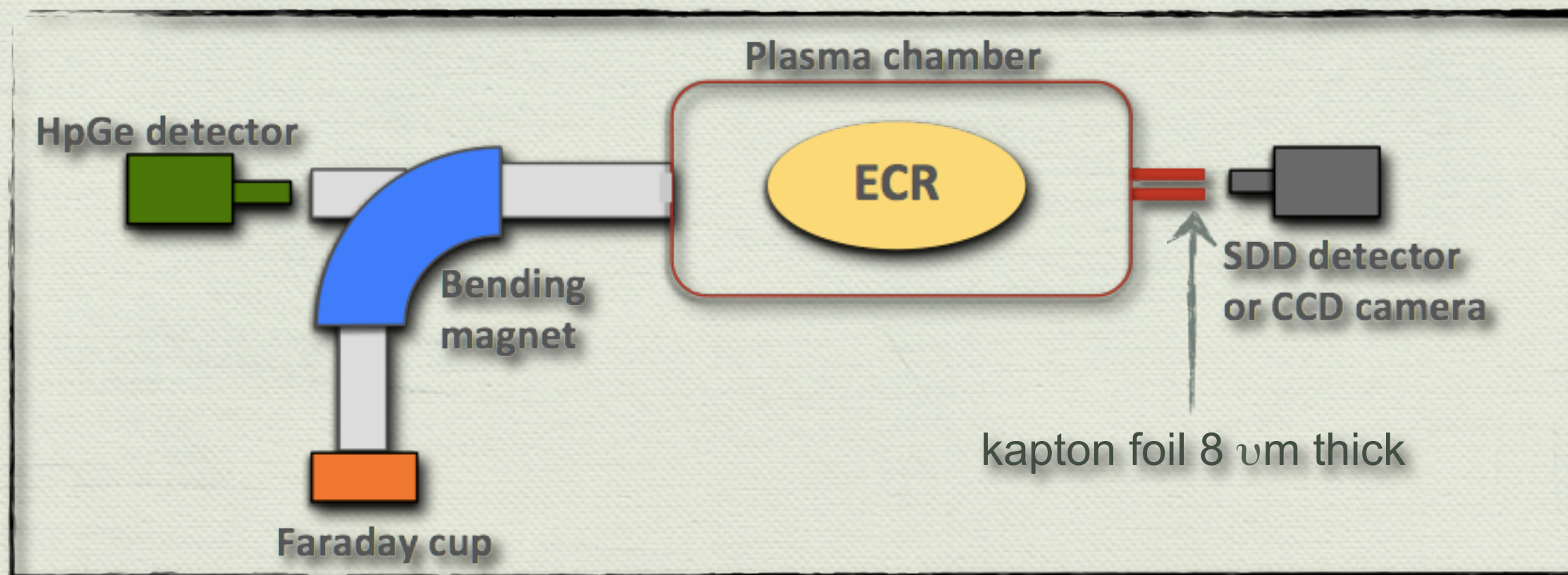
Plasma at optical inspection



Plasma at X-ray inspection

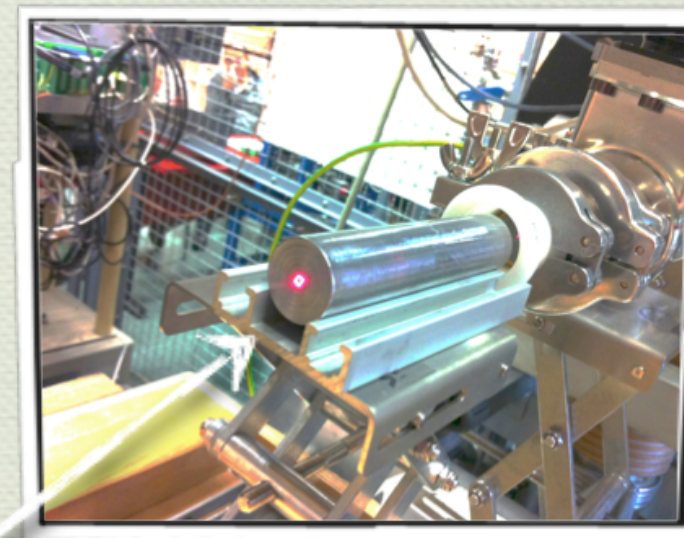
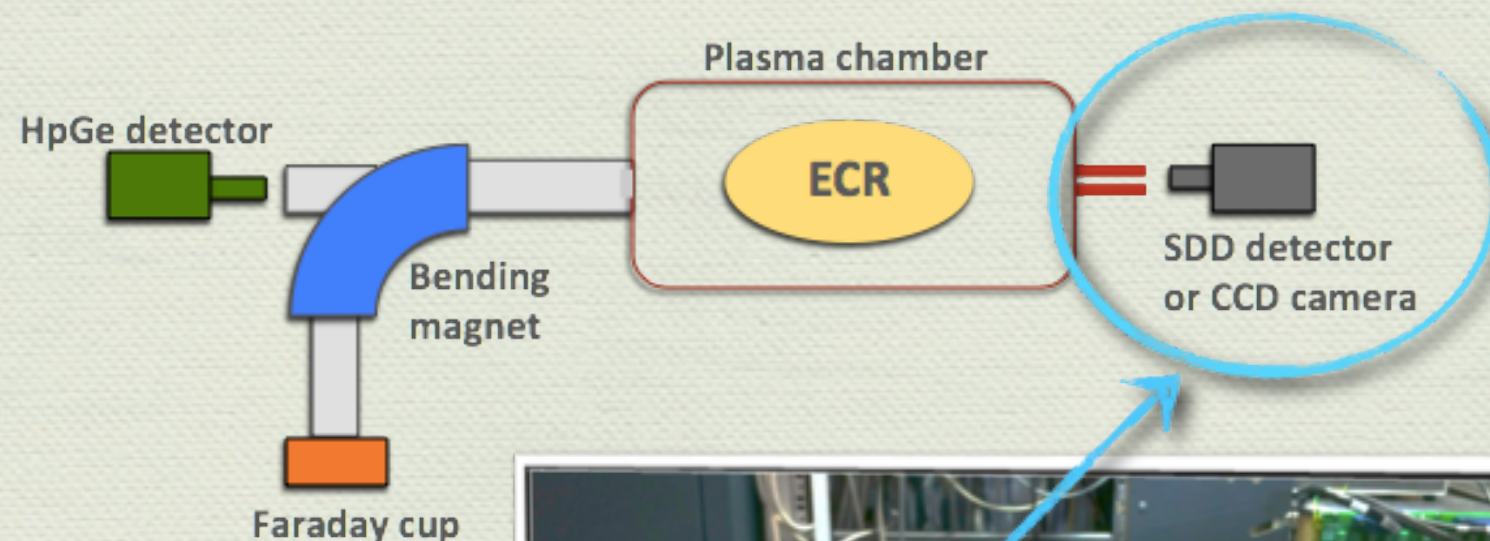
- Full-size images (LCI plasmas) show the spatial placement of different X-ray sources (energetic electrons hit the chamber wall, plasma ions)

Experimental setup for simultaneous measurement of density, temperature and CSD

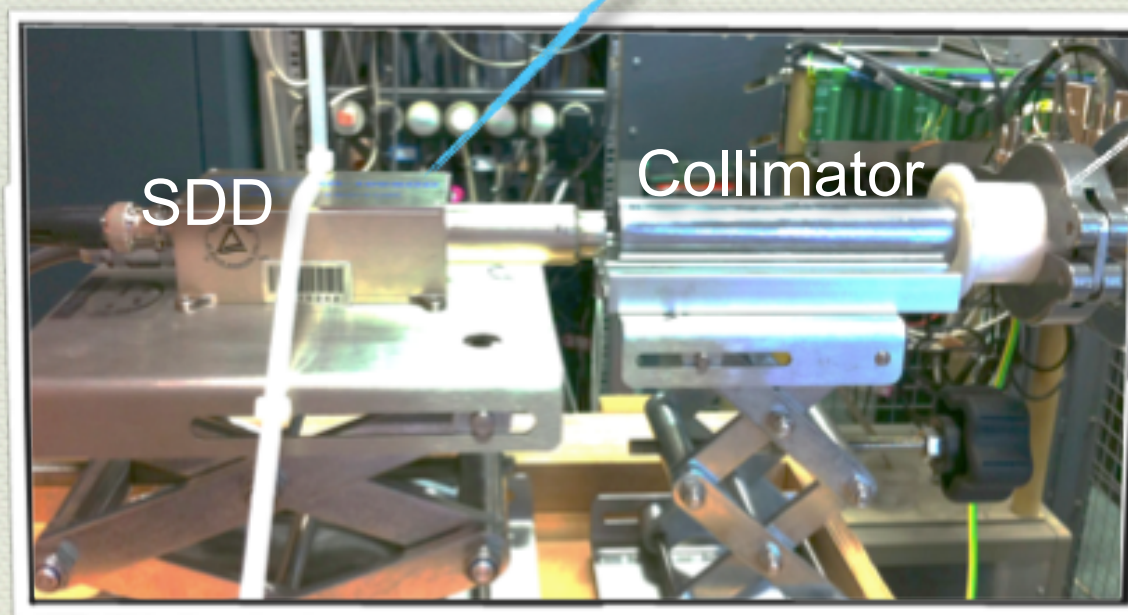


- Three detectors were used for a broad characterization of the EEDF:
 - HpGe for "hot electrons" $E > 30 \text{ keV}$
 - SDD for "warm electrons" $2 < E < 30 \text{ keV}$
 - CCD camera for imaging and 2D resolved spectroscopy $1 < E < 10 \text{ keV}$

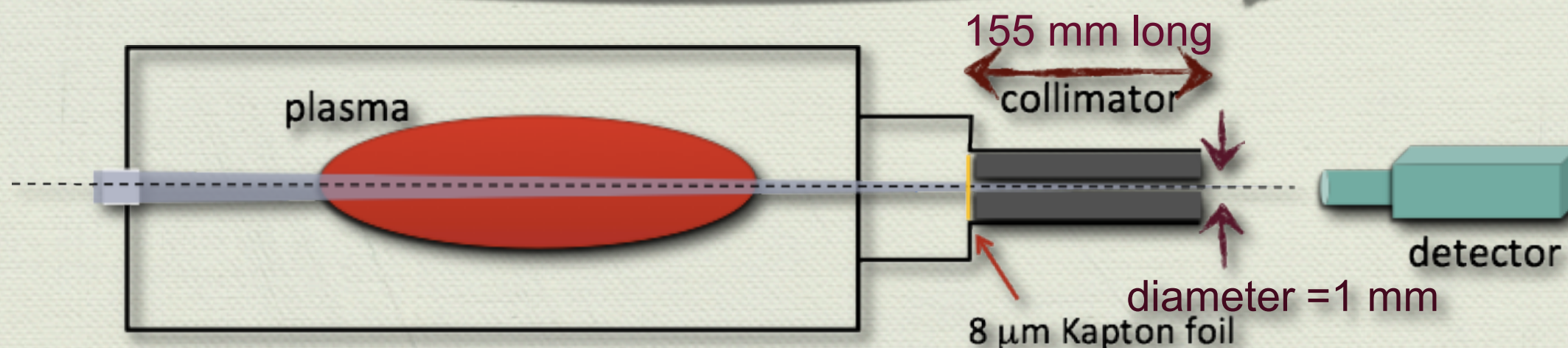
SDD - Setup



Collimator
alignement



Bulk lead 155 mm long
drilled collimator for
near axis inspection



"LONG" collimator

SDD - Data Analysis

Analysis procedure consists in evaluating the **Experimental Emissivity** after ε_g calculation, that must be then compared to the **Theoretical Emissivity** by fitting procedure.

Exp. Emissivity

$$J(h\nu) = h\nu \frac{N^{ch}(h\nu)}{\varepsilon_g t} \frac{4\pi}{\Delta EV_p \Omega_{Tot}}$$

Theor. Emissivity

$$J_{M-K}(h\nu) = \boxed{N_i N_e} (Z\hbar)^2 \left(\frac{4\alpha}{\sqrt{6m_e}} \right)^3 \left(\frac{\pi}{kT_{Mw}} \right)^{1/2} e^{(-h\nu/kT_{Mw})}$$

↓ Plasma density
 ↓ Plasma temperature

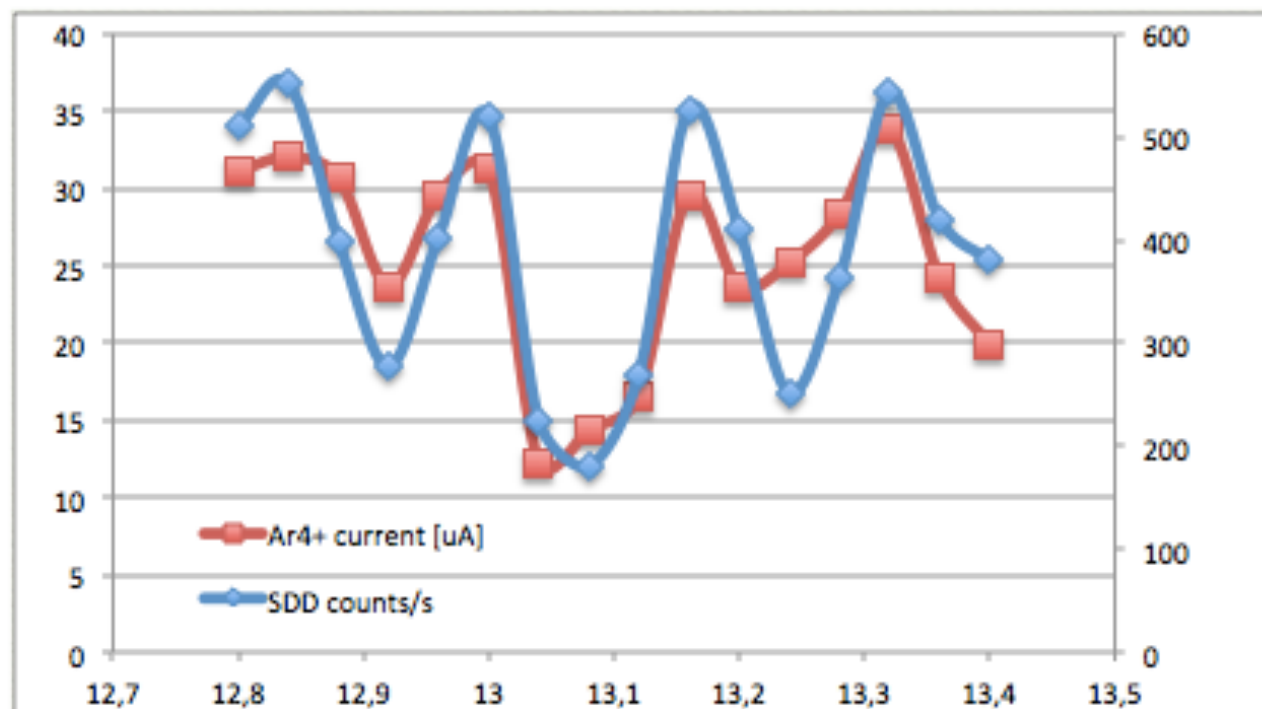
SDD/HPGe - Parameters space

Freq. [GHz]	RF power	gas pressure
12,8	30 W	3,50E-06 mbar
12,84	Ext. Voltage	Gas type
12,88	10 kV (beam ON)	Argon
12,92		Argon+Oxygen
12,96	Coils (inj/mid/ext)	
13	100% each	
13,04	80% each	
13,08	60% each	
13,12		
13,16		
13,2		
13,24		
13,28		
13,32		
13,36		
13,4		

Observation of spectral density and temperature variation in the low/high energy part of the spectrum (warm electrons $1 < E < 30$ keV; hot electrons $50 < E < 300$ keV) versus RF frequency, coils setup (high/low mirror ratio), gas mixing.

Observation of the plasma structure by CCD based – pin-hole camera

(SDD) F.T.E. study

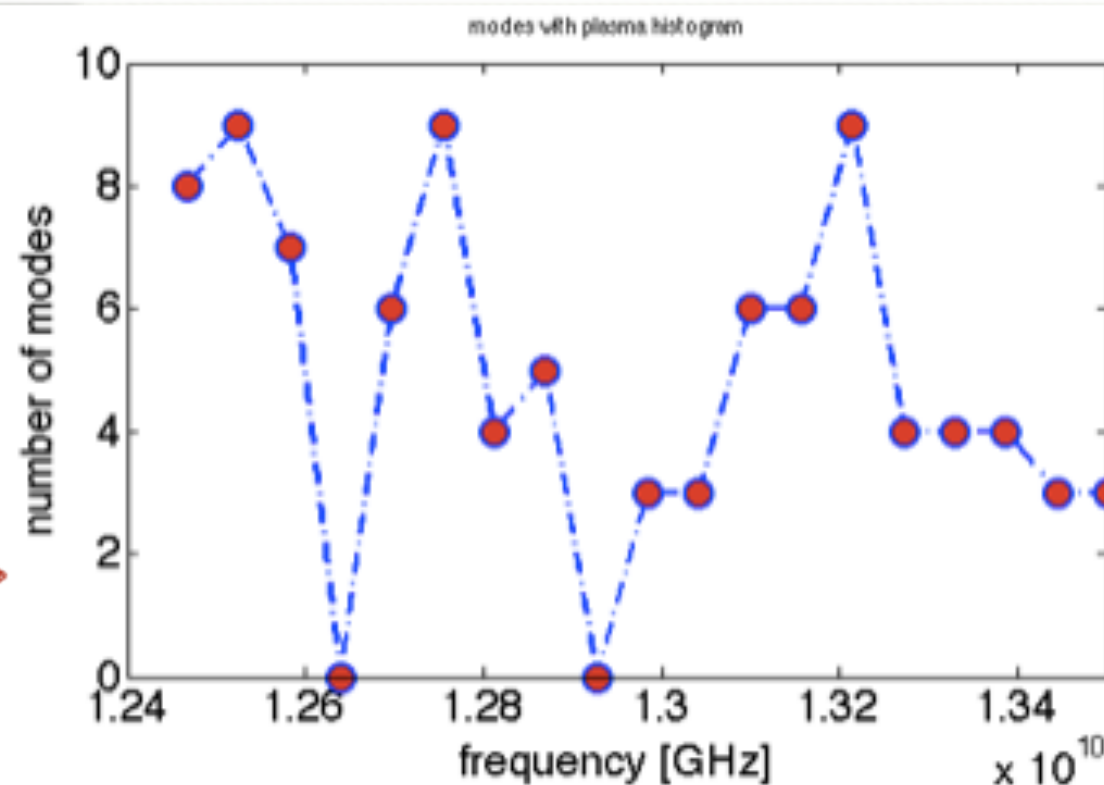


Very Strong correlation (!!!) between Ar4+ current, X-ray flux and modal density

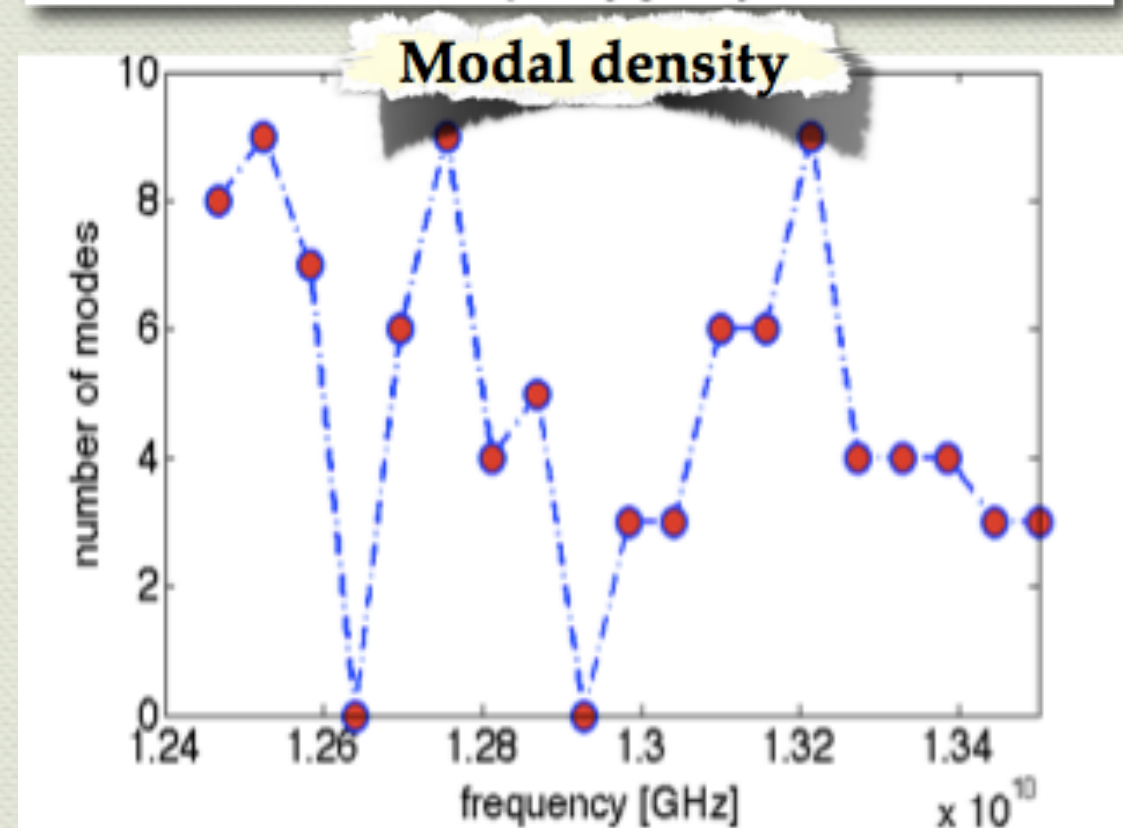
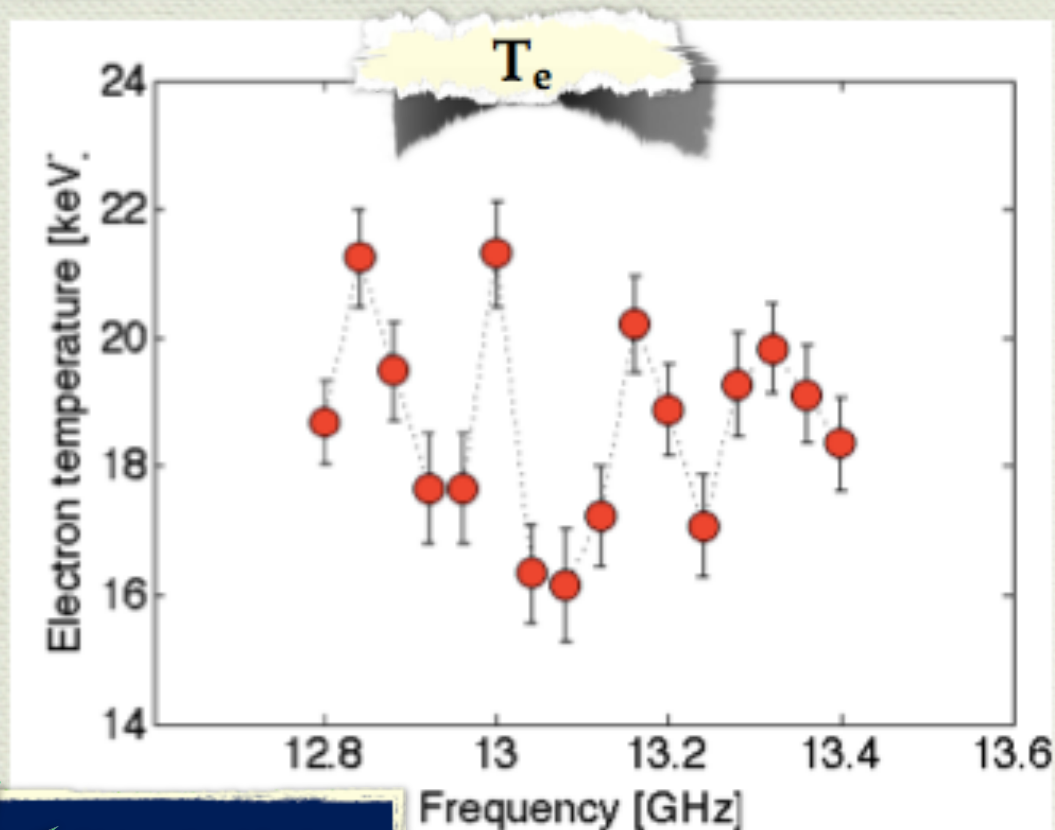
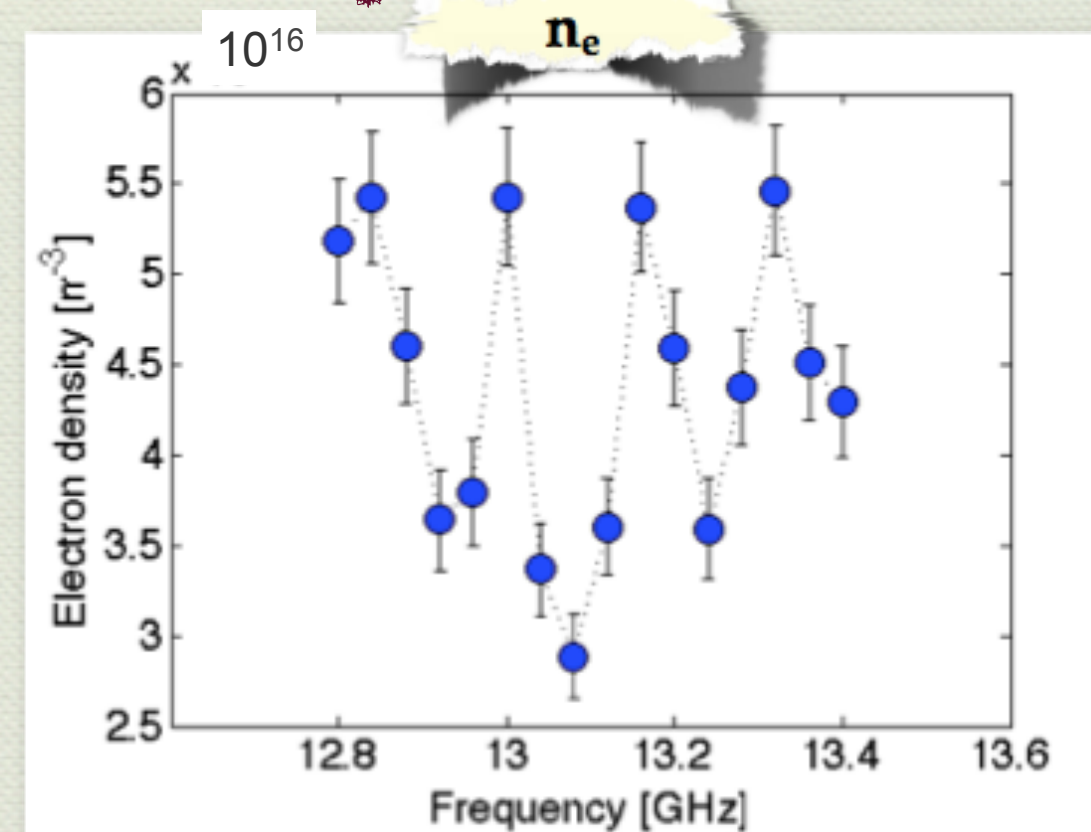
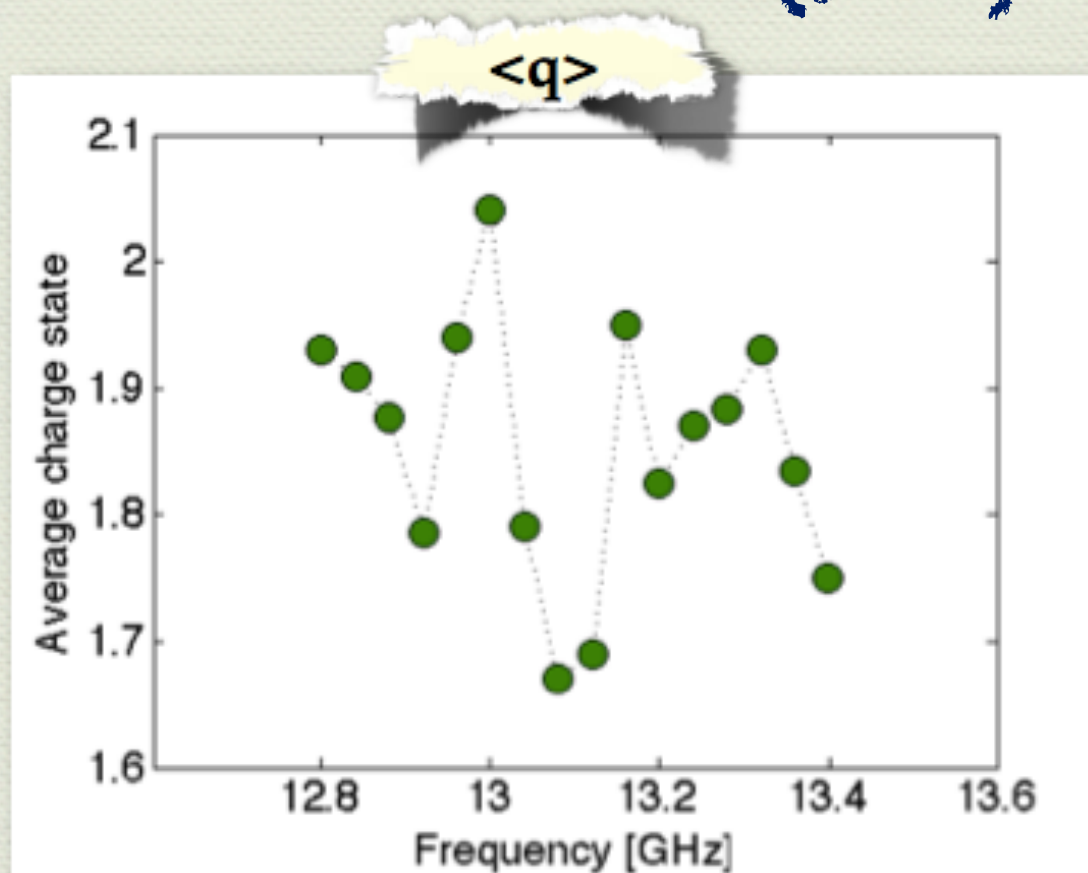
Same number of "peaks", but with upshifted frequency (plasma effect).

Strong correlation among:

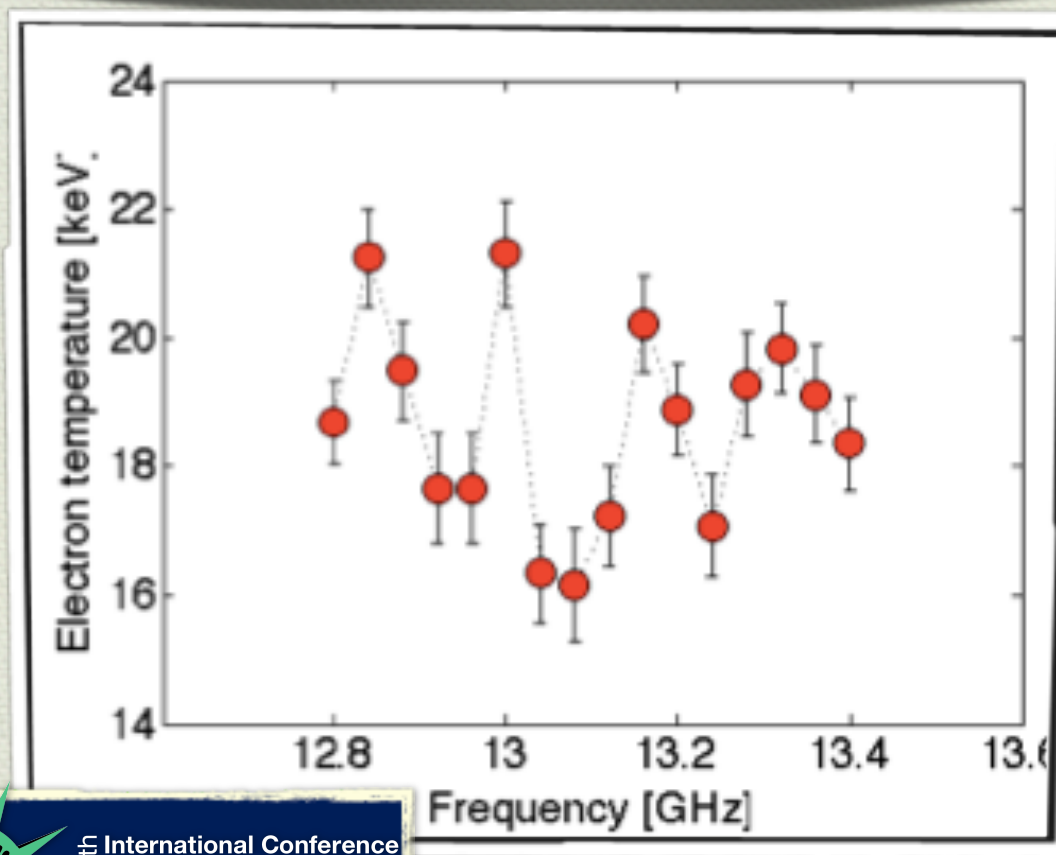
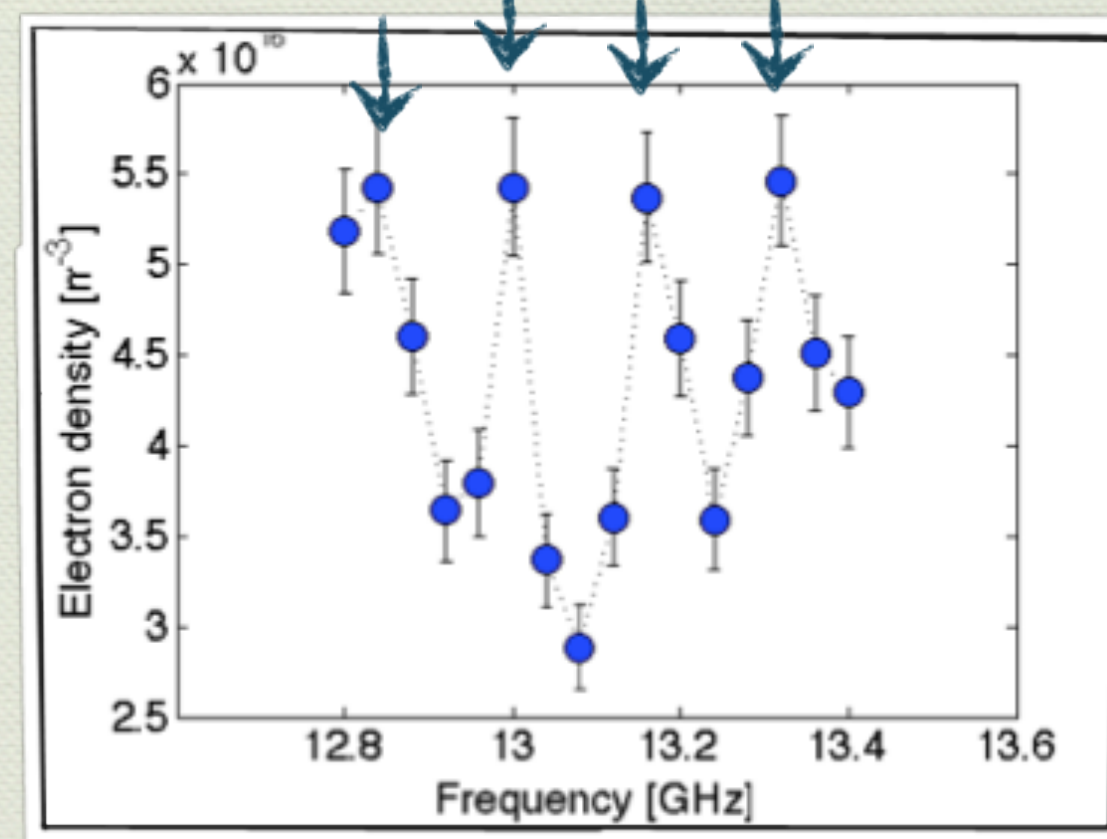
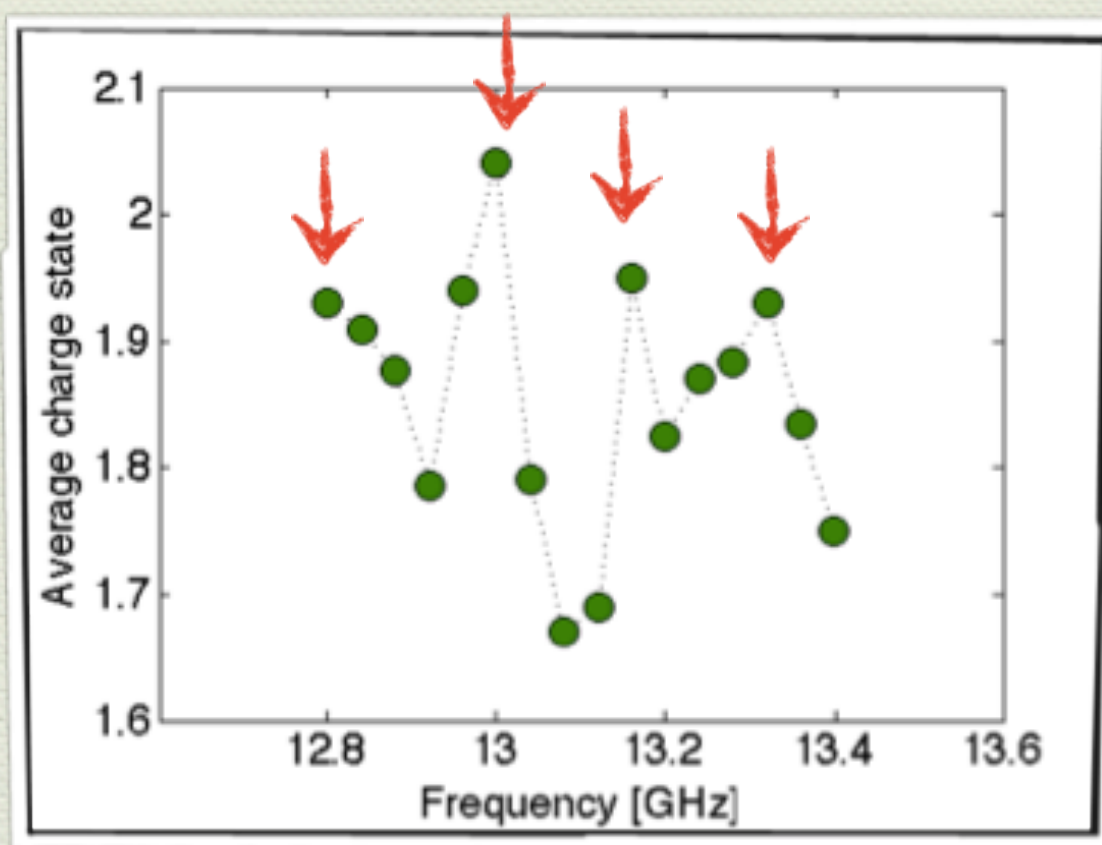
- (i) Ar4+ current,
- (ii) SDD counts/sec. and
- (iii) e.m. modal density distribution



(SDD) F.T.E. study

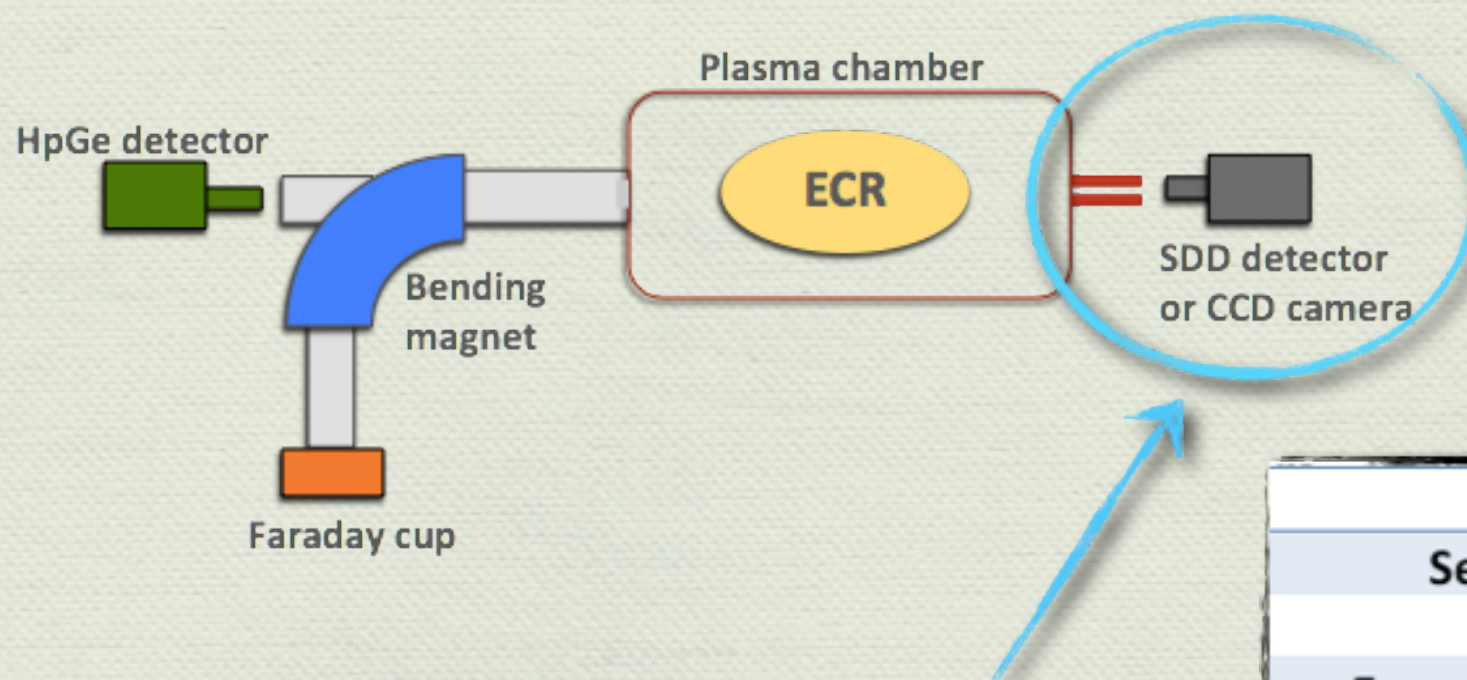


(SDD) F.T.E. study

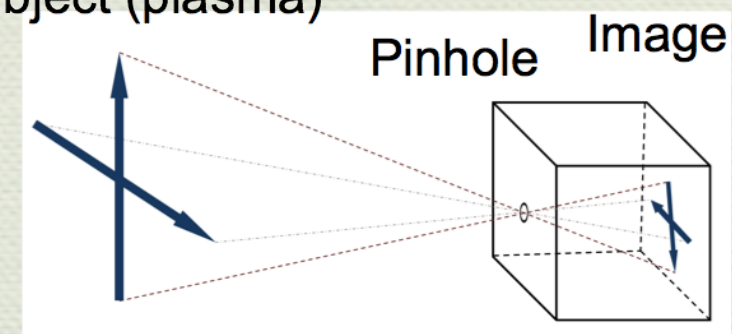


- Warm electron density
range $2.5 - 5.5 \cdot 10^{16} m^{-3}$
- Warm el. temperature
range 13-22 keV

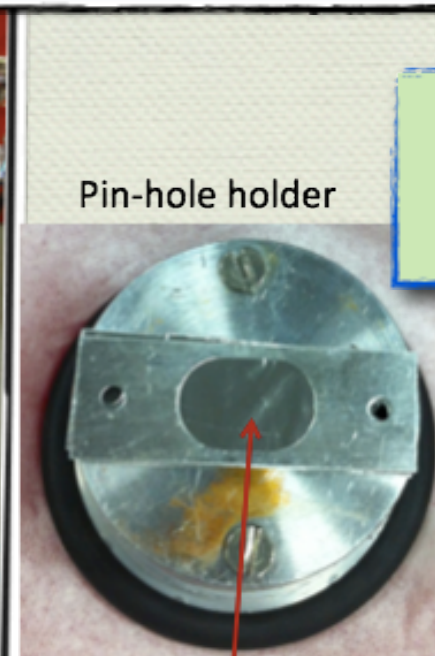
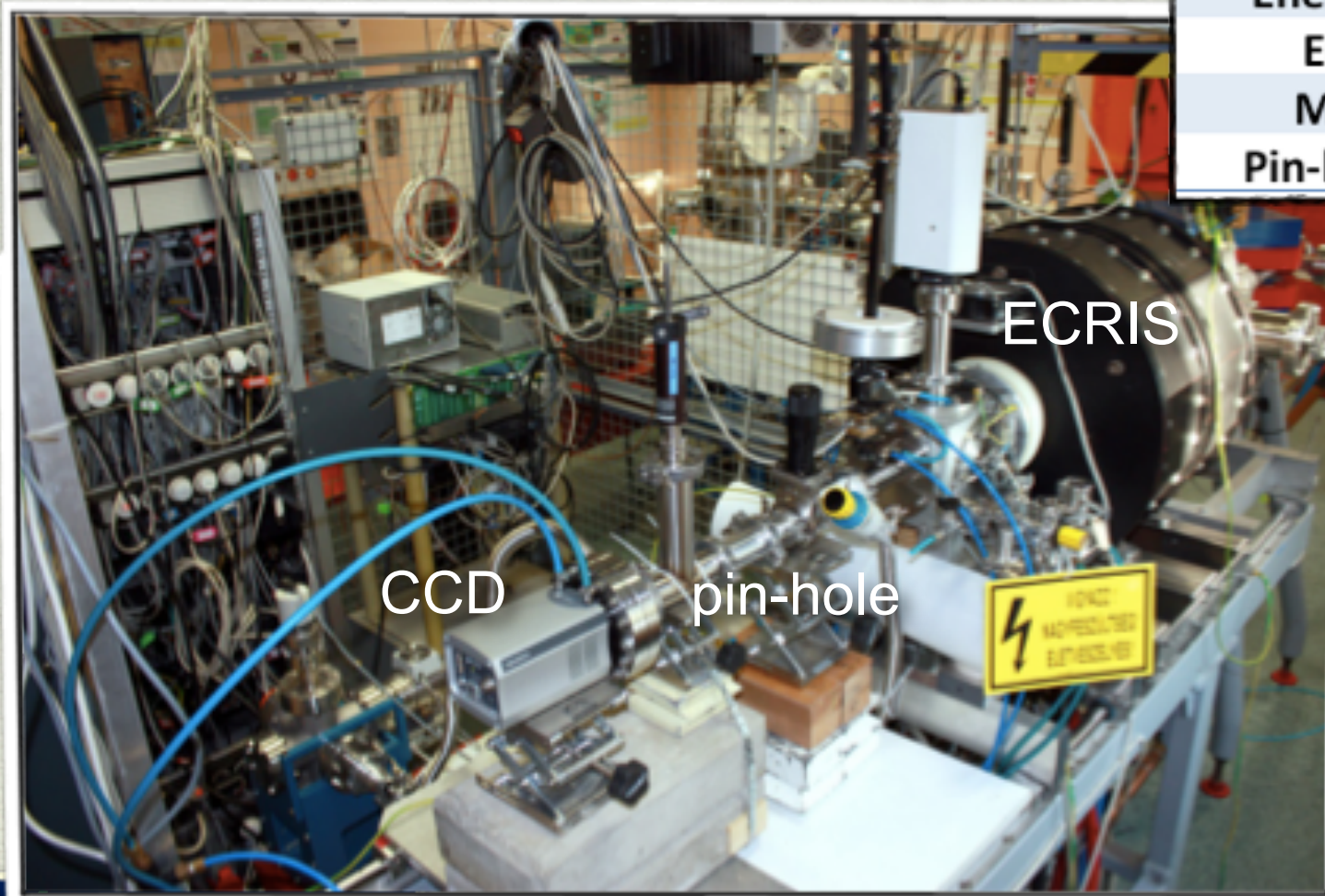
CCD camera Set-up



Object (plasma)

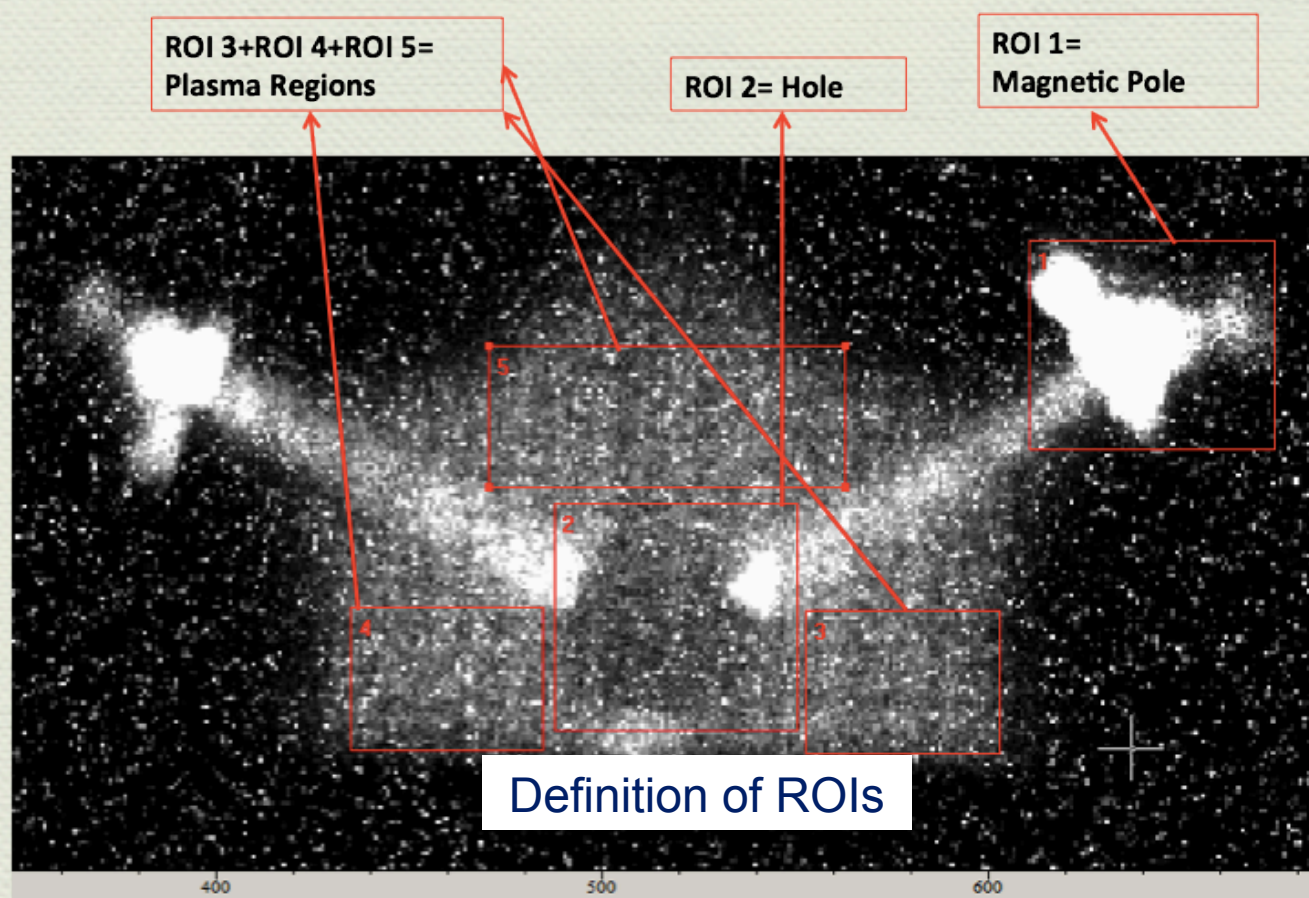


Model	Andor Technology - Newton
Sensor size	27.6 mm x 6.9 mm
Pixels	1024 x 255 (0.3 MP)
Energy Resolution	150 eV
Energy range	1-10 keV
Magnification	0.082-0.124-0.158
Pin-hole diameters	75 μ m and 100 μ m (W and Pb)



For more details see
R. Rach et al. ThuPS09

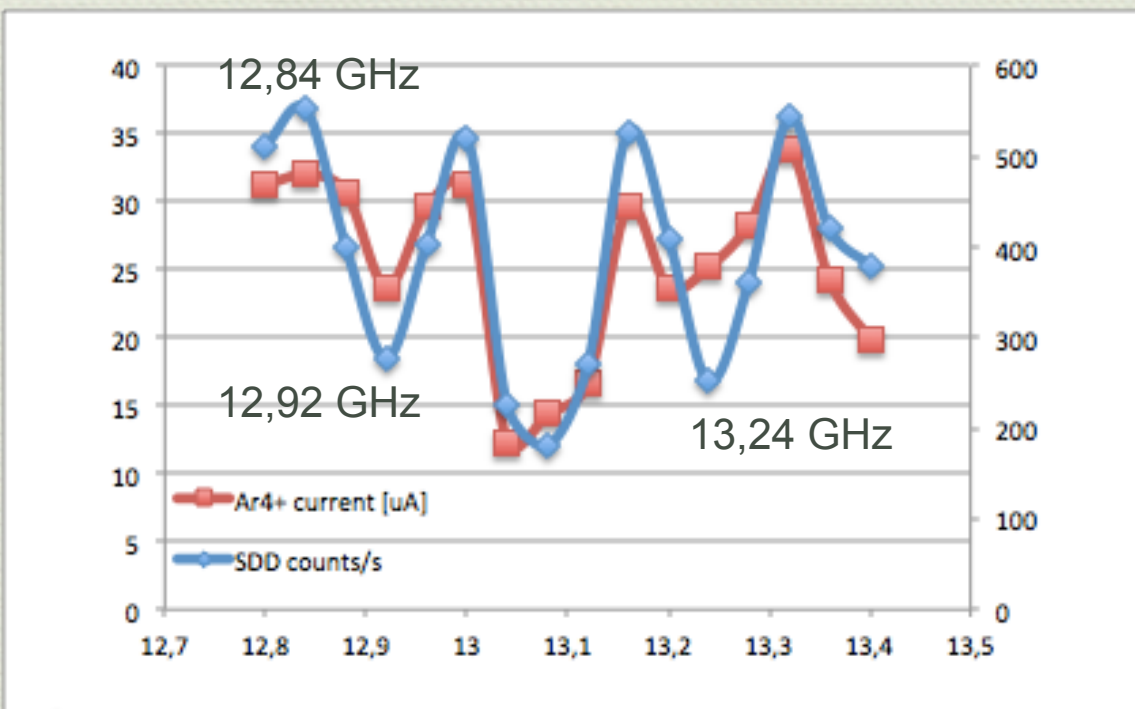
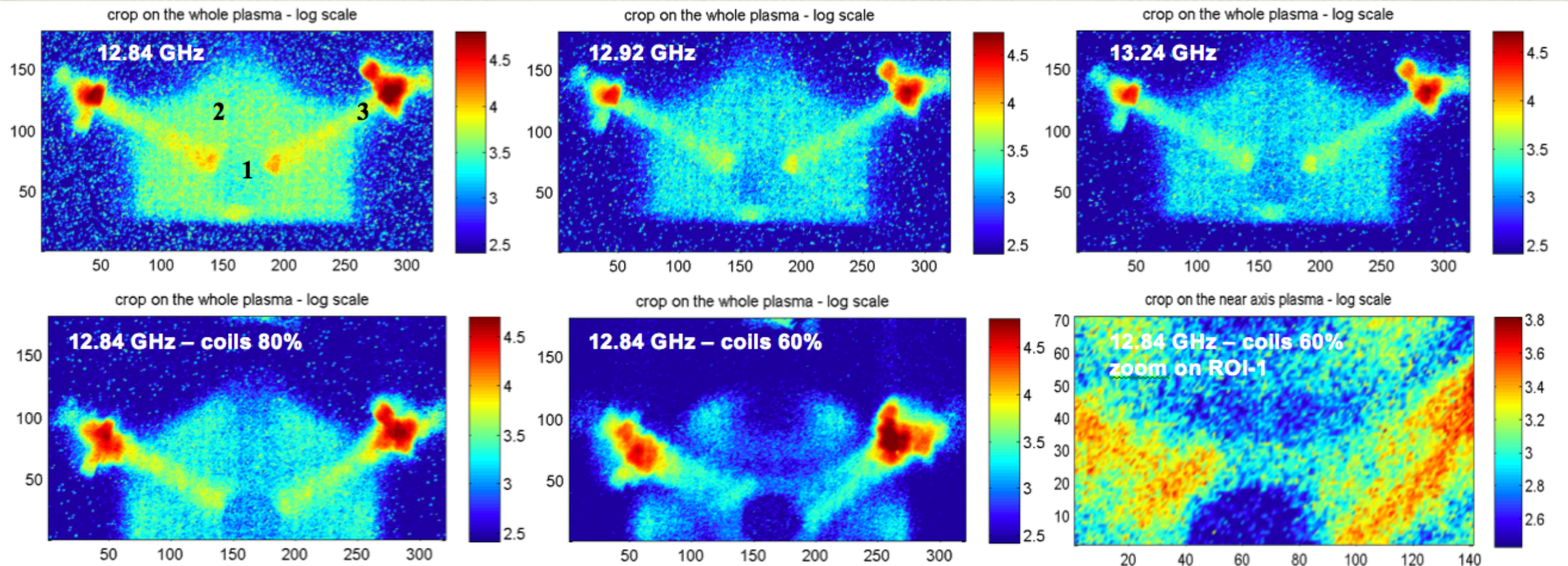
X-ray imaging



- **X-ray imaging:** single frame acquisition, up to 30-40 sec. needed, no energy information;
- **Photon Counting mode:** from 10^{-5} to 0.3 sec., depending on the ROI.

- A Stainl-Steel grid was placed at injection edplate allowing plasma inspection
- Spatial resolution is high enough to find the mesh in X-ray images

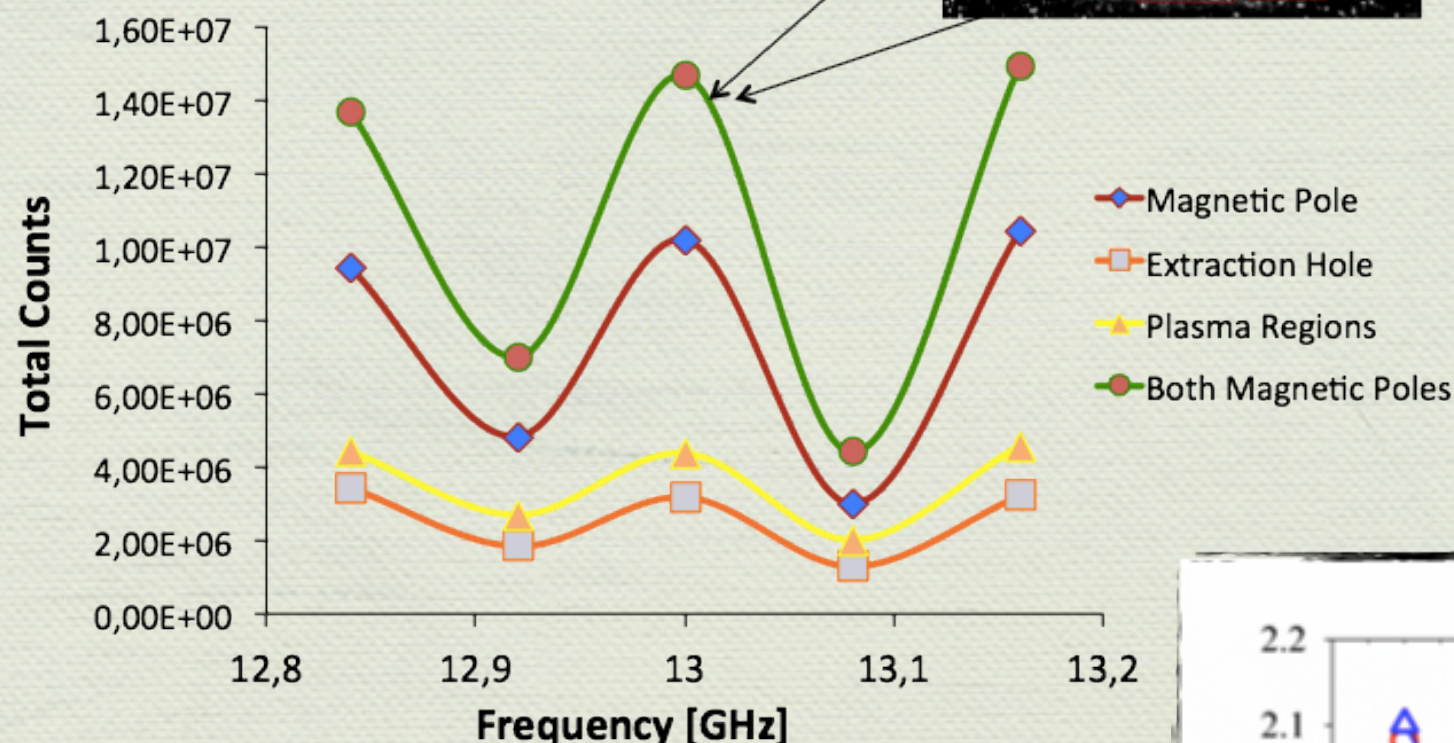
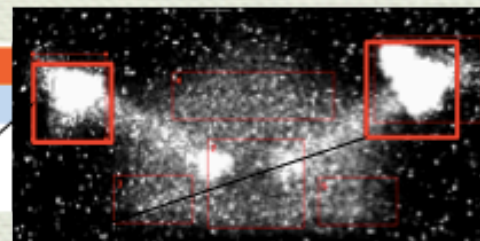
X-ray imaging



- From a general inspection of the pictures, it is clearly visible the structure of the plasma:
- the hole in the near axis region
- the branches due to the electrons escaping from the confinement
- the hot spots due to lost electrons producing bremsstrahlung radiation when impinging on the chamber walls.

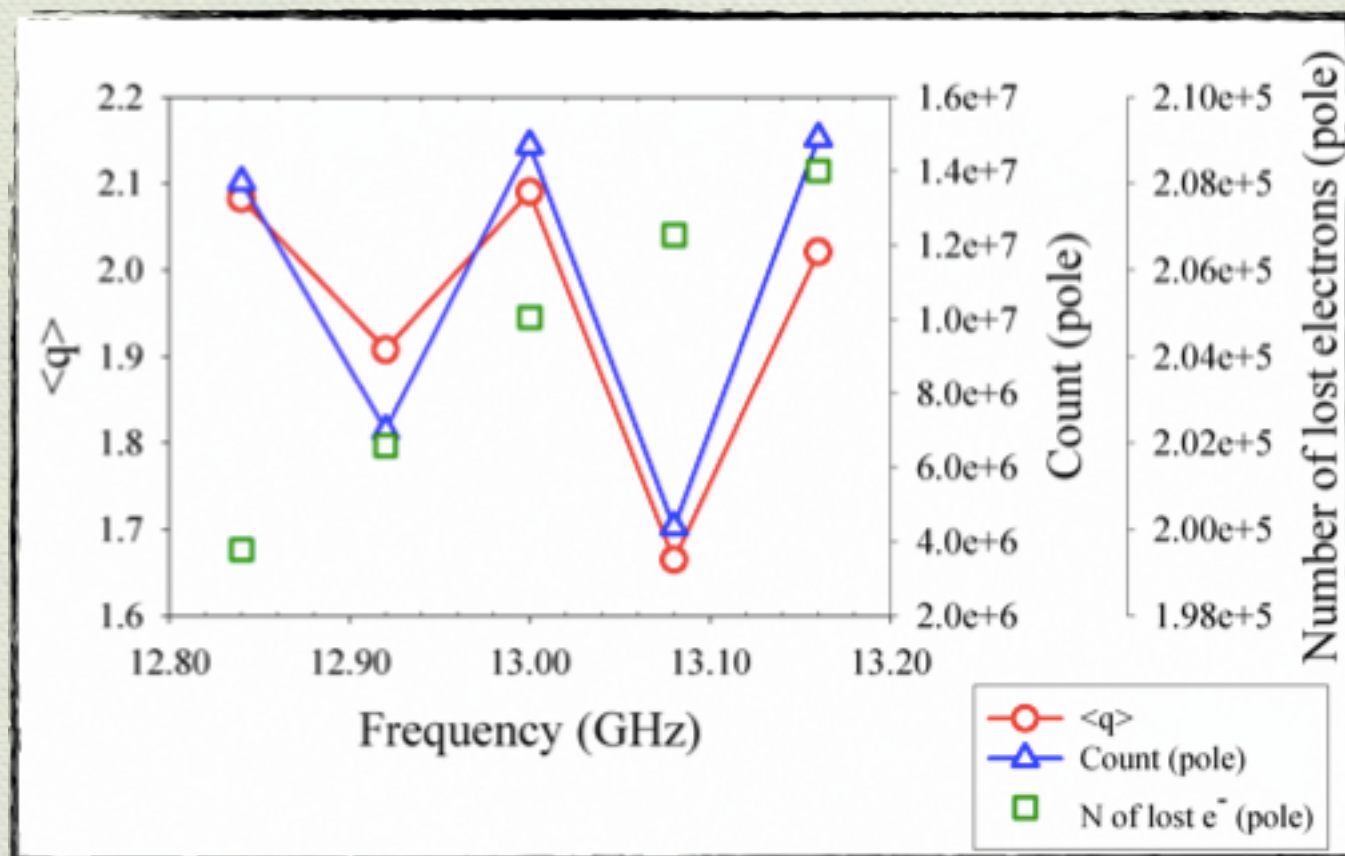
X-ray imaging

RF power [W]	Coils (inj/mid/ext)	gas pressure
30	100% each	3,30E-06
Acquisition Time 15 sec		Gas: Argon



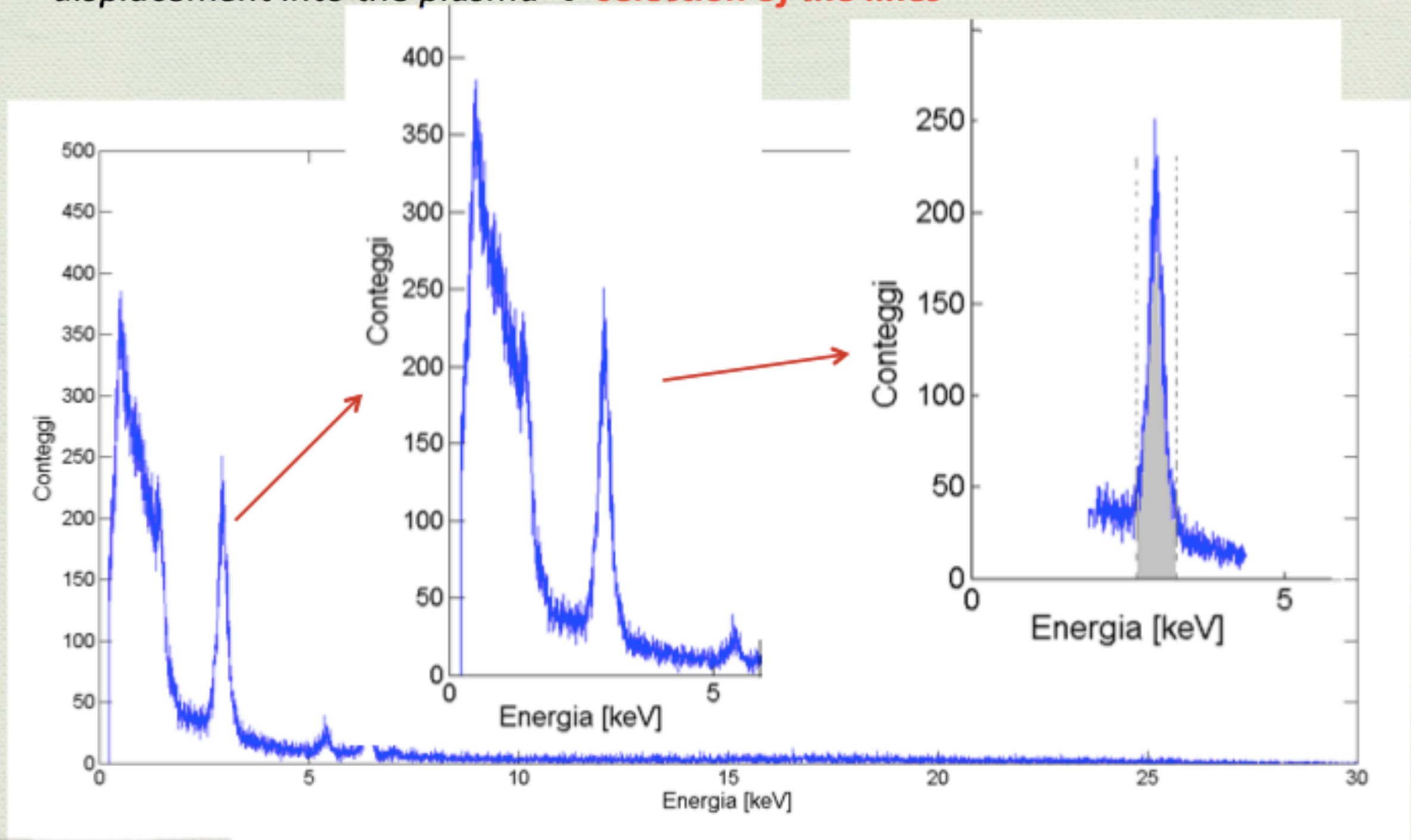
Rough evaluation of
X-ray E.C./ROI
where the energy content is
 $n\text{-ph.el} = \text{flux} \times \text{energy}.$

TRAP-Cad code was used
to investigate the number of
lost electrons vs. frequency,
comparing them to exp. results



Plasma inspection by energy filtering

Selection of fluorescence lines for the extrapolation of the various elements displacement into the plasma → **selection of the lines**

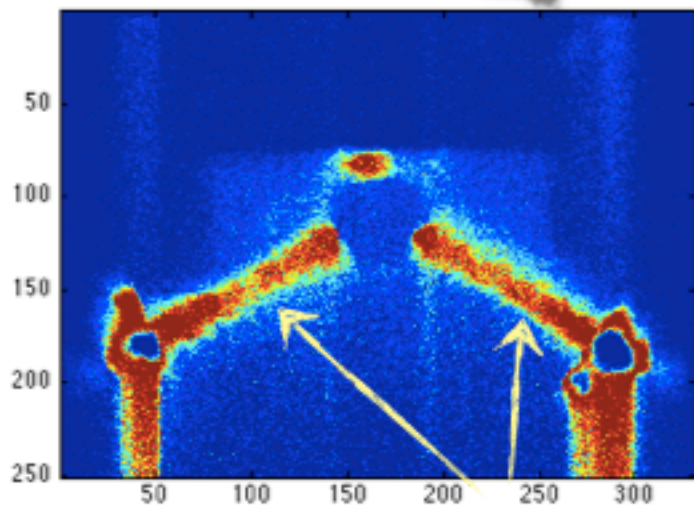


Plasma inspection after energy filtering

12.84 GHz - distribution at different energies

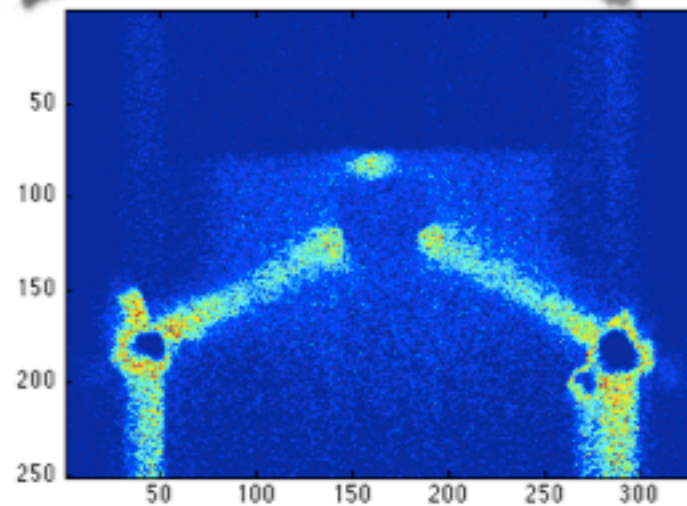
(equalized pseudocolor maps)

$E < 1.5$ keV

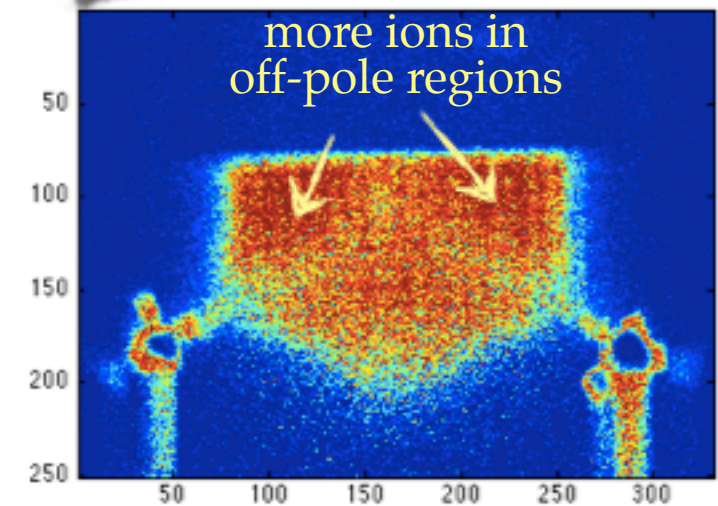


structures in
the "arms"

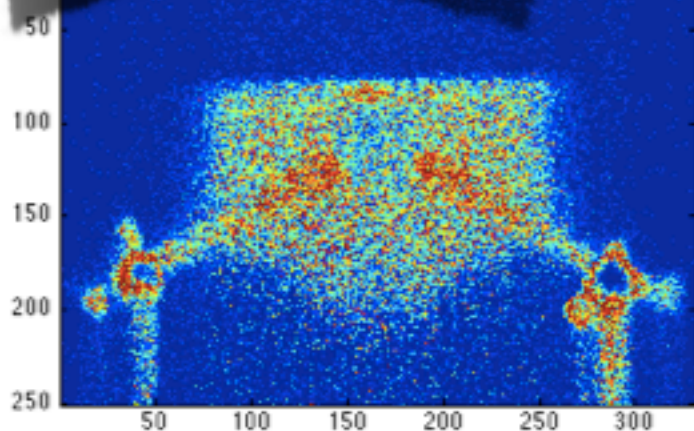
$1.5 < E < 2.5$ keV



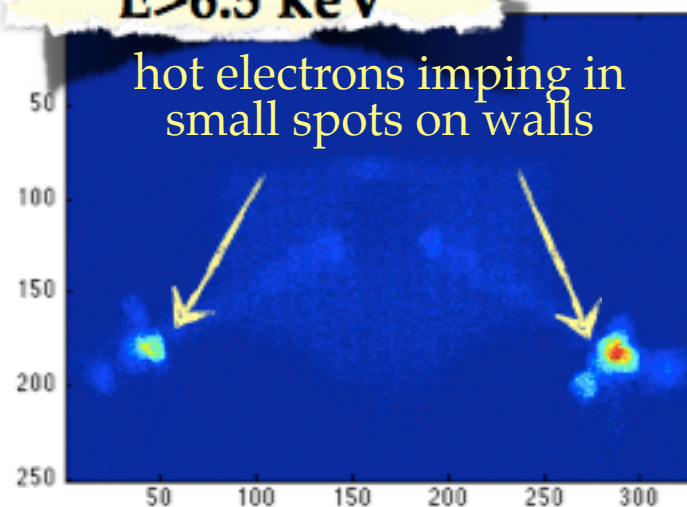
$2.5 < E < 3.5$ keV - Ar ions



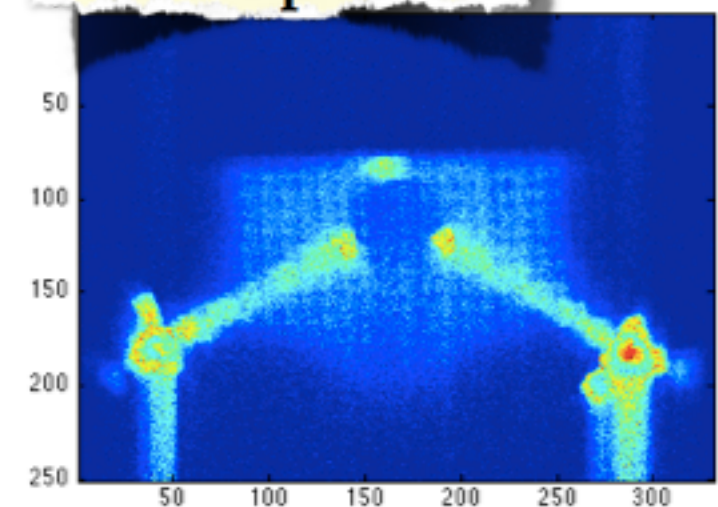
$3.5 < E < 6.5$ keV



$E > 6.5$ keV



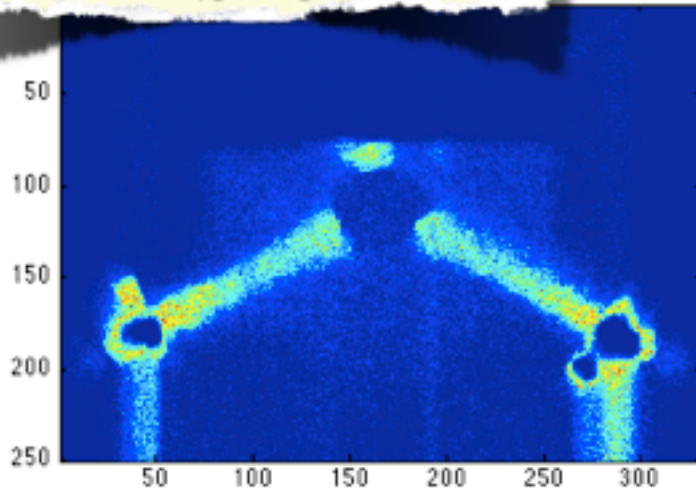
Whole plasma



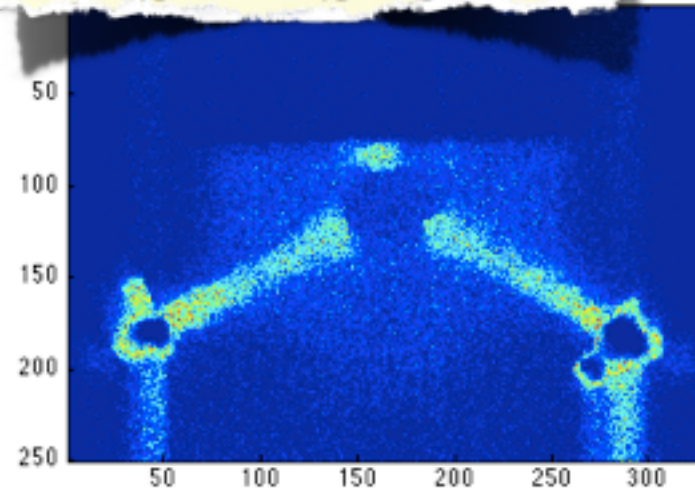
Plasma inspection after energy filtering

12.92 GHz - distribution at different energies
(equalized pseudocolor maps)

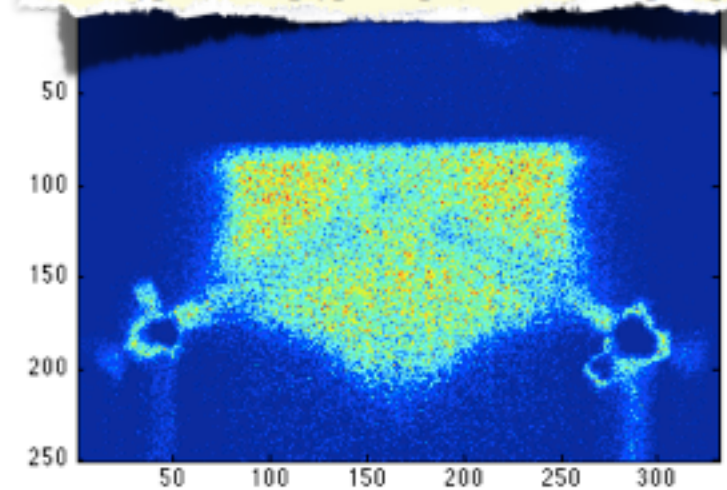
E < 1.5 keV



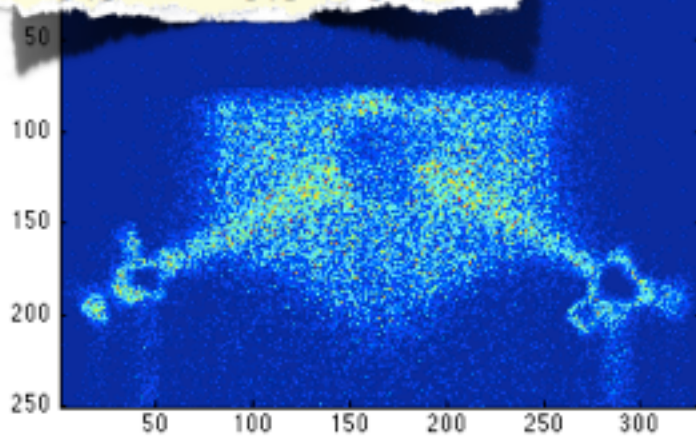
1.5 < E < 2.5 keV



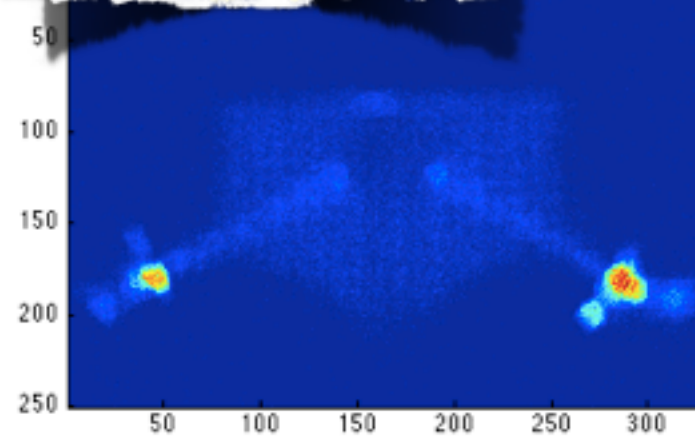
2.5 < E < 3.5 keV - Ar ions



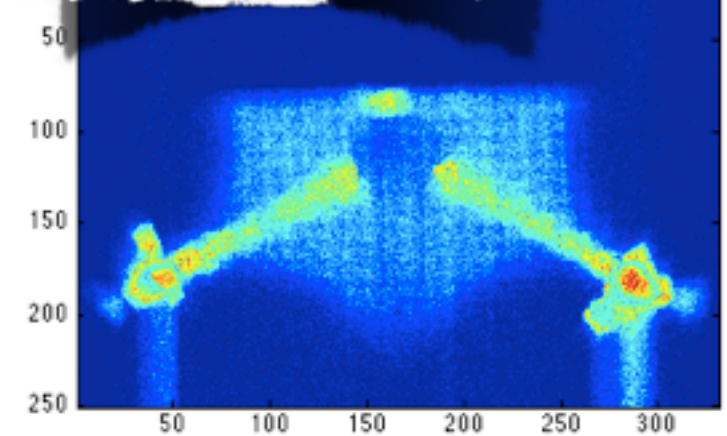
3.5 < E < 6.5 keV



E > 6.5 keV



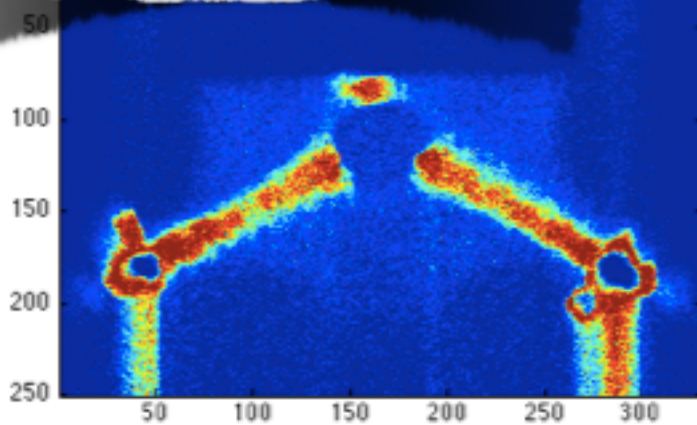
Whole plasma



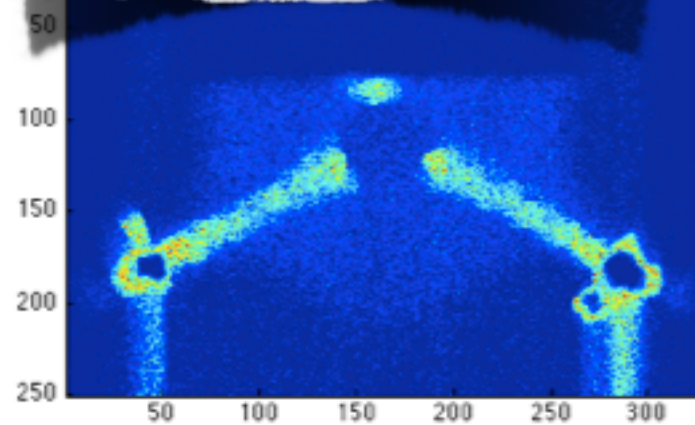
Plasma inspection after energy filtering

13.24 GHz - distribution at different energies
(equalized pseudocolor maps)

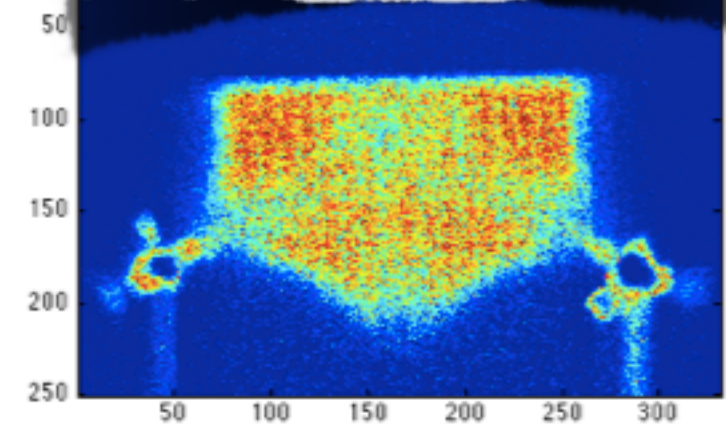
$E < 1.5$ keV



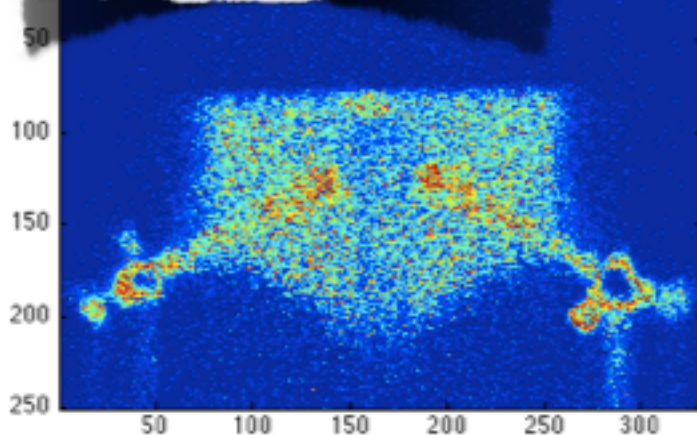
$1.5 < E < 2.5$ keV



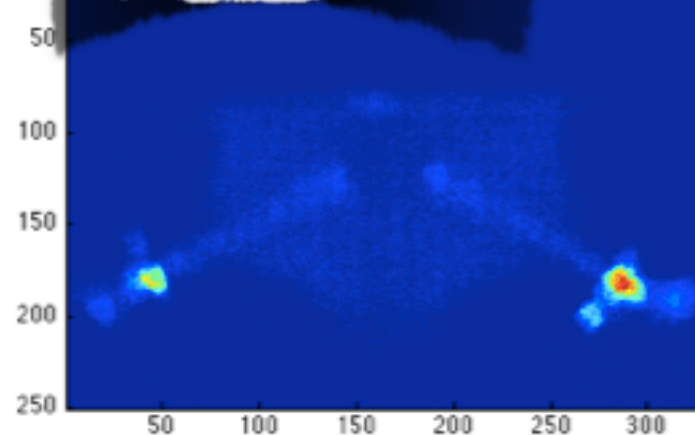
$2.5 < E < 3.5$ keV - Ar ions



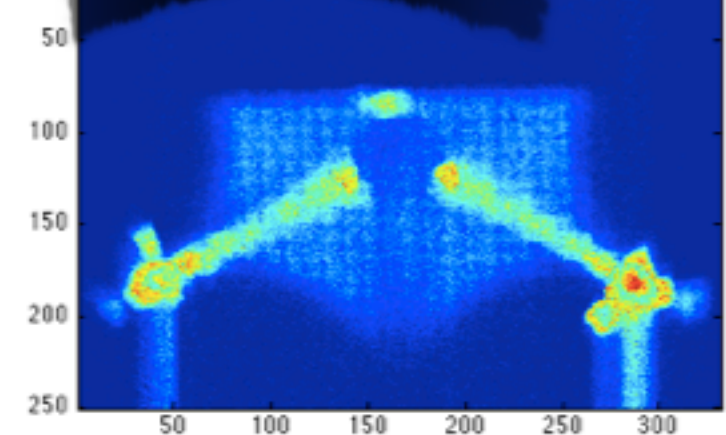
$3.5 < E < 6.5$ keV



$E > 6.5$ keV

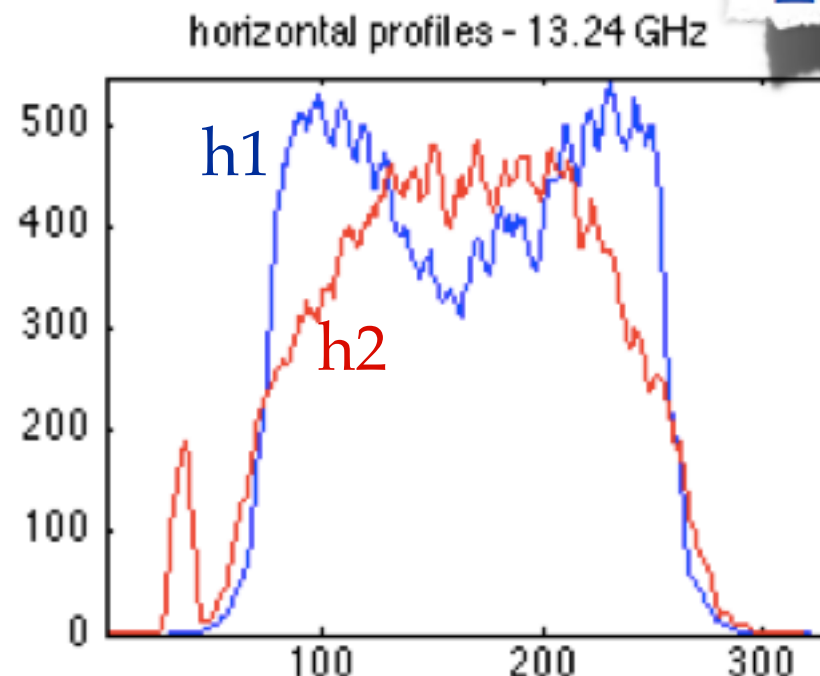
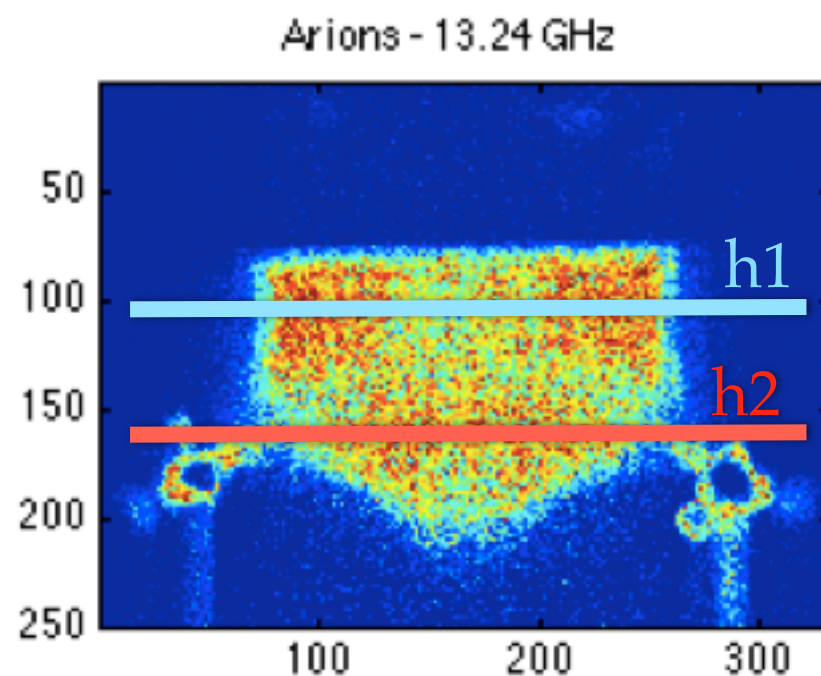


Whole plasma



Analysis of plasma morphology

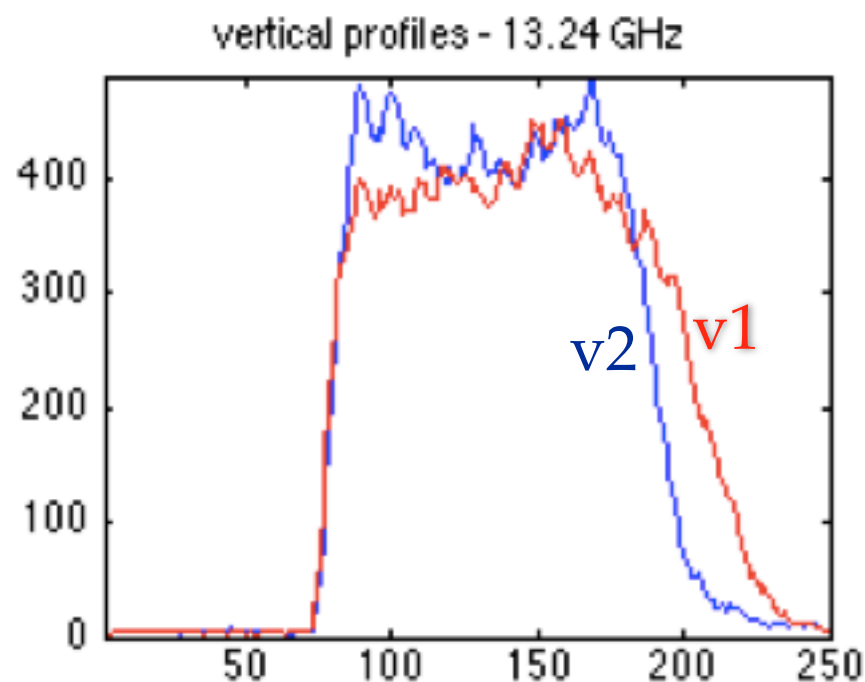
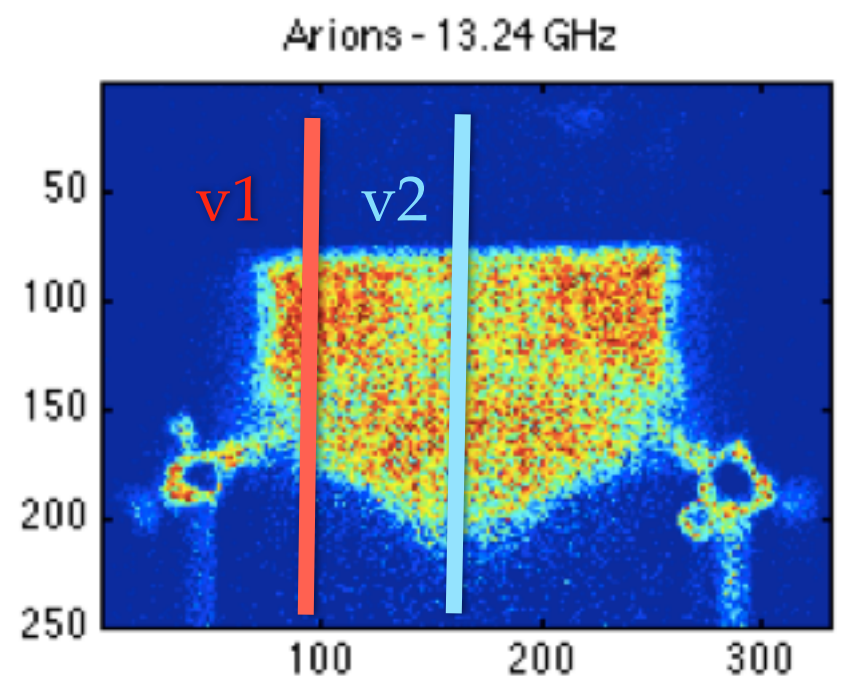
$2.8 < E < 3.5$ keV



- ◆ A more detailed analysis of Ar distribution through 1D profiles
 - 2+2 horizontal/vertical profiles
 - Evidence of “hollow plasma” with axial density depletion
 - Very good spatial resolution (profiles show grid-elements)

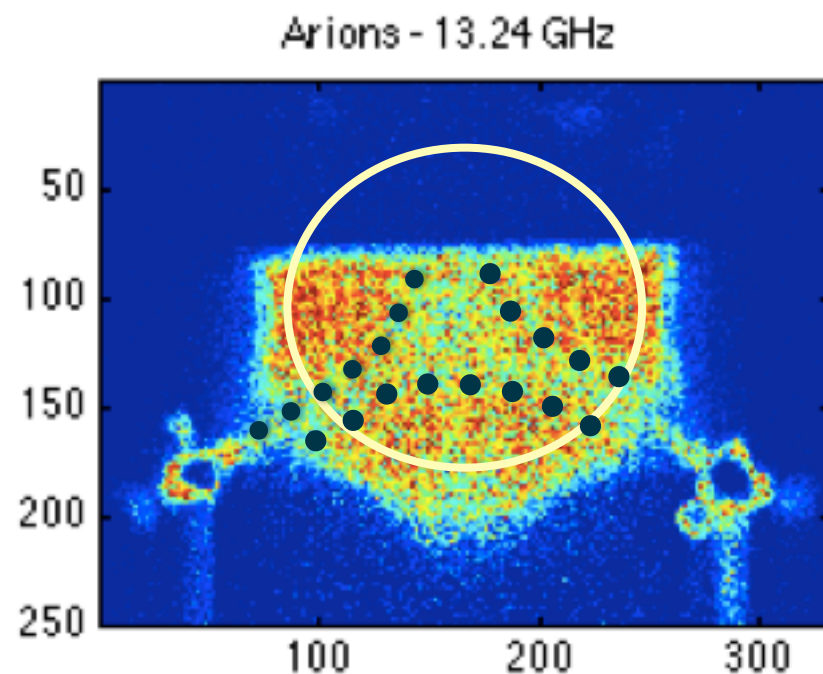
Analysis of plasma morphology

$2.8 < E < 3.5$ keV



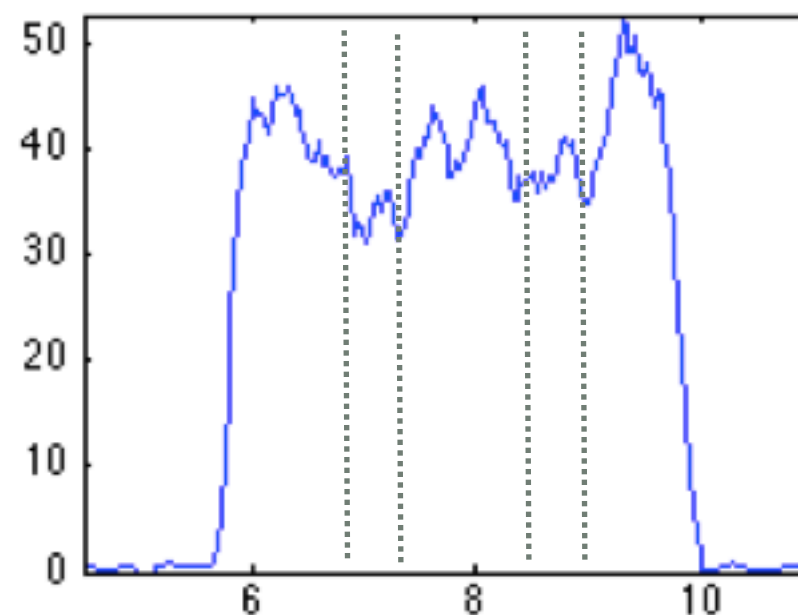
Analysis of plasma morphology

$2.8 < E < 3.5$ keV



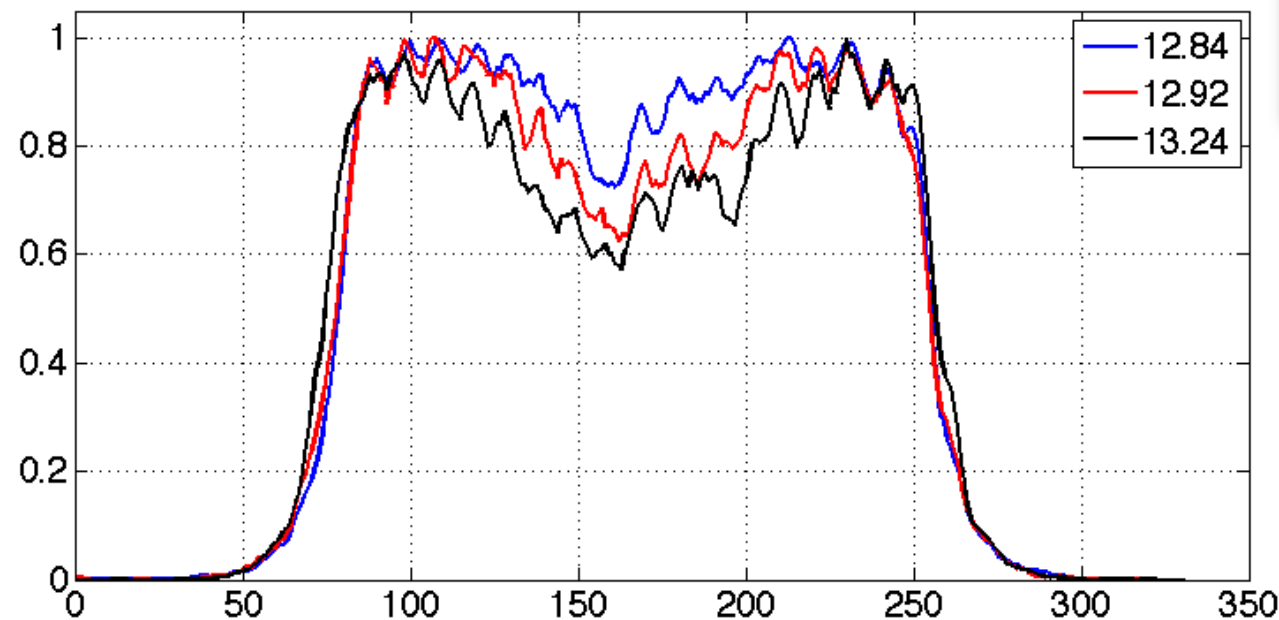
Pole depletion

azimuthal density profile



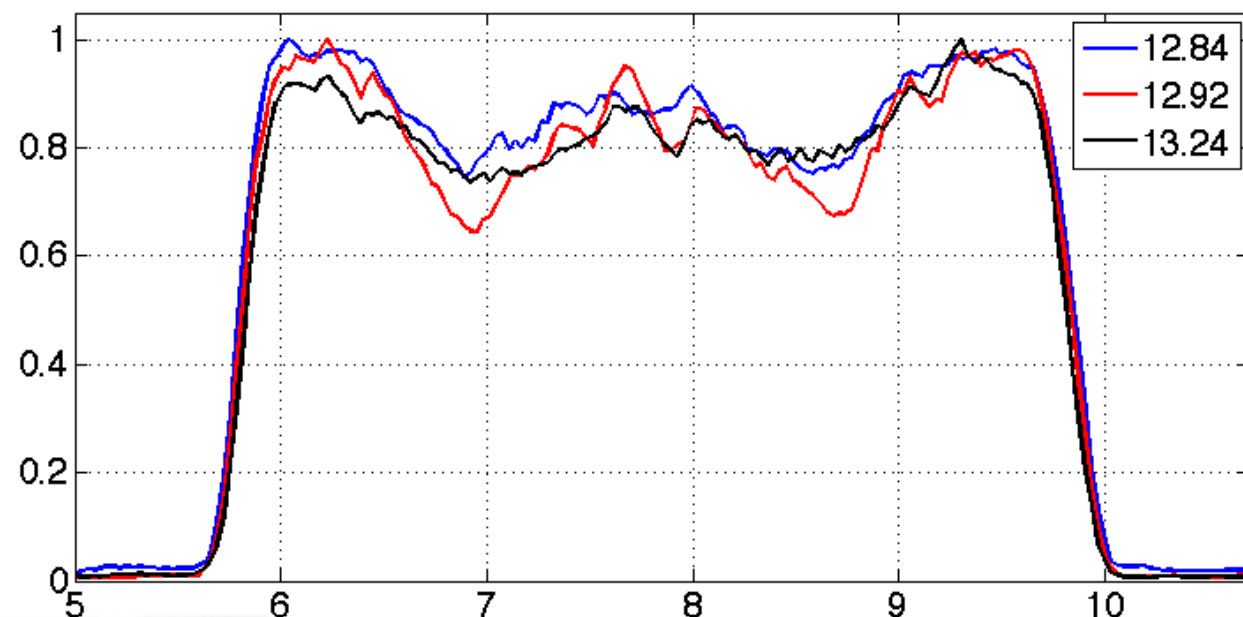
- Azimuthal profile
- Asymmetric plasma
- Magnetic bunch depletion

Analysis of shape factors



horizontal profiles

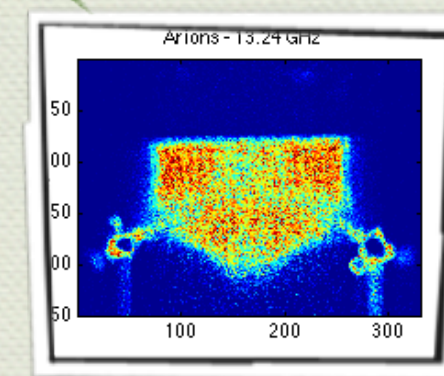
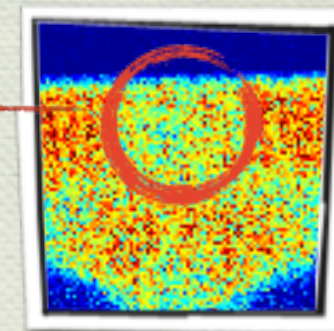
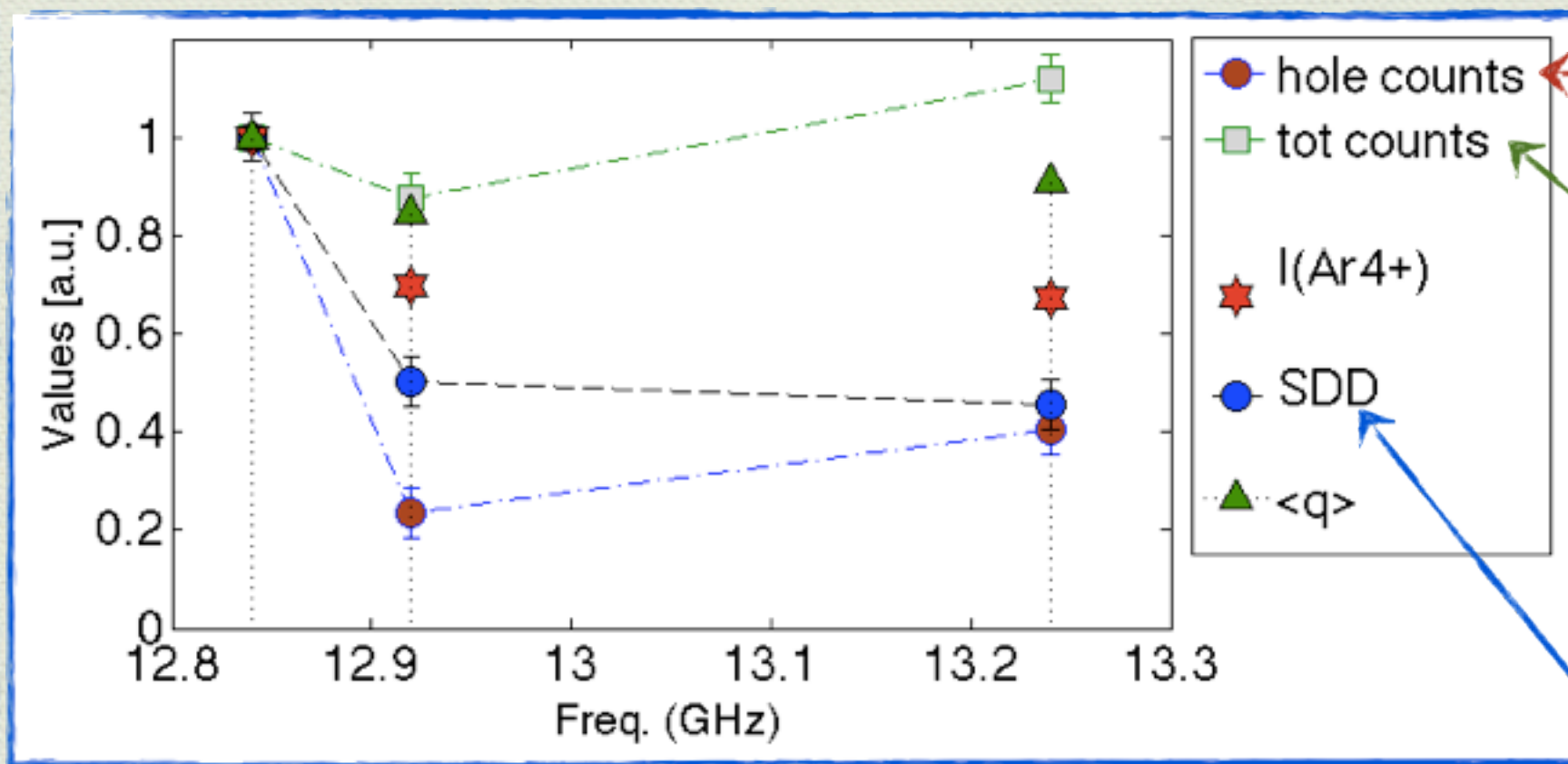
SHAPE FACTOR:
regardless from absolute intensity, the “hollow type” profile is affected by the RF freq.



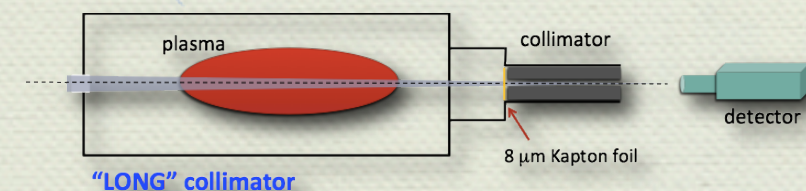
azimuthal profiles

depletion in “poles” regions also varies with RF frequency

Analysis of plasma morphology



full Ar-lines image integration



X-rays along the SDD sightline

Relative (to 12.84 GHz) comparisons:
Despite 13.24 GHz has the highest number of counts in the full-frame image, but its "near-axis" density is lower than 12.84 GHz case

Strict interplay between total density and - especially - concentration in near axis region comes out.

Comparison with self-consistent simulations

Solving the **time-dependent Vlasov equation**, including single particle collisions

$$\frac{\partial f_\alpha}{\partial t} + \vec{v} \cdot \vec{\nabla} f_\alpha + \frac{q_\alpha}{m_\alpha} \left(\vec{E} + \frac{\vec{v} \times \vec{B}}{c} \right) \cdot \vec{\nabla}_{\vec{v}} f_\alpha = 0$$

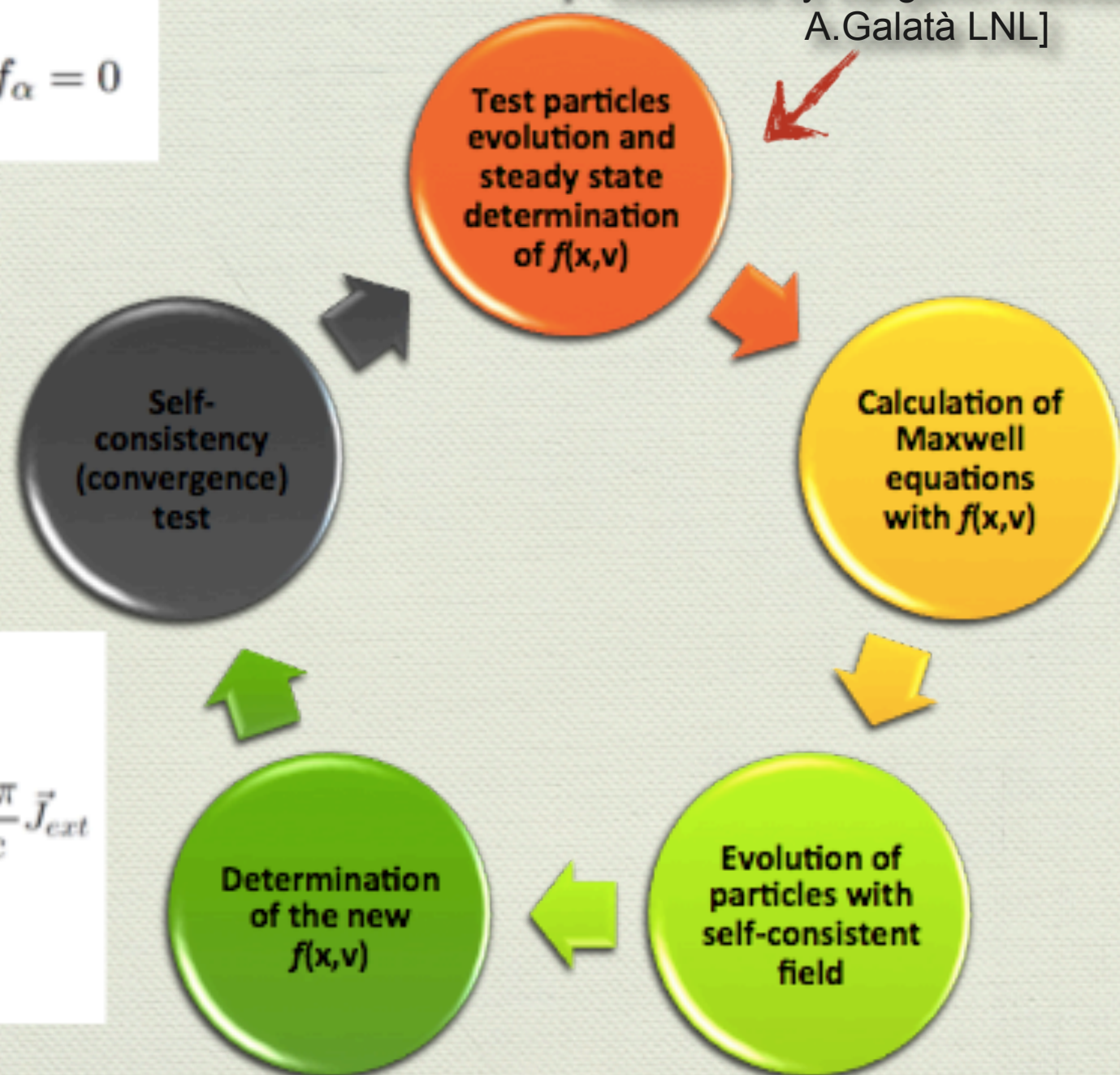
$$\frac{d\vec{v}}{dt} = \frac{q}{m_0 \gamma} \left[\vec{E} + \vec{v} \times \vec{B} - \frac{\vec{v} \cdot \vec{E}}{c^2} \vec{v} \right]$$

Collisions by Langevin method [jointly
A.Galatà LNL]

Step-by-step current

Step-by-step plasma density

$$\begin{aligned} \vec{\nabla} \cdot \vec{E} &= 4\pi \sum_{\alpha} \bar{n}_{\alpha} q_{\alpha} \int f_{\alpha} d\vec{v} + 4\pi \rho_{ext} \\ \vec{\nabla} \times \vec{B} &= \frac{1}{c} \frac{\partial \vec{E}}{\partial t} + \frac{4\pi}{c} \sum_{\alpha} \bar{n}_{\alpha} q_{\alpha} \int \vec{v} f_{\alpha} d\vec{v} + \frac{4\pi}{c} \vec{J}_{ext} \\ \vec{\nabla} \times \vec{E} &= -\frac{1}{c} \frac{\partial \vec{B}}{\partial t} \end{aligned}$$



Comparison with self-consistent simulations

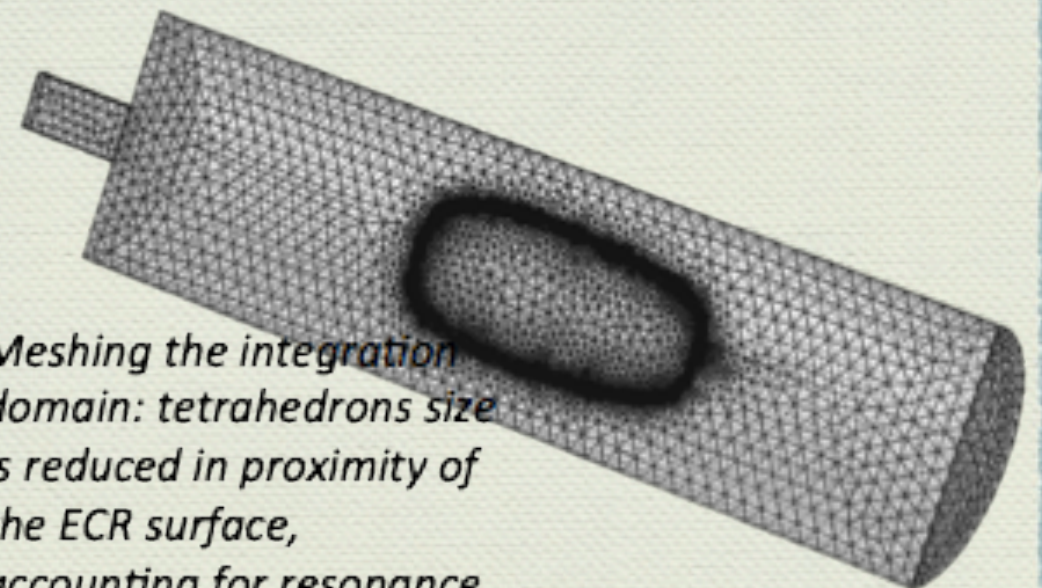
Solution of Maxwell's equations in **COMSOL** using MUMPS direct solver

Full anisotropic dielectric tensor for the magnetized plasma computed in **MATLAB**

Electromagnetic field in ECRIS Plasma

$$\nabla \times \nabla \times \mathbf{E} - \frac{\omega^2}{c^2} \overline{\overline{\epsilon_r}} \cdot \mathbf{E} = 0$$

Wave equation with tensorial permittivity



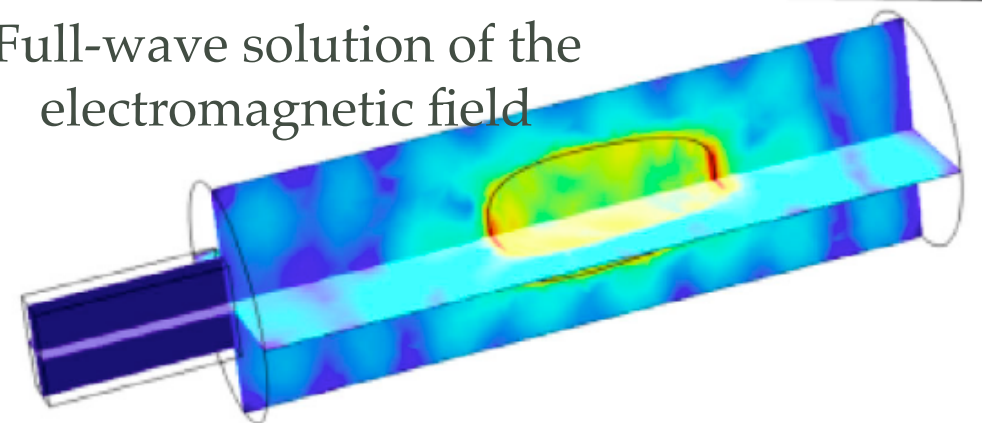
Meshing the integration domain: tetrahedrons size is reduced in proximity of the ECR surface, accounting for resonance.

$$\overline{\overline{\epsilon}} = \epsilon_0 \overline{\overline{\epsilon_r}} = \epsilon_0 \left(\overline{\overline{\epsilon'}} - i \overline{\overline{\epsilon''}} \right) = \epsilon_0 \left(\overline{\overline{I}} - \frac{i \overline{\overline{\sigma}}}{\omega \epsilon_0} \right)$$

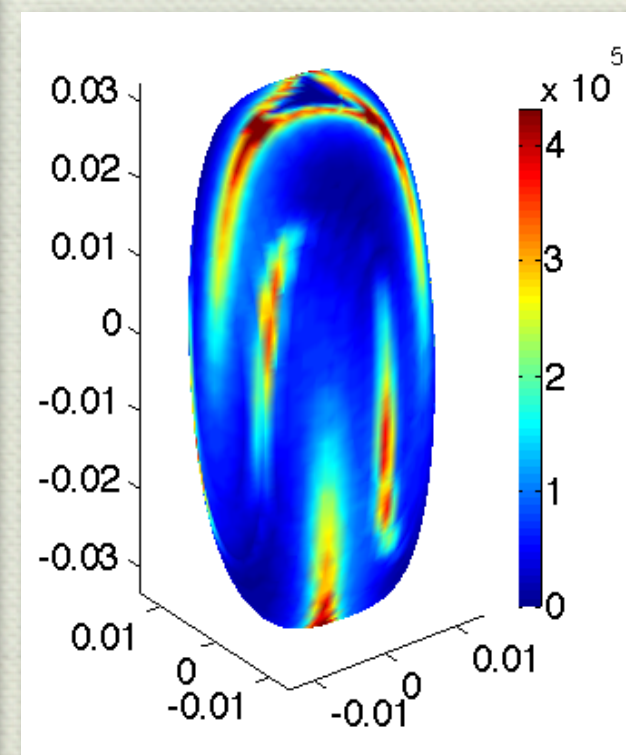
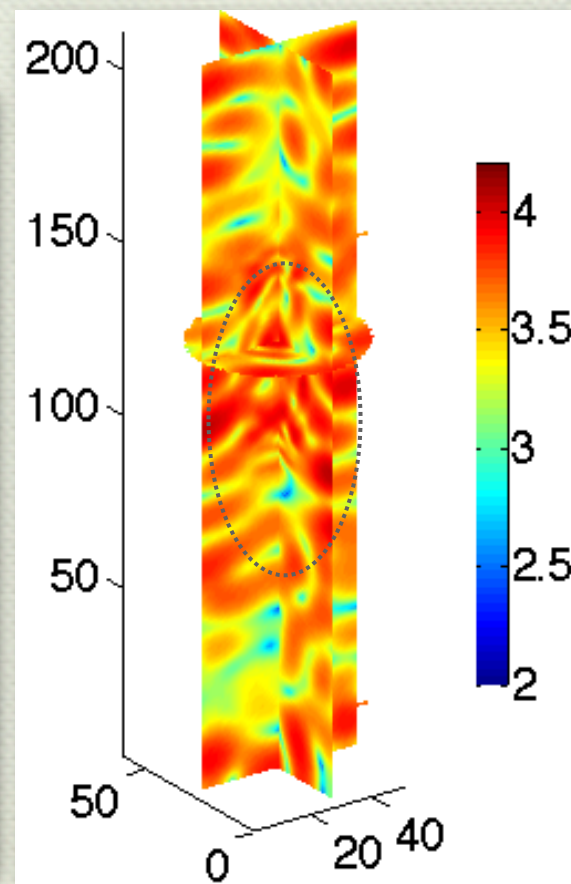
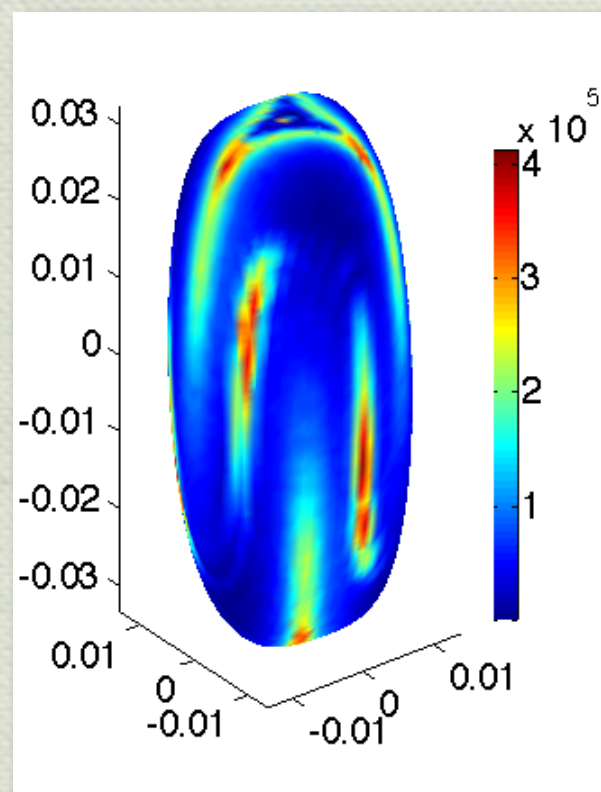
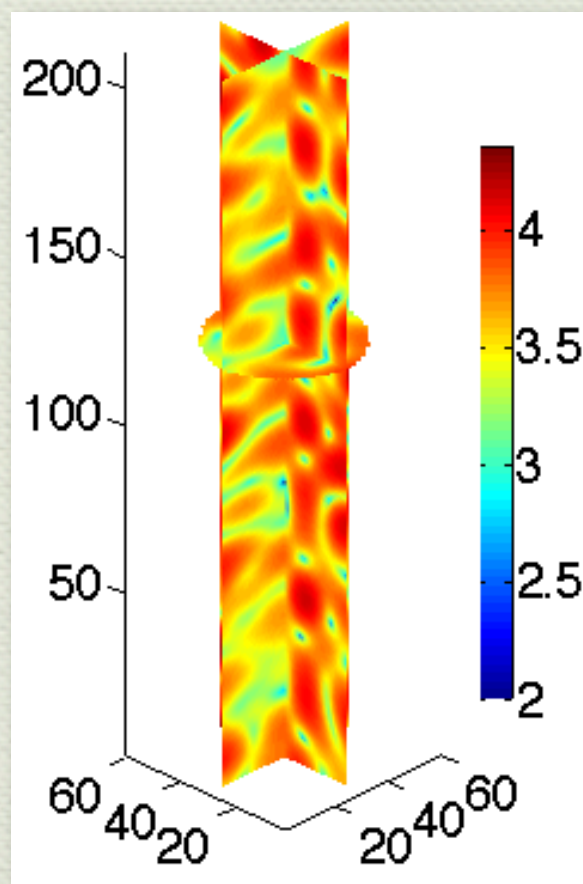
$$= \epsilon_0 \begin{bmatrix} 1 + i \frac{\omega_p^2}{\omega} \frac{a_x}{\Delta} & i \frac{\omega_p^2}{\omega} \frac{c_z + d_{xy}}{\Delta} & i \frac{\omega_p^2}{\omega} \frac{-c_y + d_{xz}}{\Delta} \\ i \frac{\omega_p^2}{\omega} \frac{-c_z + d_{xy}}{\Delta} & 1 + \frac{i \omega_p^2}{\omega} \frac{a_y}{\Delta} & i \frac{\omega_p^2}{\omega} \frac{c_x + d_{yz}}{\Delta} \\ i \frac{\omega_p^2}{\omega} \frac{c_y + d_{xz}}{\Delta} & i \frac{\omega_p^2}{\omega} \frac{-c_x + d_{zy}}{\Delta} & 1 + i \frac{\omega_p^2}{\omega} \frac{a_z}{\Delta} \end{bmatrix}$$

Full-3D non homogeneous dielectric permittivity
Tensor depends on local density and B-field

Full-wave solution of the electromagnetic field



Searching self-consistency



Freq. dom. solution **step 0**
(vacuum cavity)

Particle Tracking **step 1**
(vacuum field
+plasmoid-halo initial
density distr.)

Freq. dom. solution **step 1**
(70% density from
plasmoid halo model
+30% step-1 density
structure)

Particle Tracking **step 2**
(70% vacuum field +
30% step-1 full-wave
calculated field)

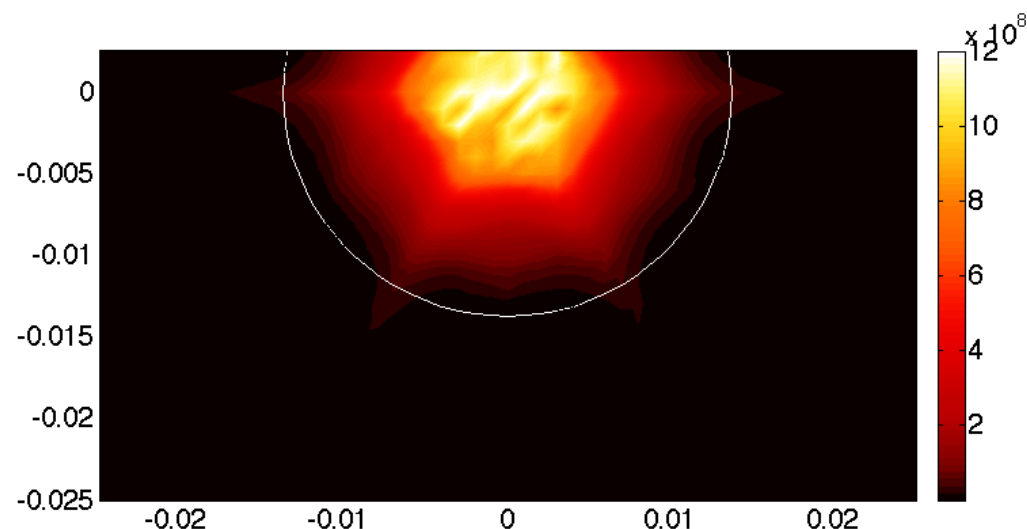
Plasma shape at different energy domains

12.84 GHz

Cold Electrons

$E < 1 \text{ keV}$

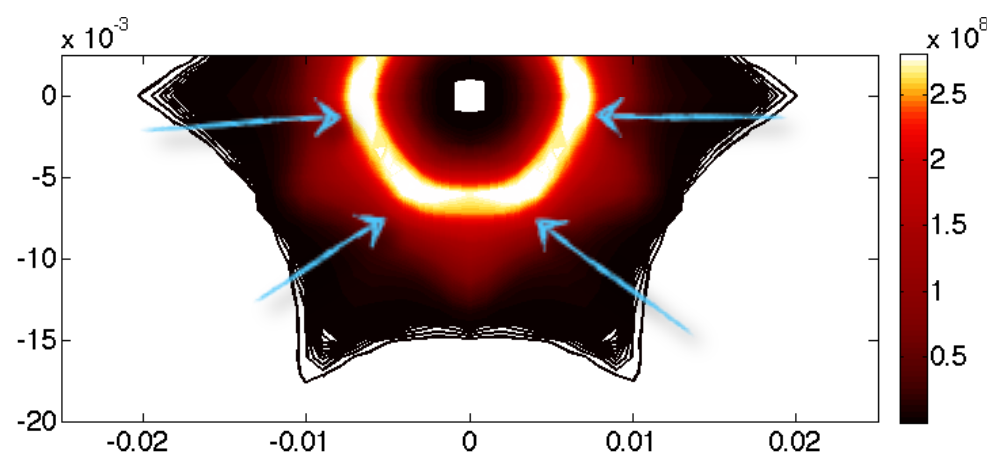
concentration in the near axis region



Warm electrons

$2 \text{ keV} < E < 30 \text{ keV}$

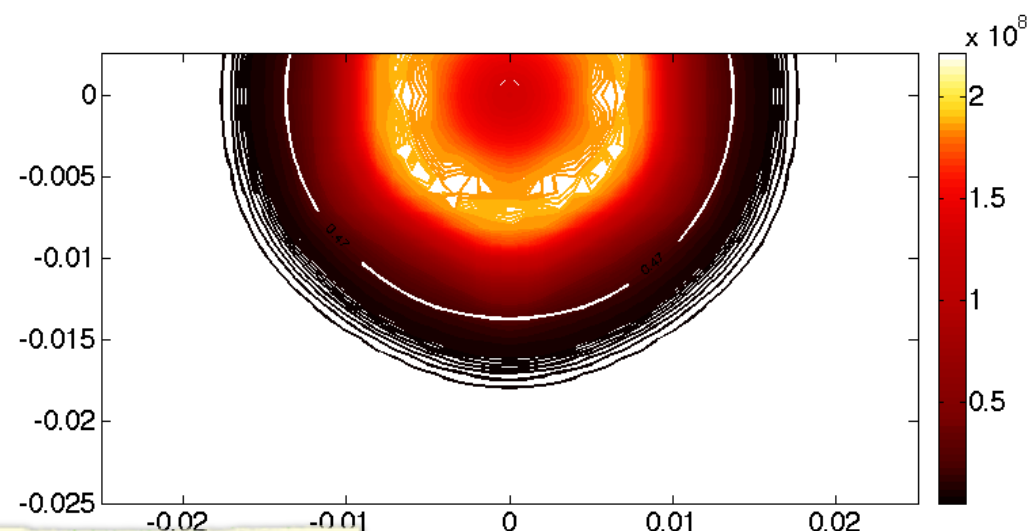
bright annulus with intense spots in off-pole region



Hot electrons

$E > 30 \text{ keV}$

broad annulus well inside the resonance layer

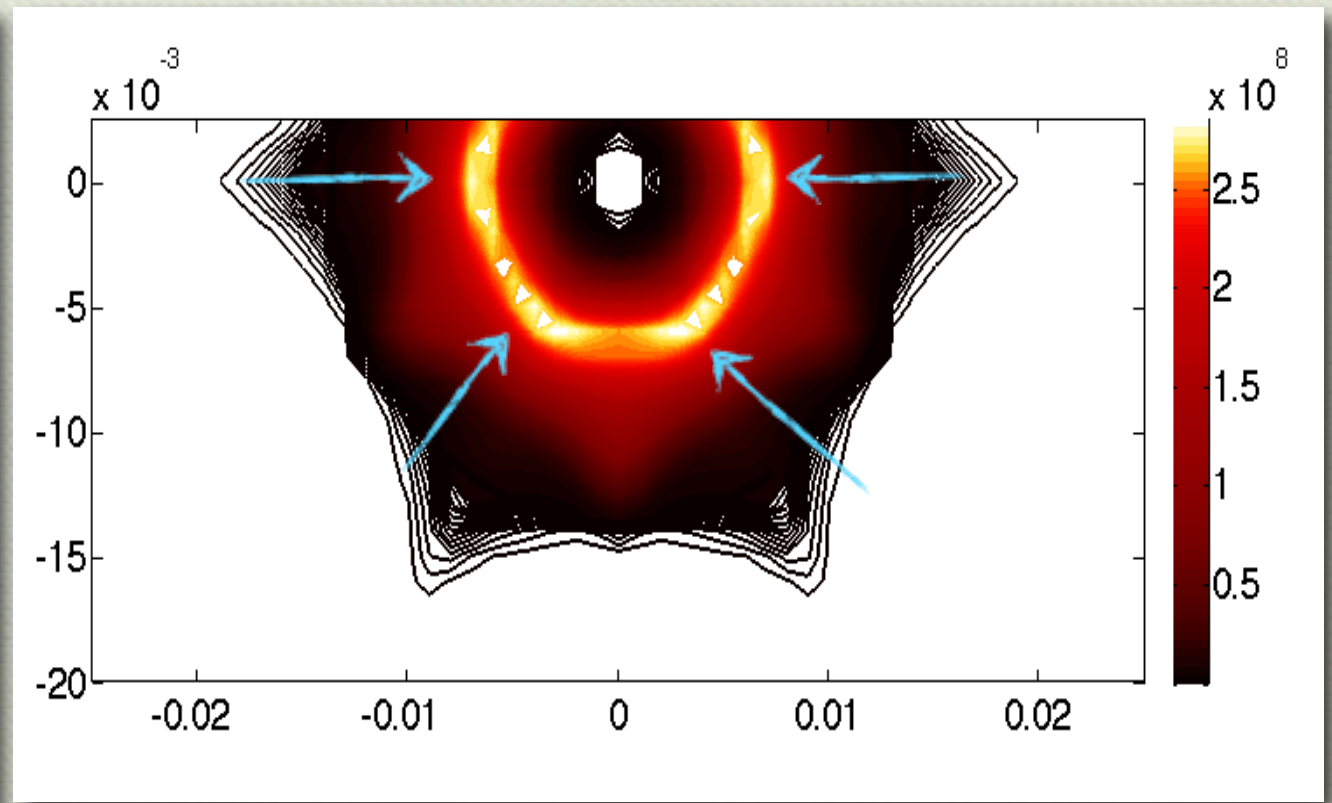
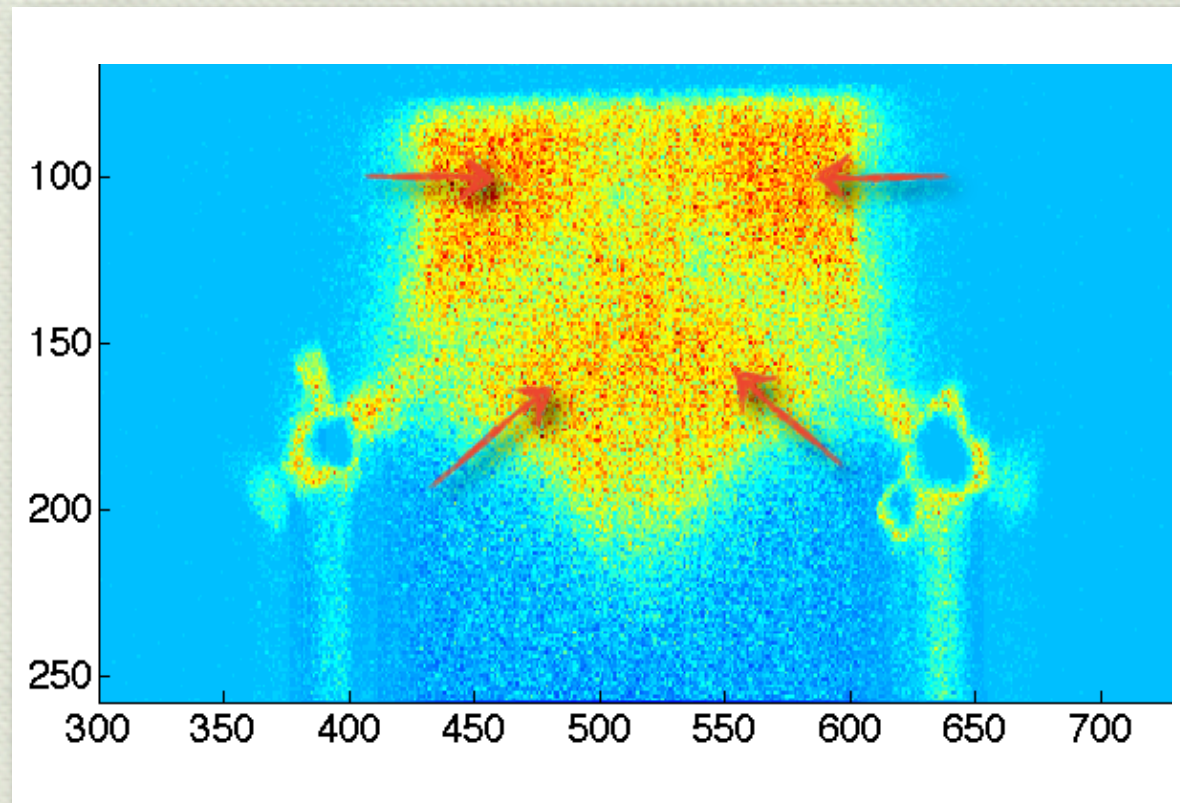


Comparison to self-consistent simulations

12.92 GHz

Experimental result Ar-fluor. 3 keV

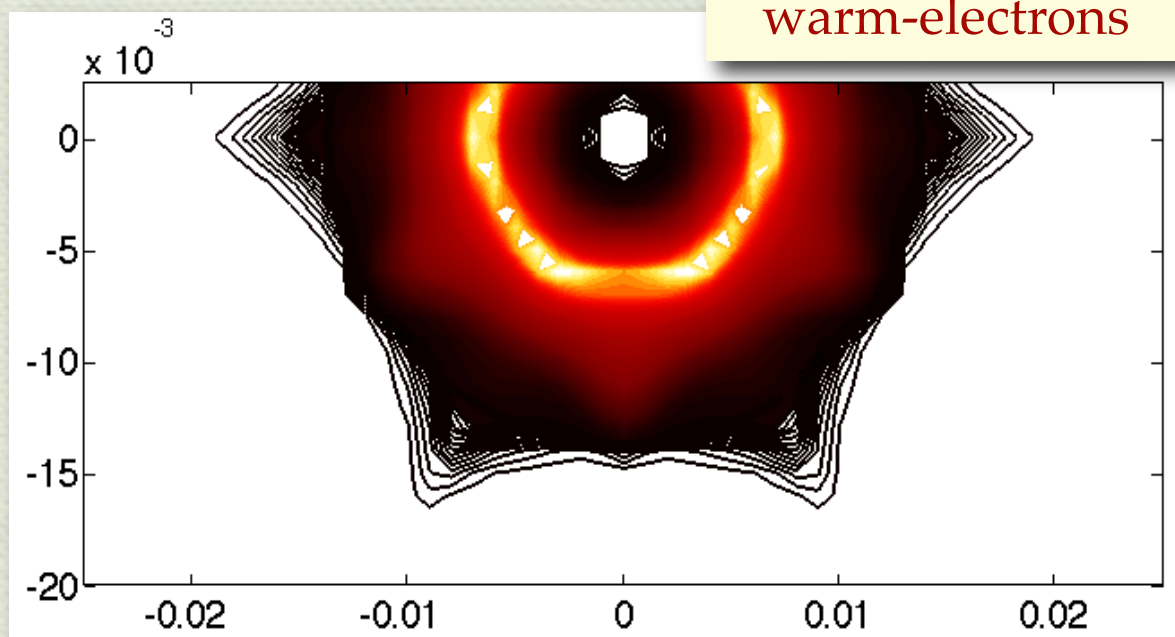
Simulations - warm electrons at $2 < E < 30$ keV



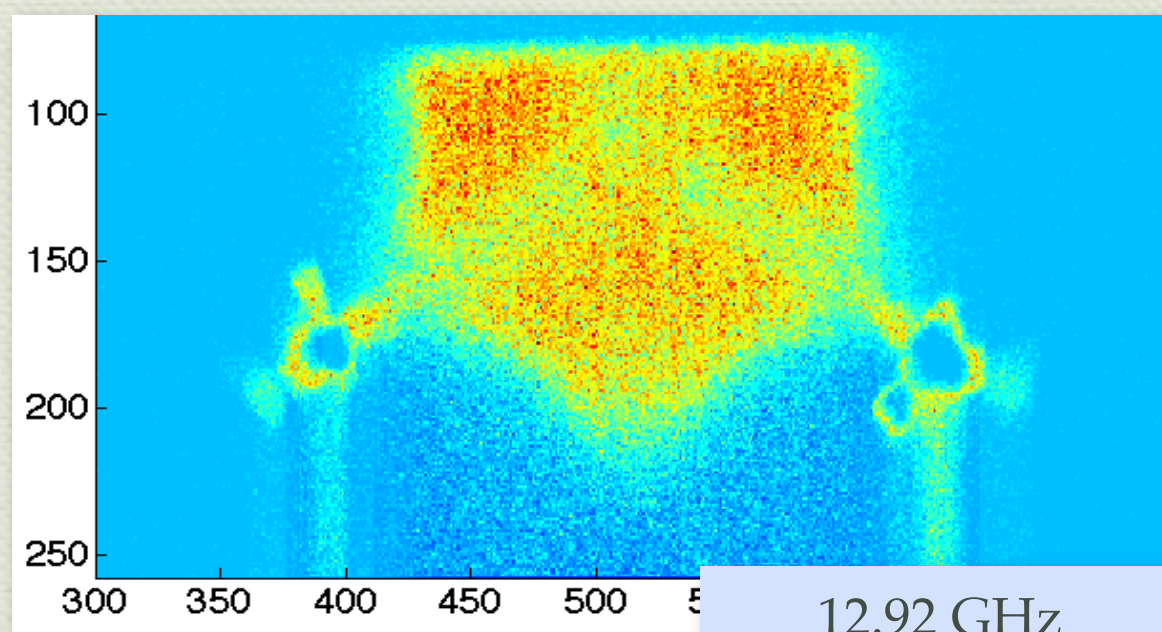
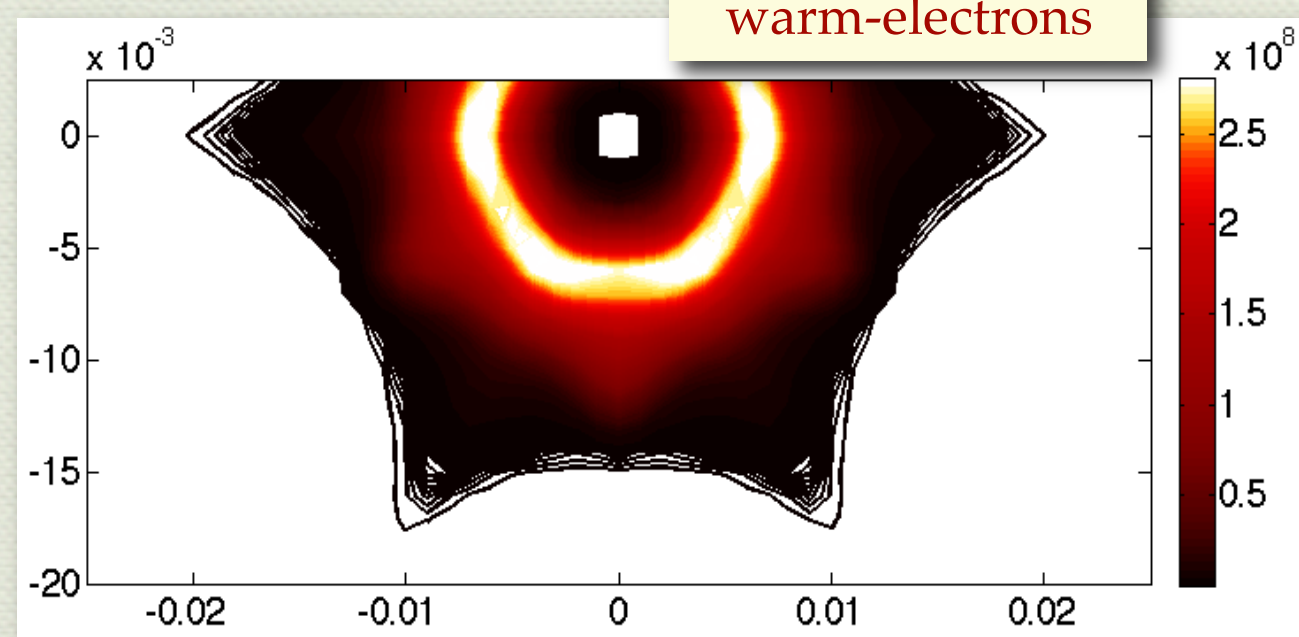
- Argon ions occupy far-from-poles positions: from comparison to simulations it comes out there warm electrons (having enough energy for ionisation and excitation) are placed
- Next step: comparison of two frequencies

Comparison to self-consistent simulations 12.84 + 12.92 GHz

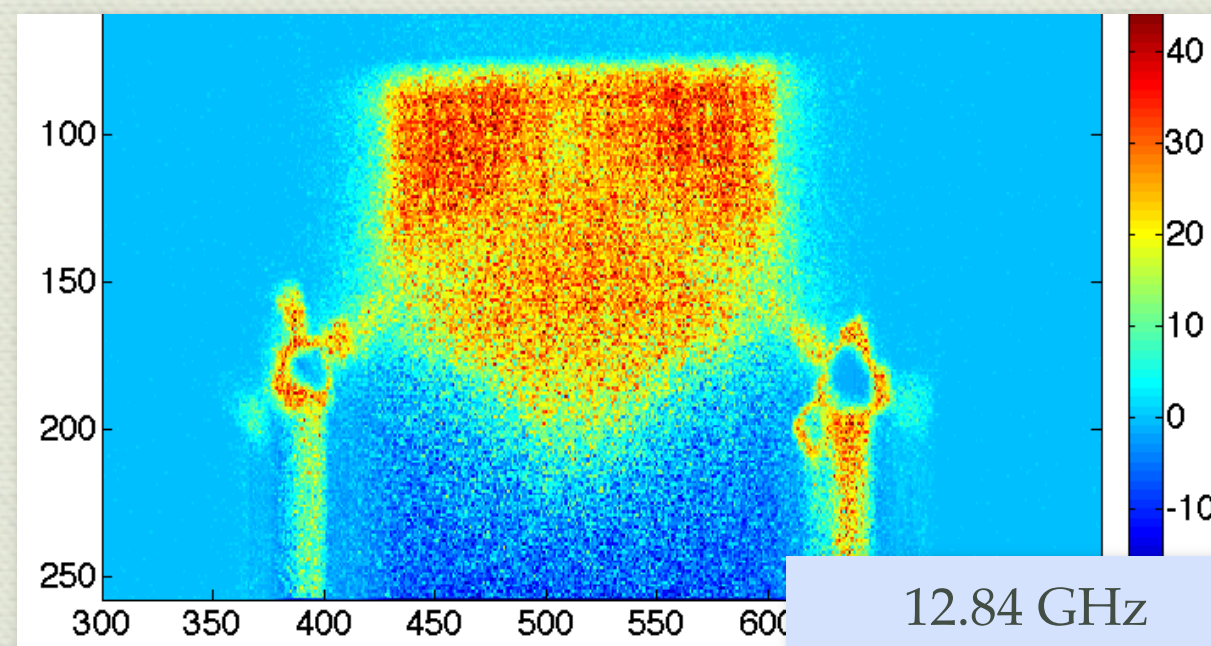
12.92 GHz
warm-electrons



12.84 GHz
warm-electrons

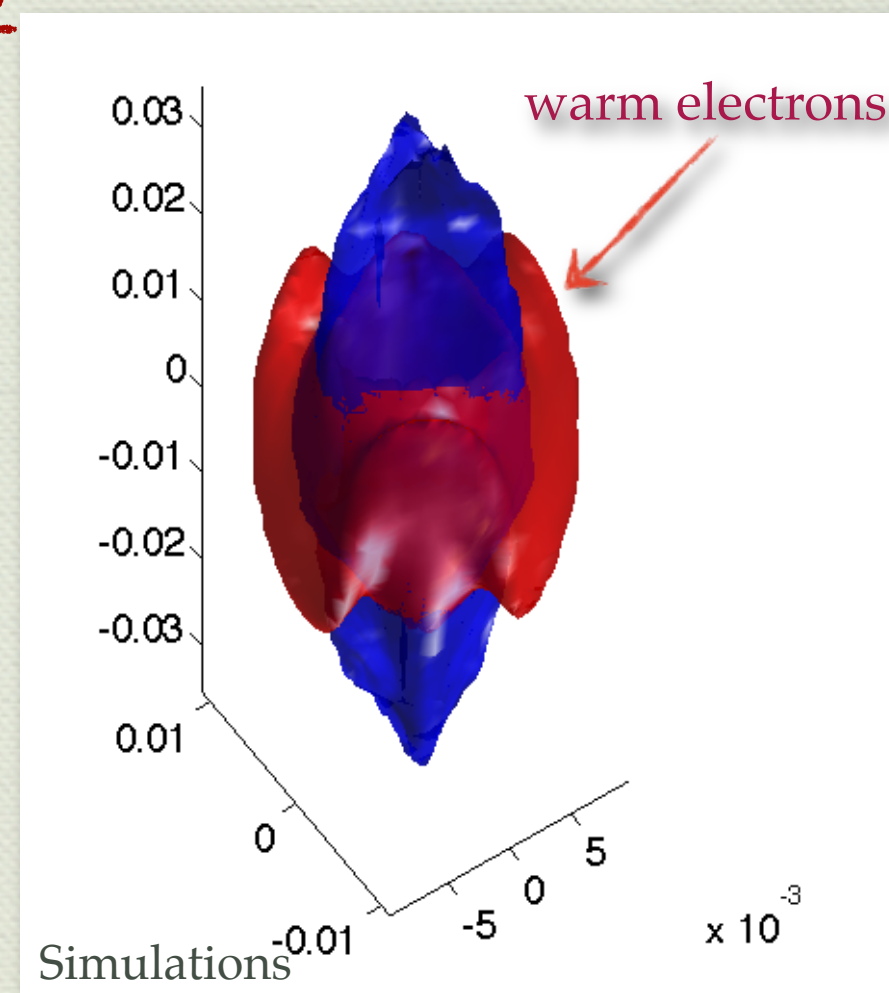
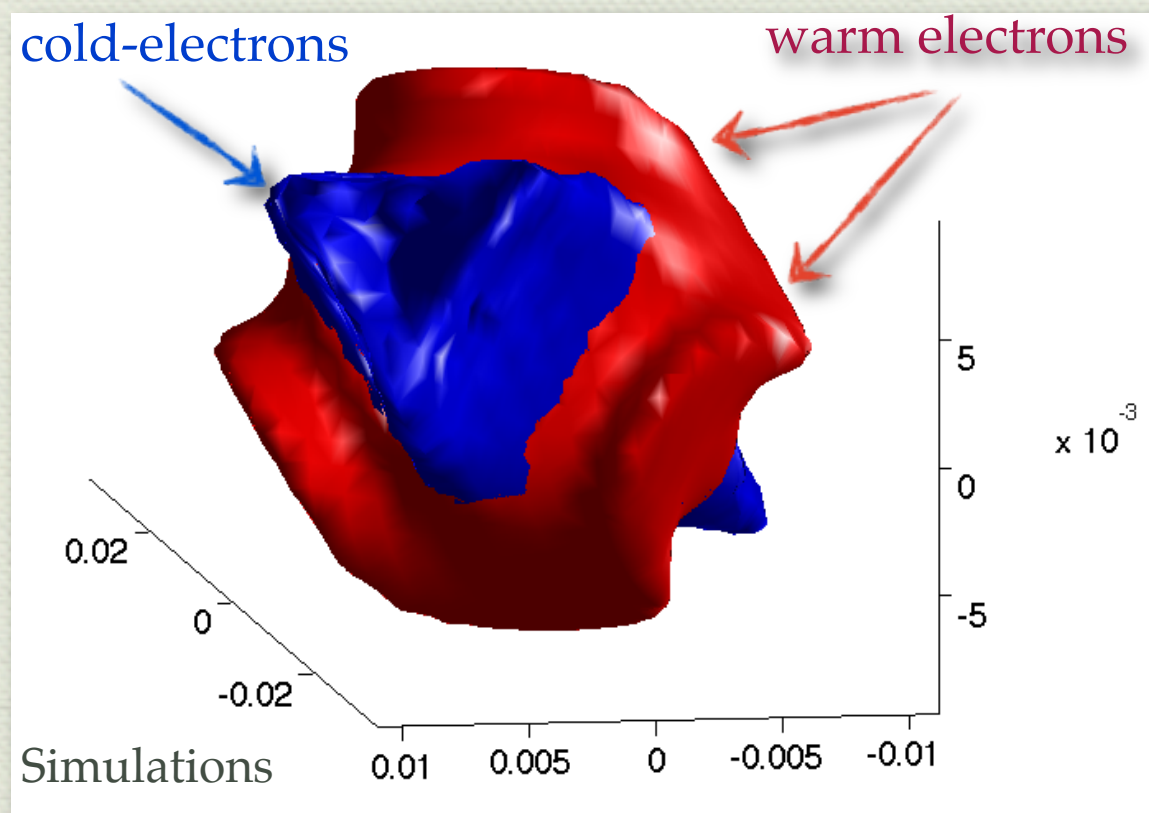


12.92 GHz
Ar fluor. lines

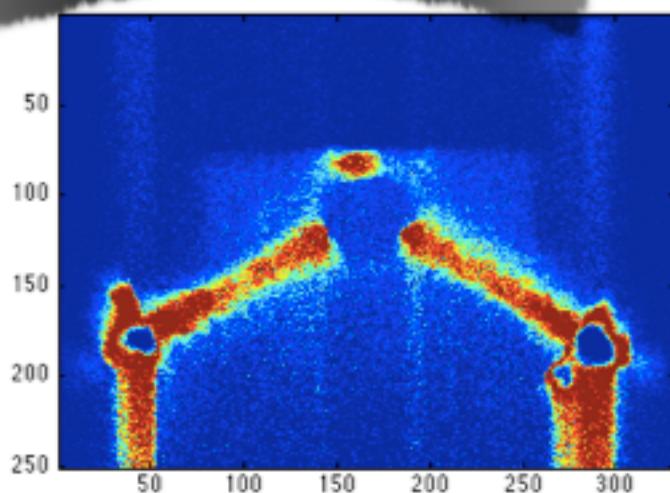


12.84 GHz
Ar fluor. lines

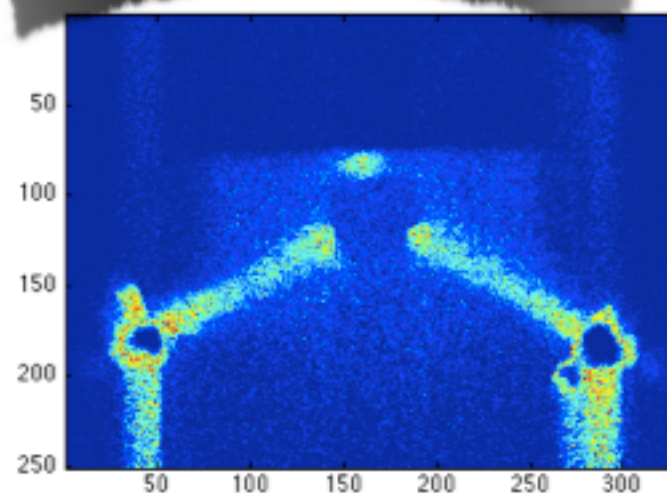
Comparison to self-consistent simulations 12.84 GHz



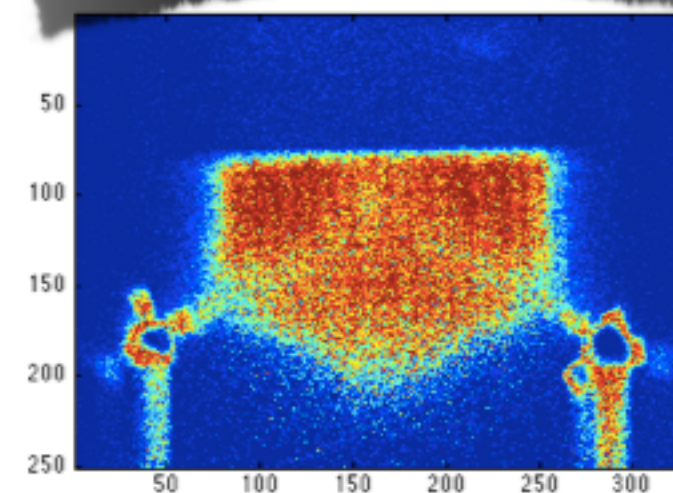
E < 1.5 keV



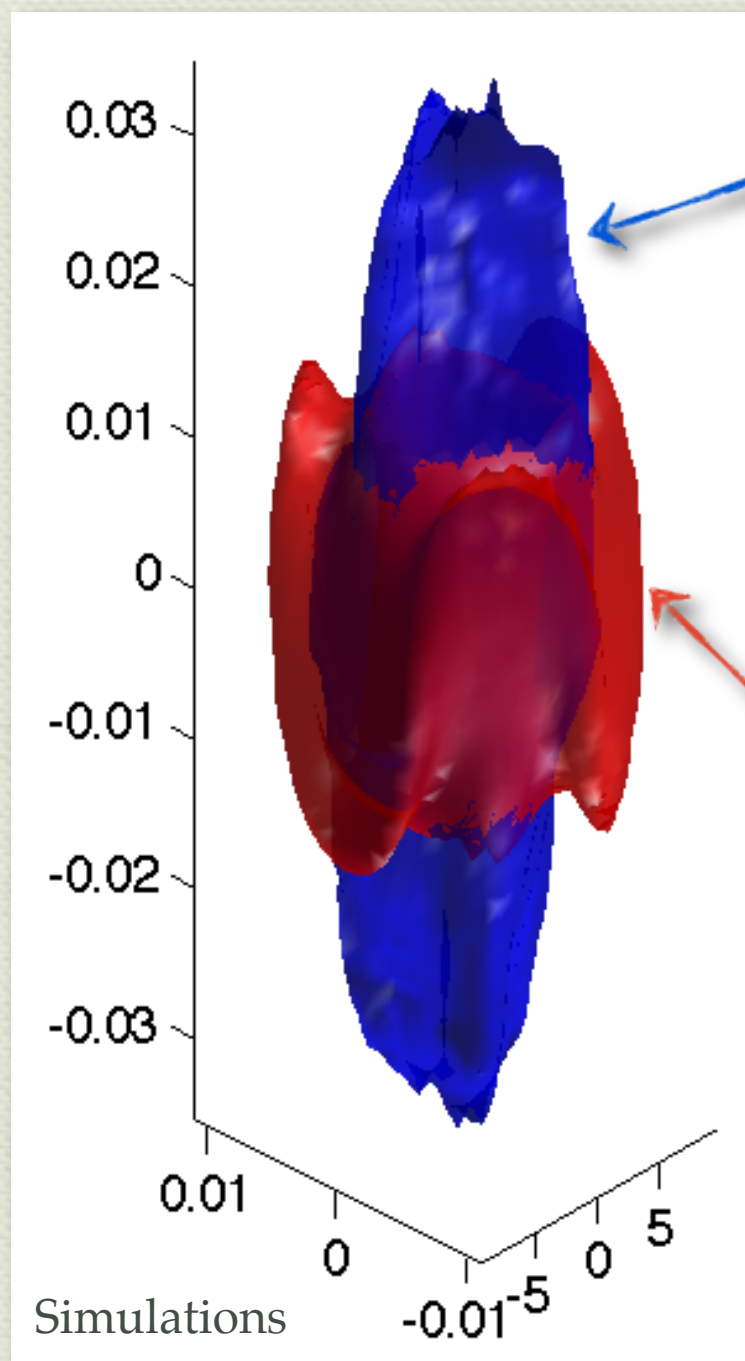
1.5 < E < 2.5 keV



2.5 < E < 3.5 keV - Ar ions



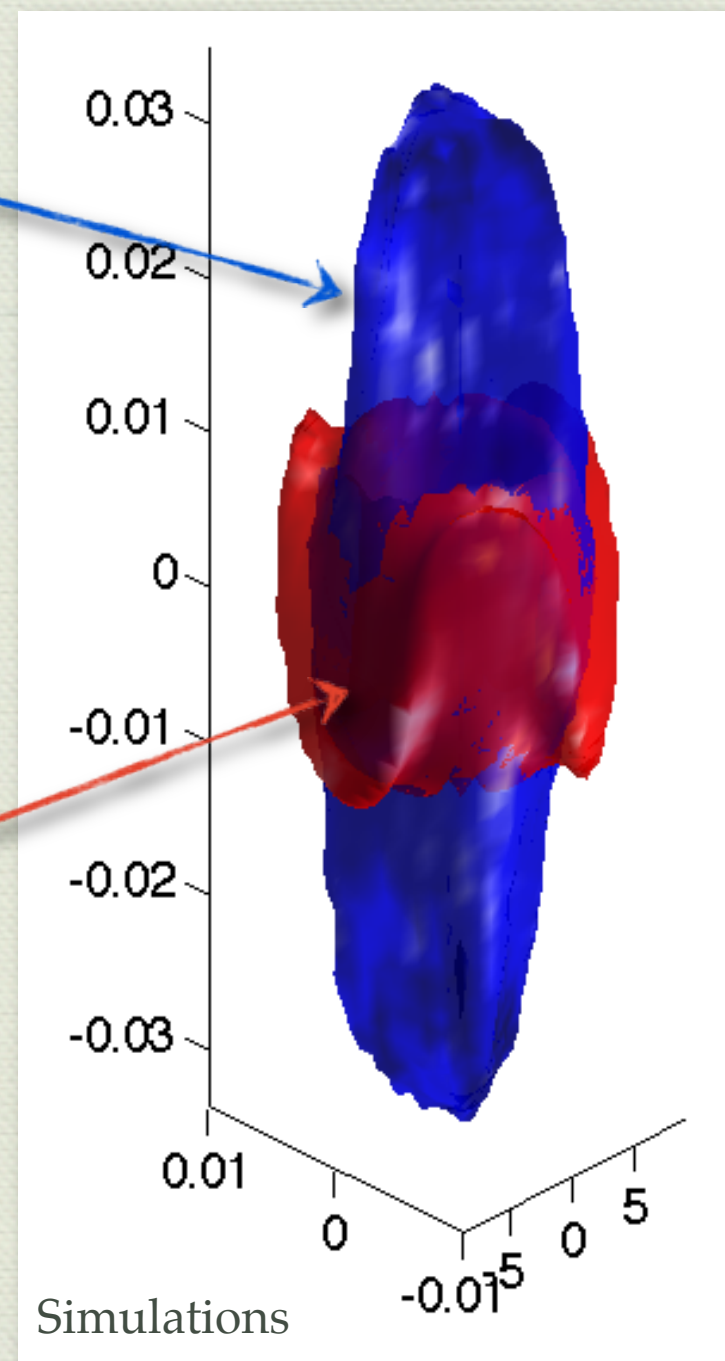
Comparison to self-consistent simulations 12.84 + 12.92 GHz



12.84 GHz
cold & warm electrons

cold-electrons

warm electrons
have different
morphology



12.92 GHz
cold & warm electrons

Achievements and Perspectives

- We are now able to see what happens into the plasma and to model through numerical simulations how it could be happen differently (and in a better way)

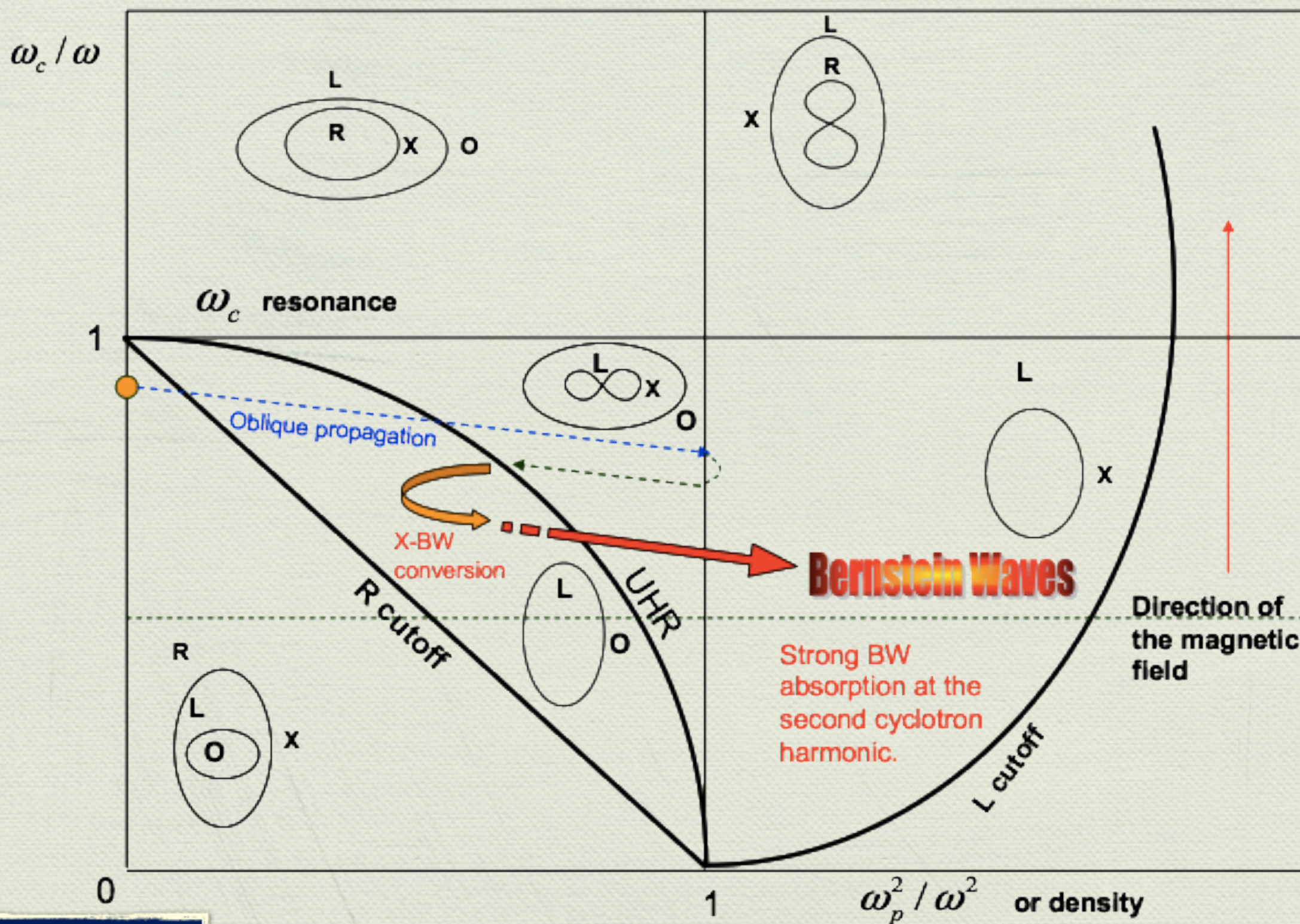
- Microwave absorption oriented design is needed: Power deposition into the plasma must be performed in a highly controlled way

Single pass absorption

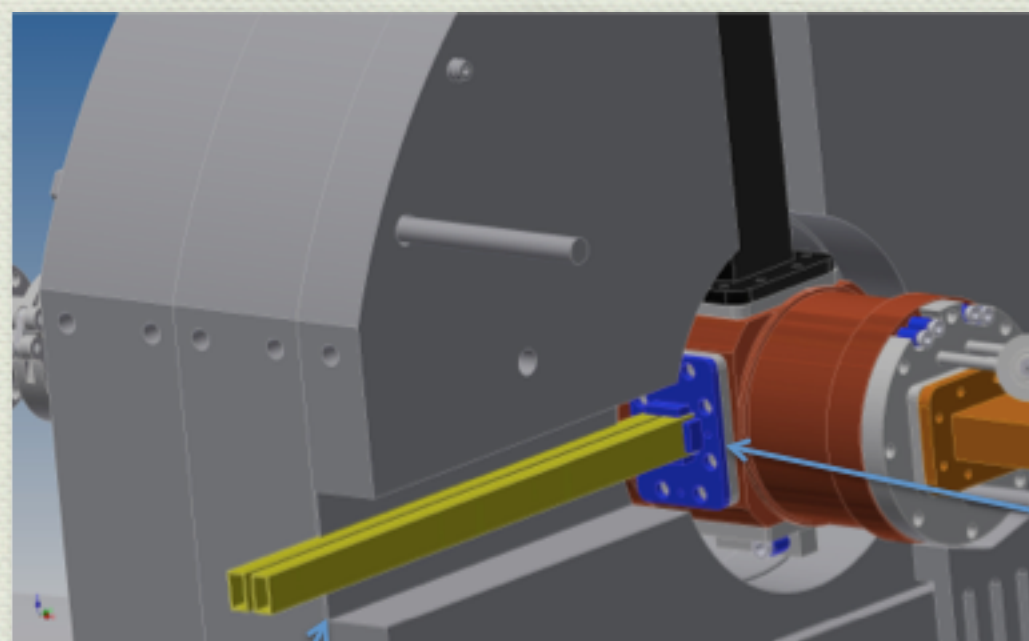
Some ideas

- STILL IN ECR-heating paradigm: are cylindrical shapes of the plasma chamber still mandatory?
- OVERCOMING ECR-heating paradigm: on-purpose design of microwave launchers for inner plasma modal conversion

Modal Conversion for overdense plasma production



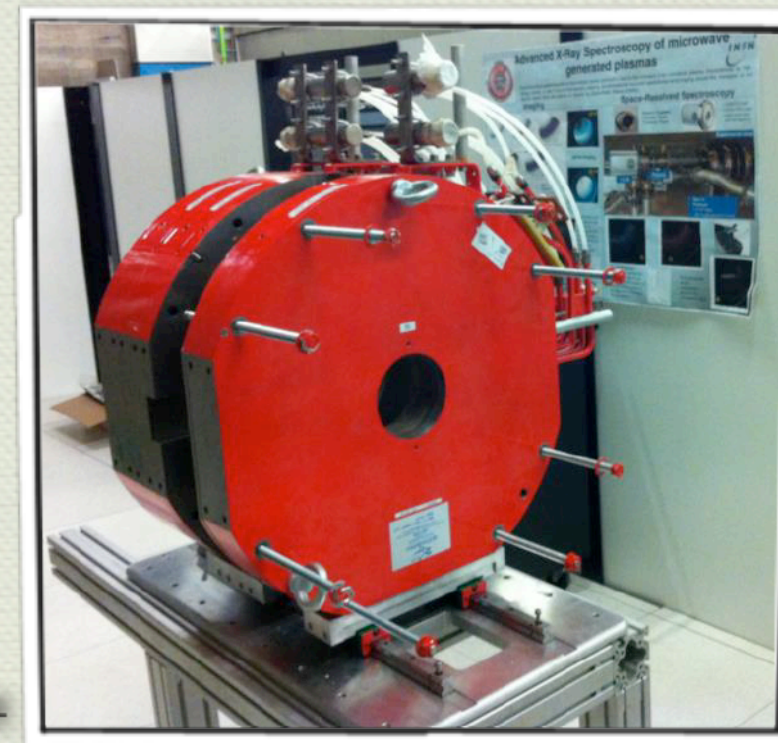
Mechanical Implementation at LNS



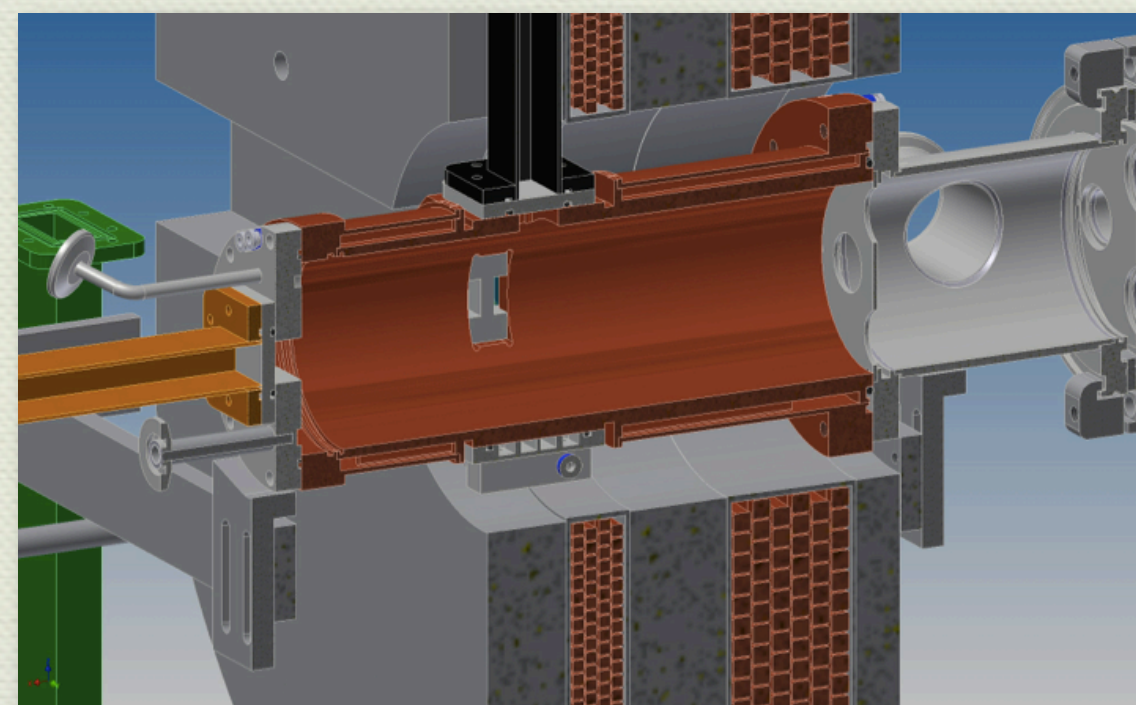
Vacuum Break window

Courtesy of S. Passarelli

ARRAY of two waveguides

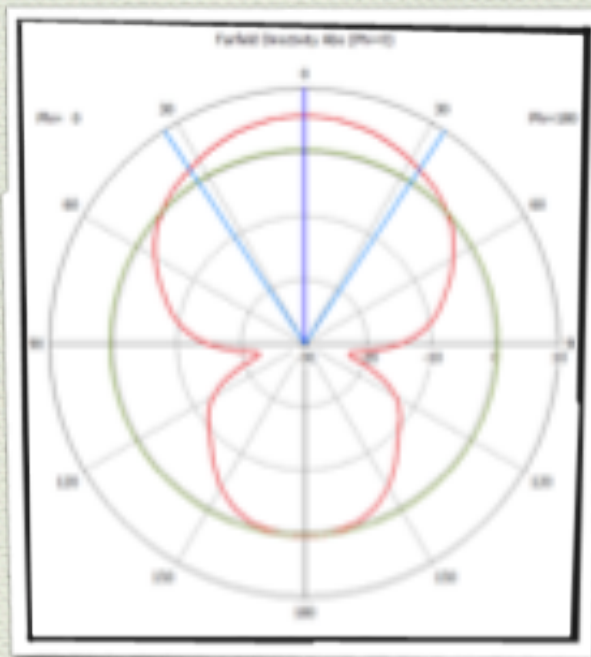


**A new setup developed at LNS for
fundamental studies: RF launcher
construction is ongoing**

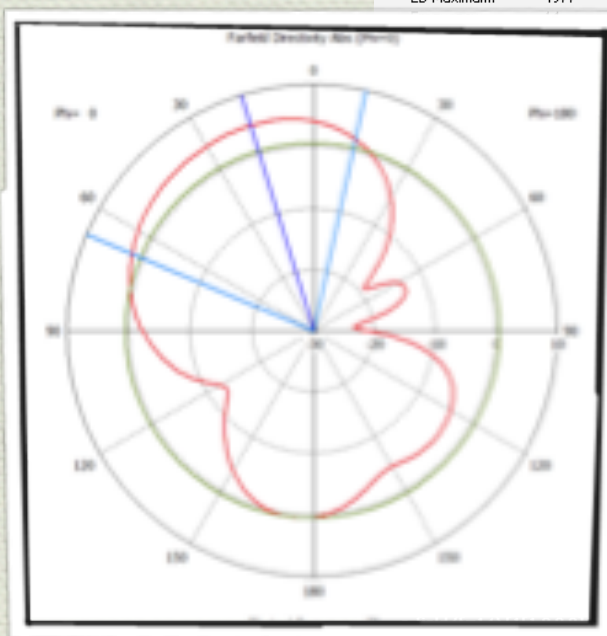
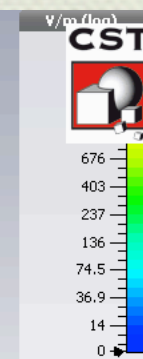
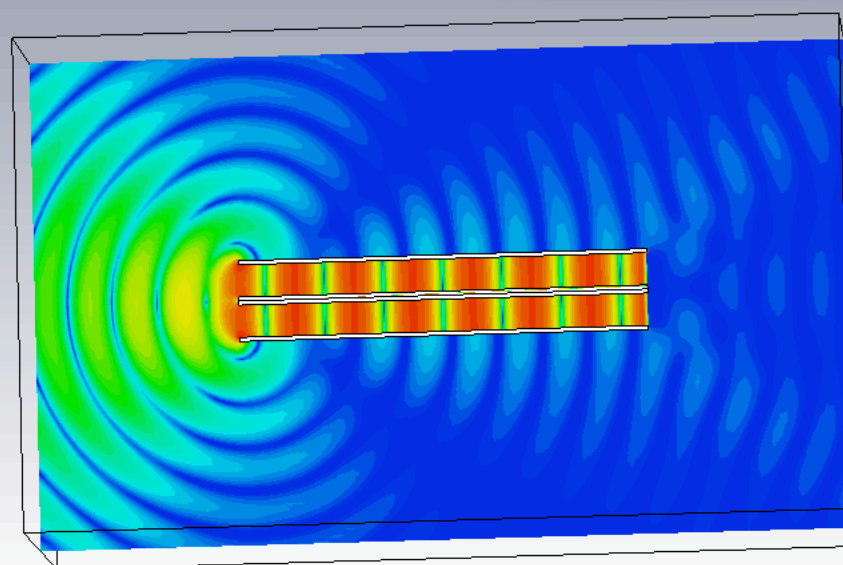


"Microwave-absorption-oriented" design

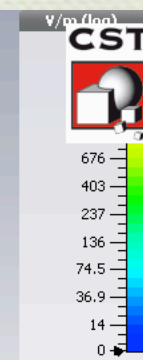
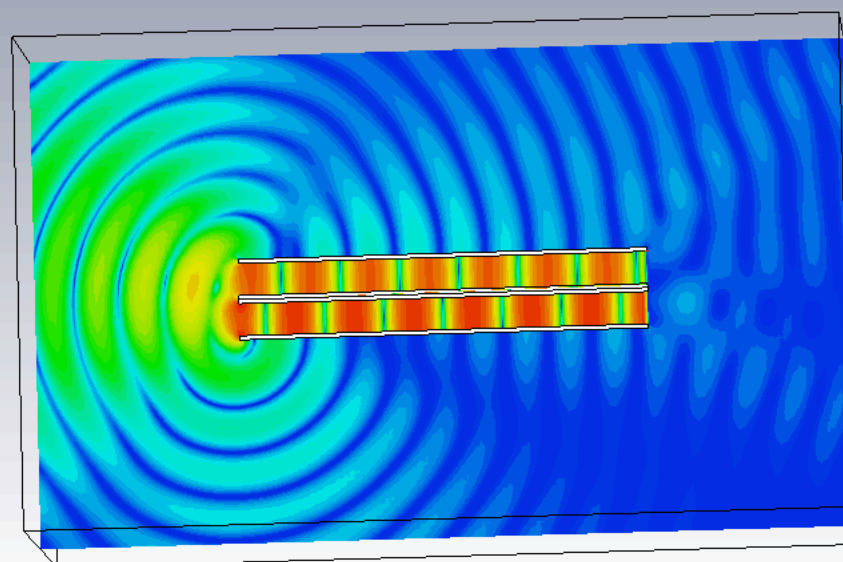
Launcher by "two-waveguides-array": lobe tilt by phase shift for optimizing oblique coupling of O-modes --> modal conversion



e-field (f=14) [1[1,0]+2[1,0],[15.2]] (peak)
Cutplane normal: 1, 0, 0
Cutplane position: 0
Component: Abs
2D Maximum: 4977

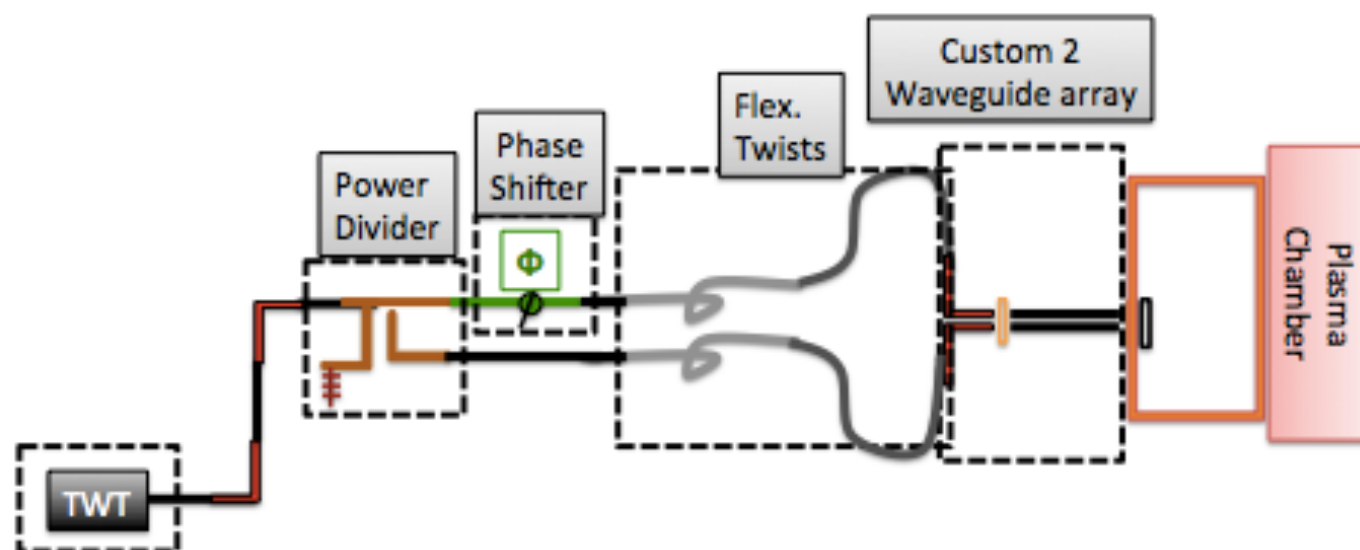


e-field (f=14) [1.0,45],[15.2]] (peak)
Cutplane normal: 1, 0, 0
Cutplane position: 0
Component: Abs
2D Maximum: 5031
Frequency: 14
303.75



Mechanical Implementation at LNS

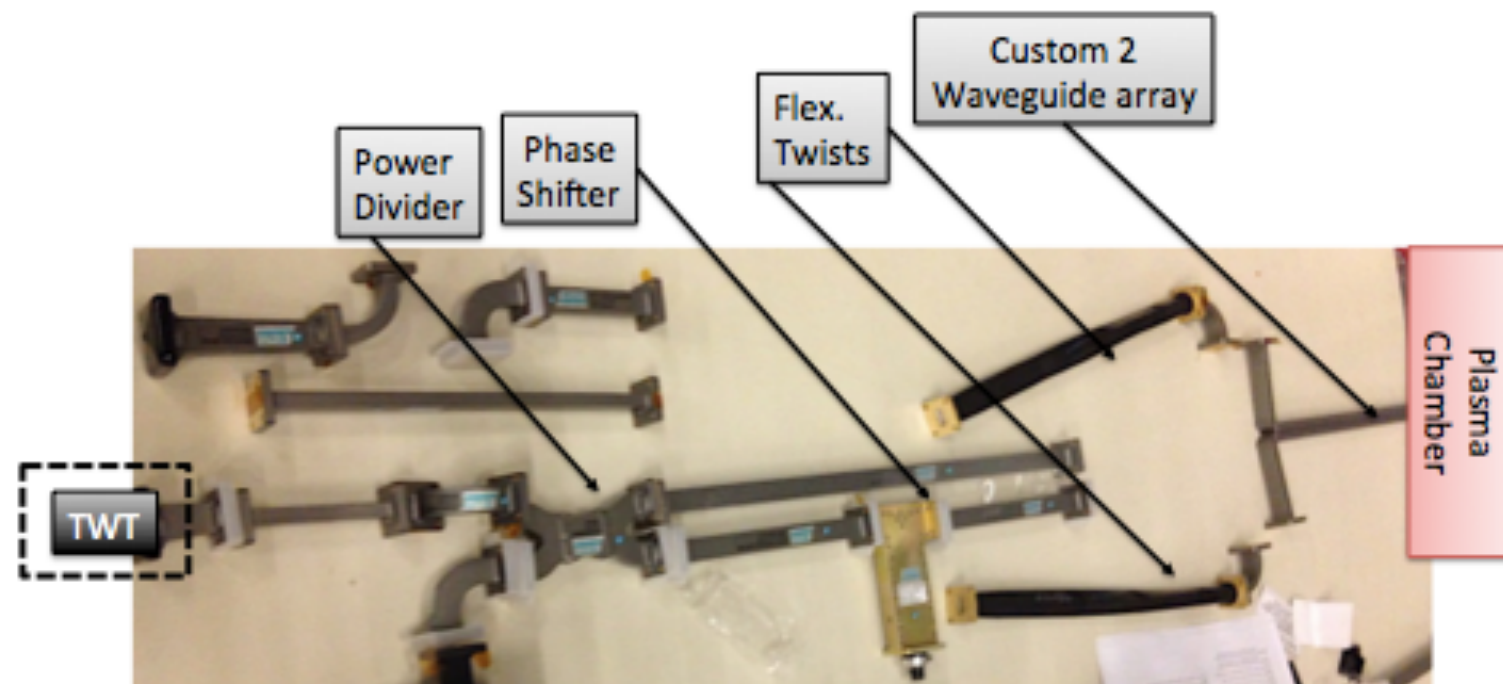
Phased waveguide array of two elements



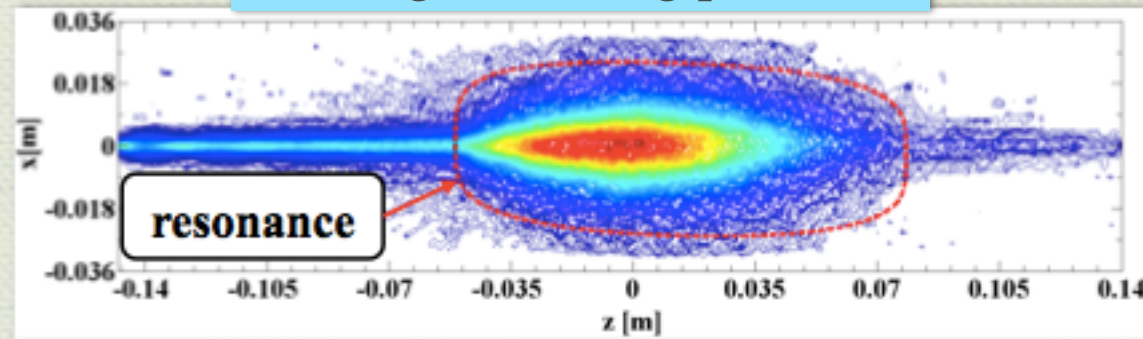
microwave
launcher:
proposed setup

- TWT ampl. 13.75-14.5 GHz
- Power divider
- Phase shifters
- flexible waveguides

MW component procurement completed

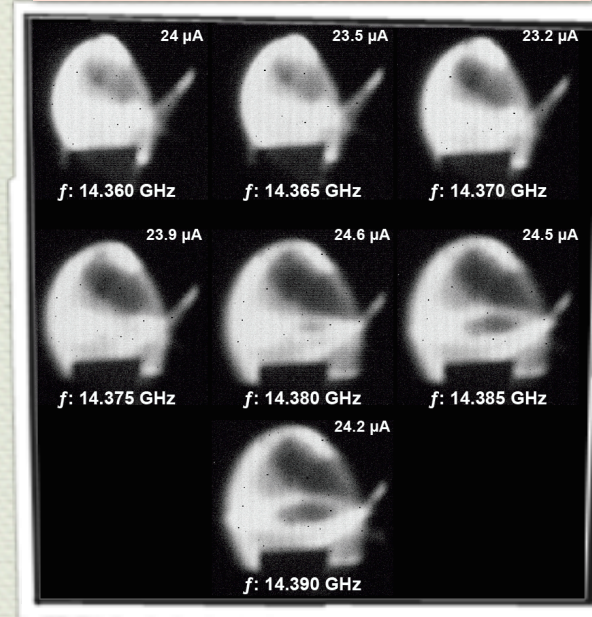


Charge breeding process



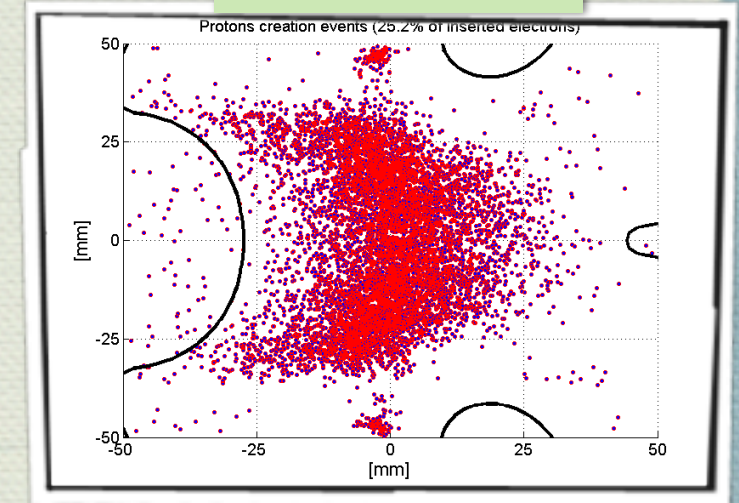
A. Galatà et al. ThuM08

Beam diagnostics



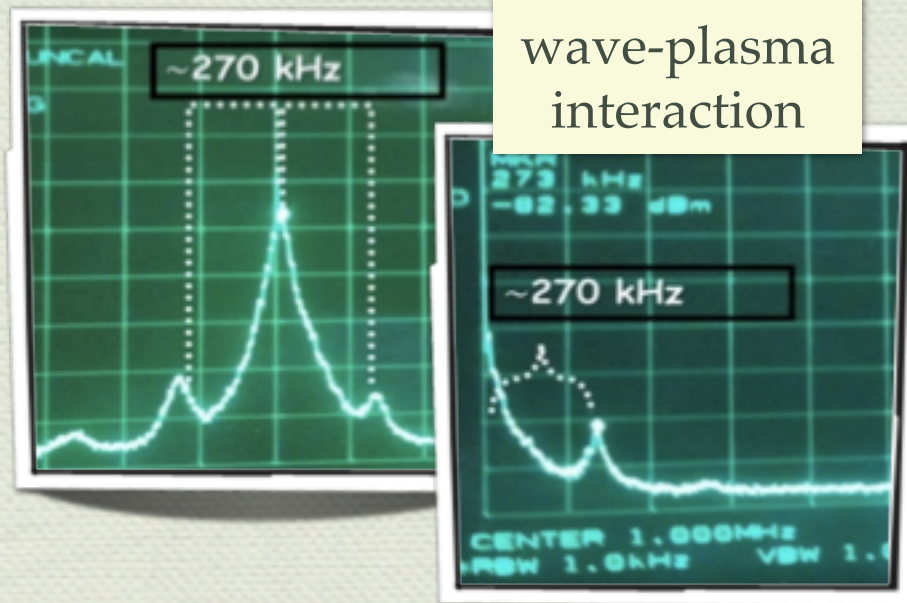
D. Nicolosi et al. MonPE21

H⁺ formation in MDIS



L. Neri et al. TuePE11

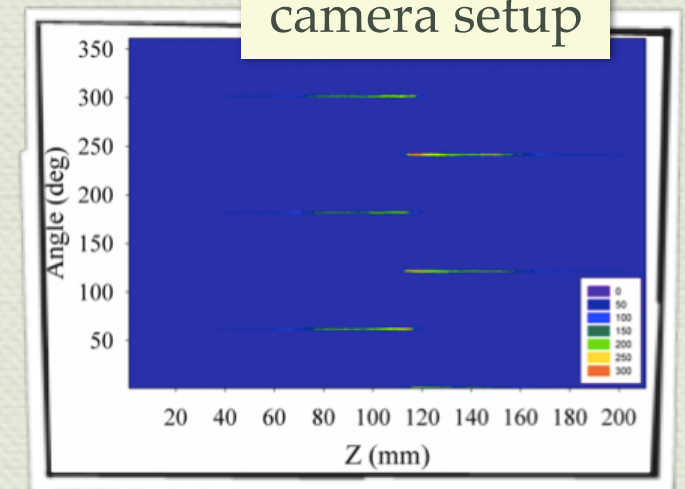
wave-plasma interaction



G. Castro et al. TuePE05

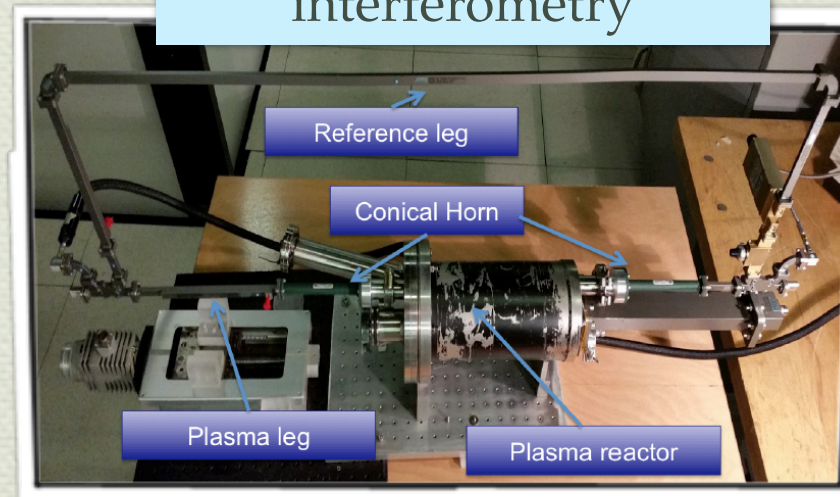
Several efforts in diagnostics and modelling

pin-hole camera setup



R. Rach et al. ThuPS09

interferometry

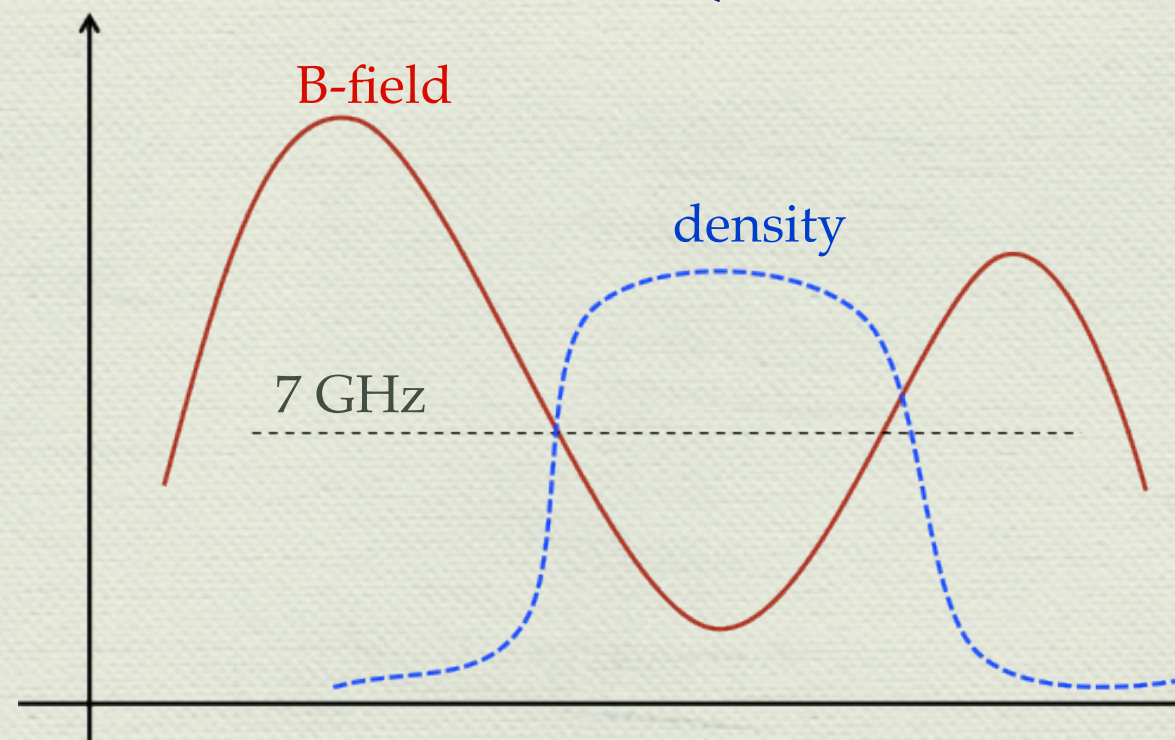


G. Torrìsi et al. TuePS27

THANK YOU
FOR YOUR
ATTENTION!!

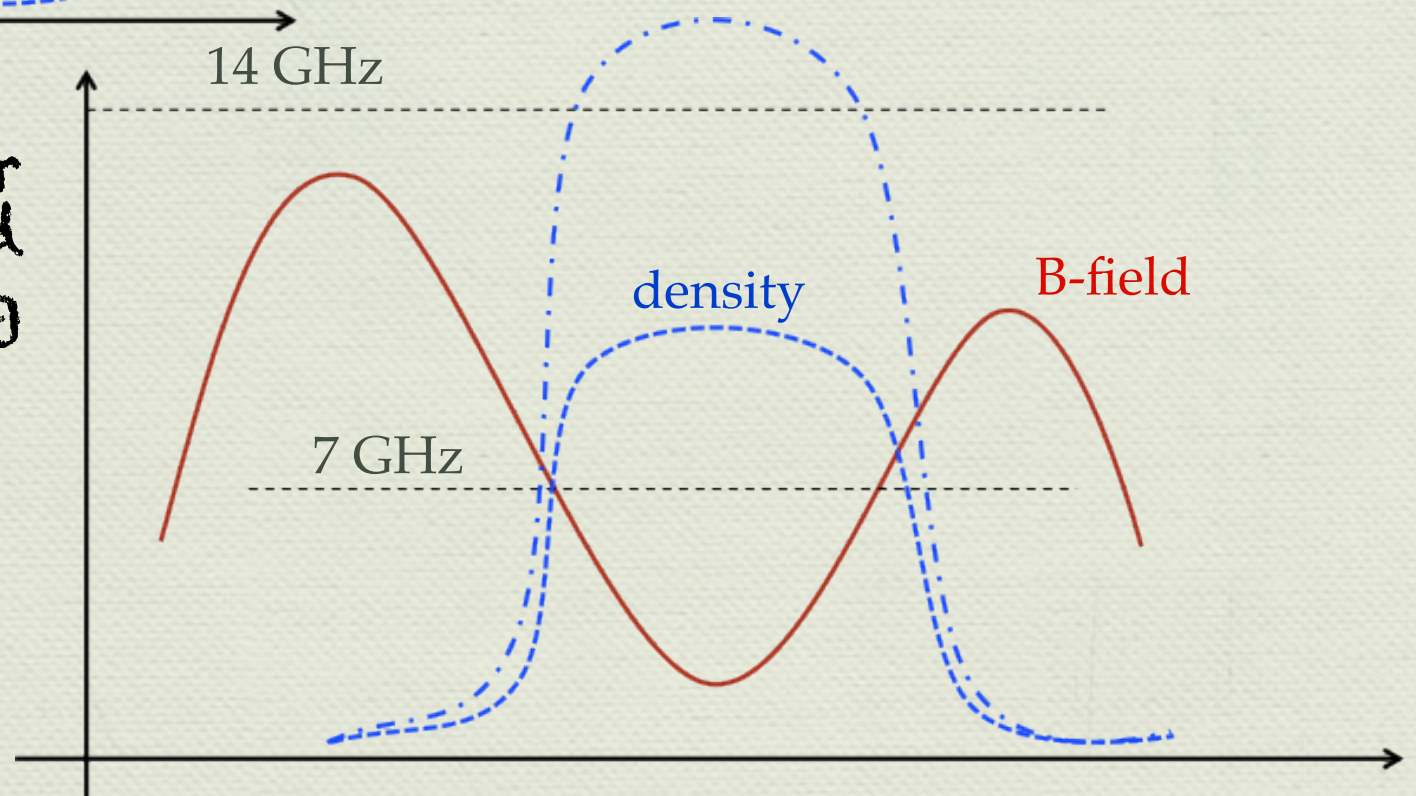
**THANK YOU FOR
YOUR
ATTENTION!!**

Boosting plasma density in a Two-Pumping-wave Scenario



Start with one frequency in order to establish a proper density profile

Launch a second wave for modal conversion and second harmonic heating

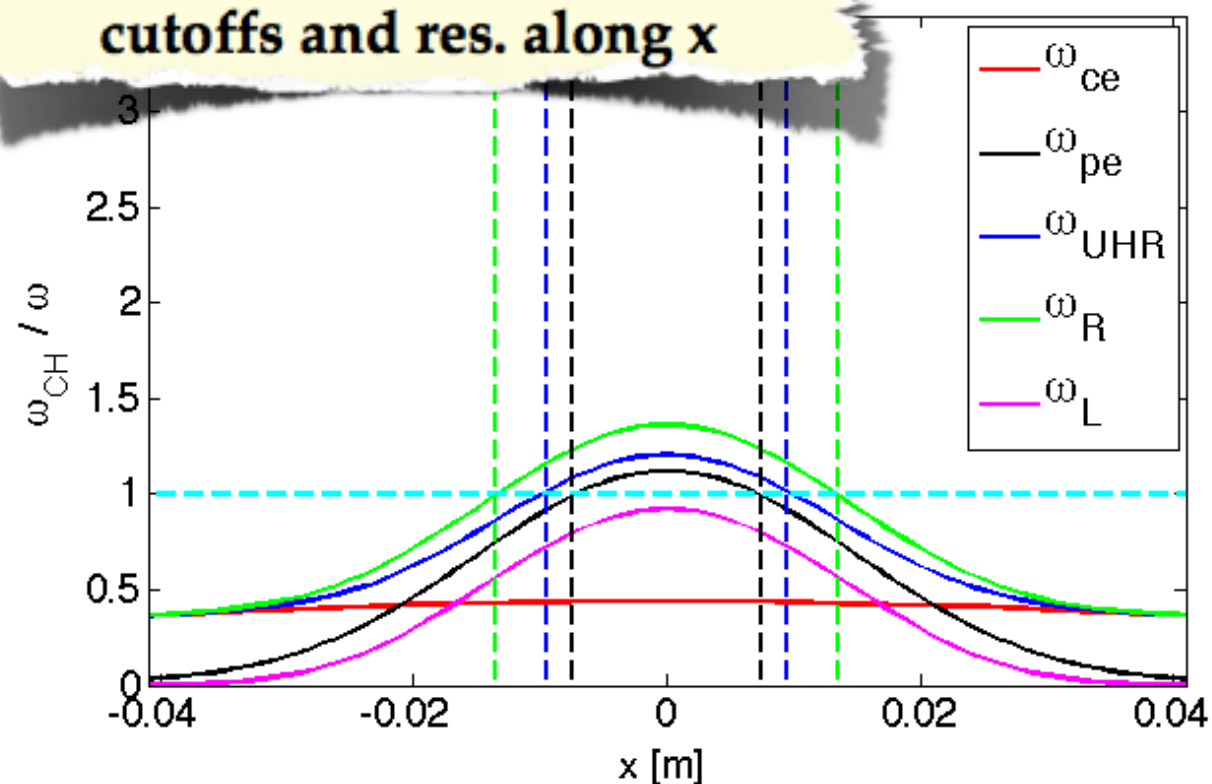


the modal conversion is a density-magnetic field profiles dependent process

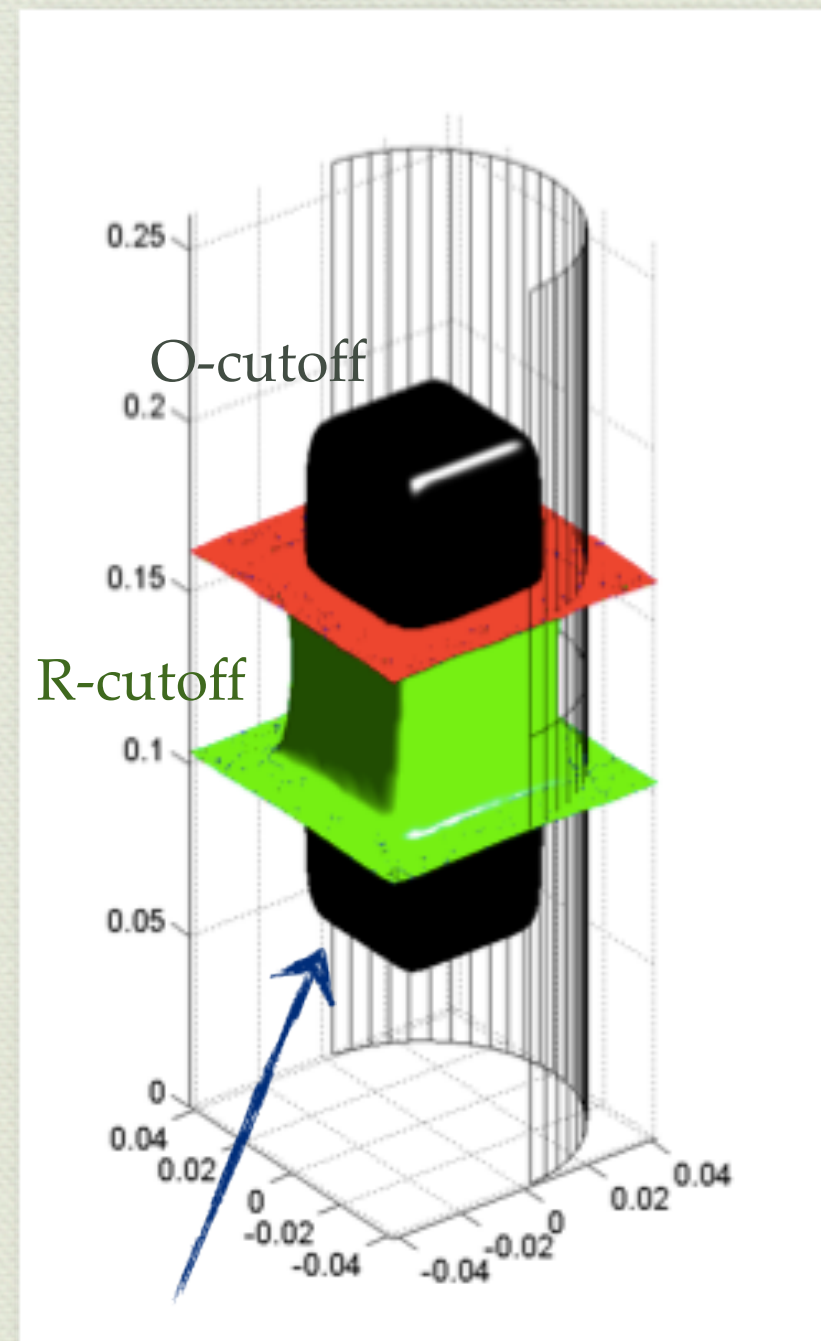
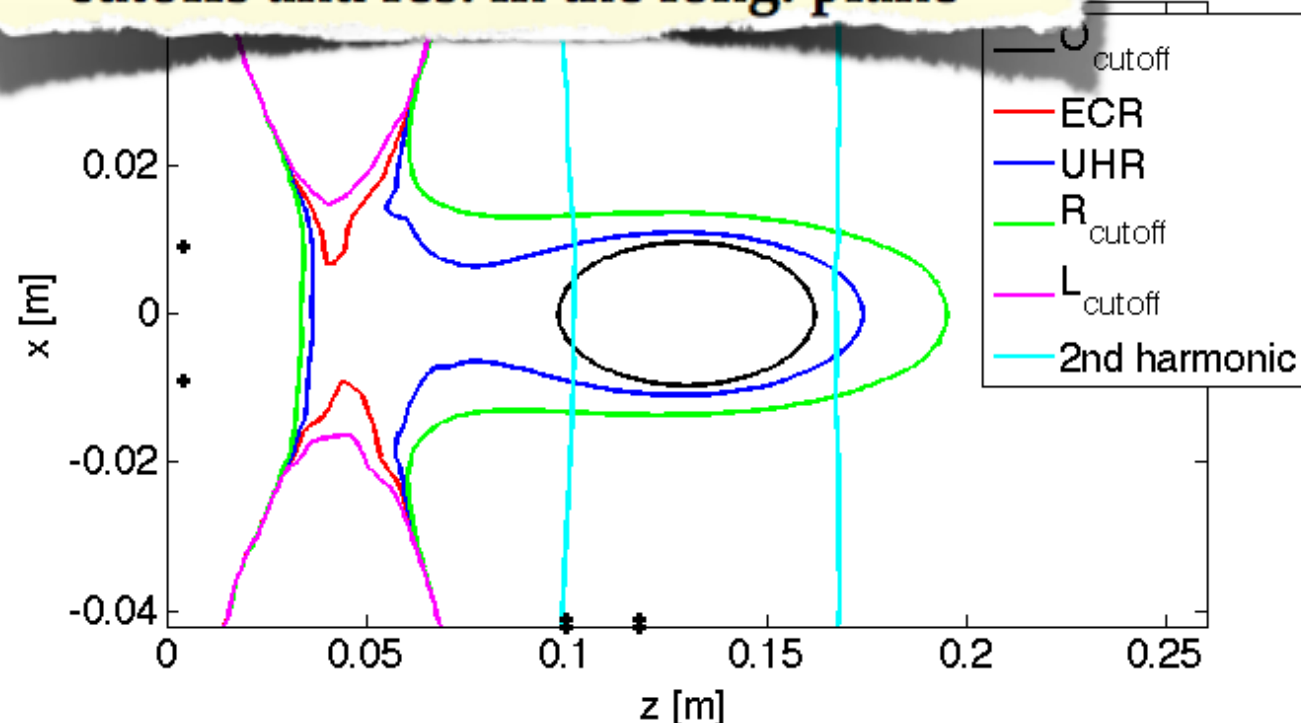
-> mastering plasma structure is mandatory for conversion optimisation

Mastering of plasma density structure

cutoffs and res. along x

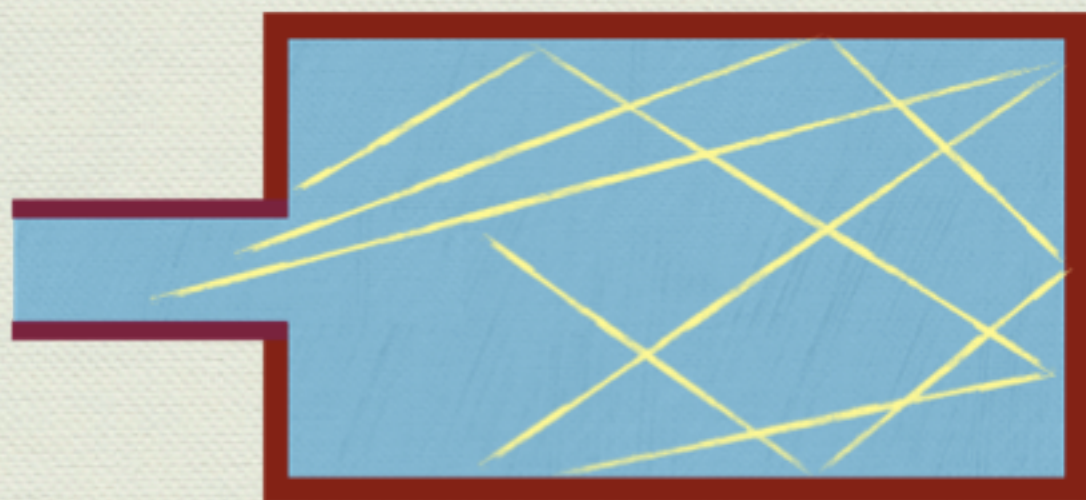


cutoffs and res. in the long. plane

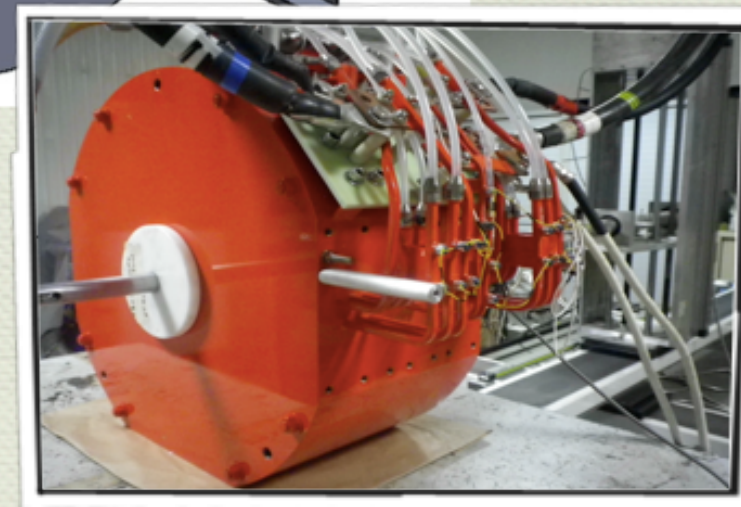
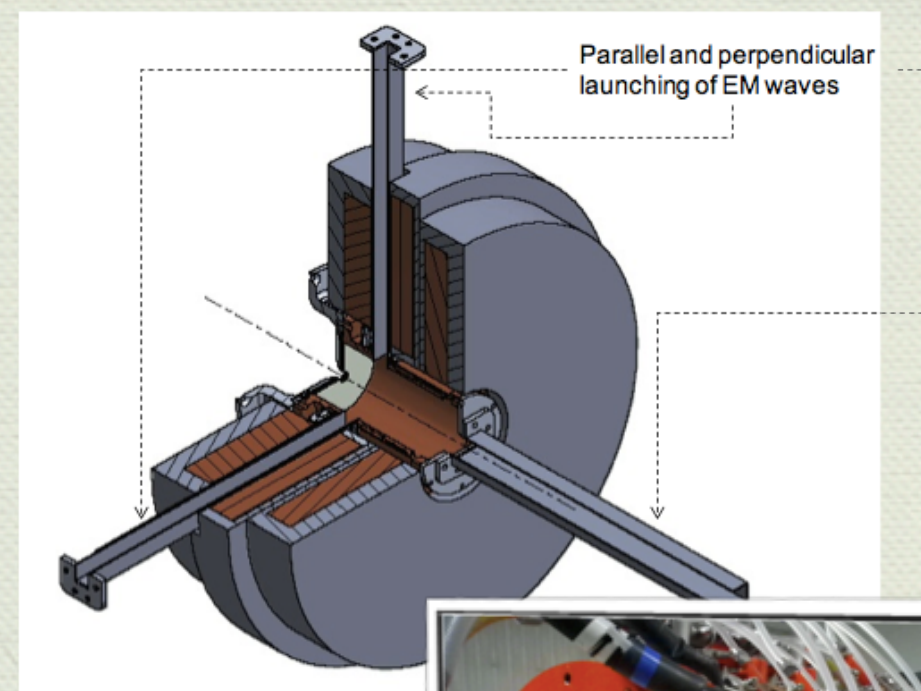


Cut-offs and resonances in 3D view

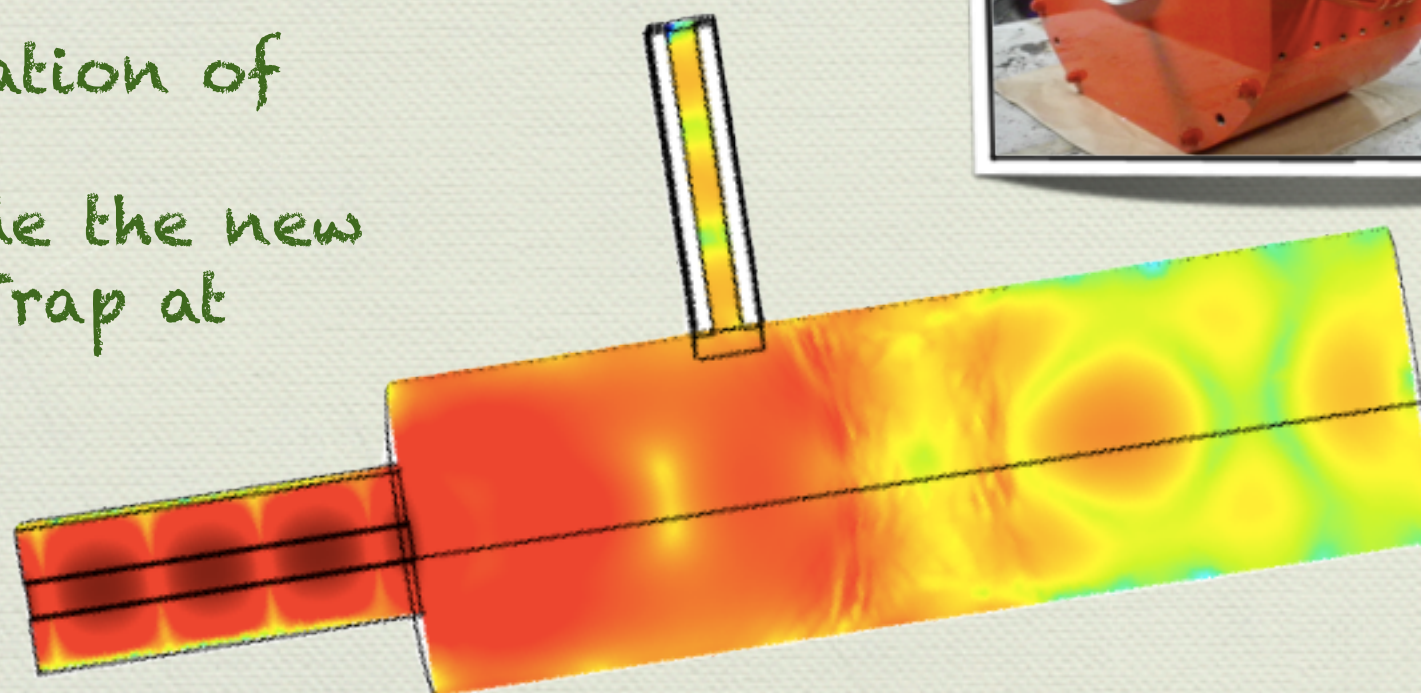
"Microwave-absorption-oriented" design



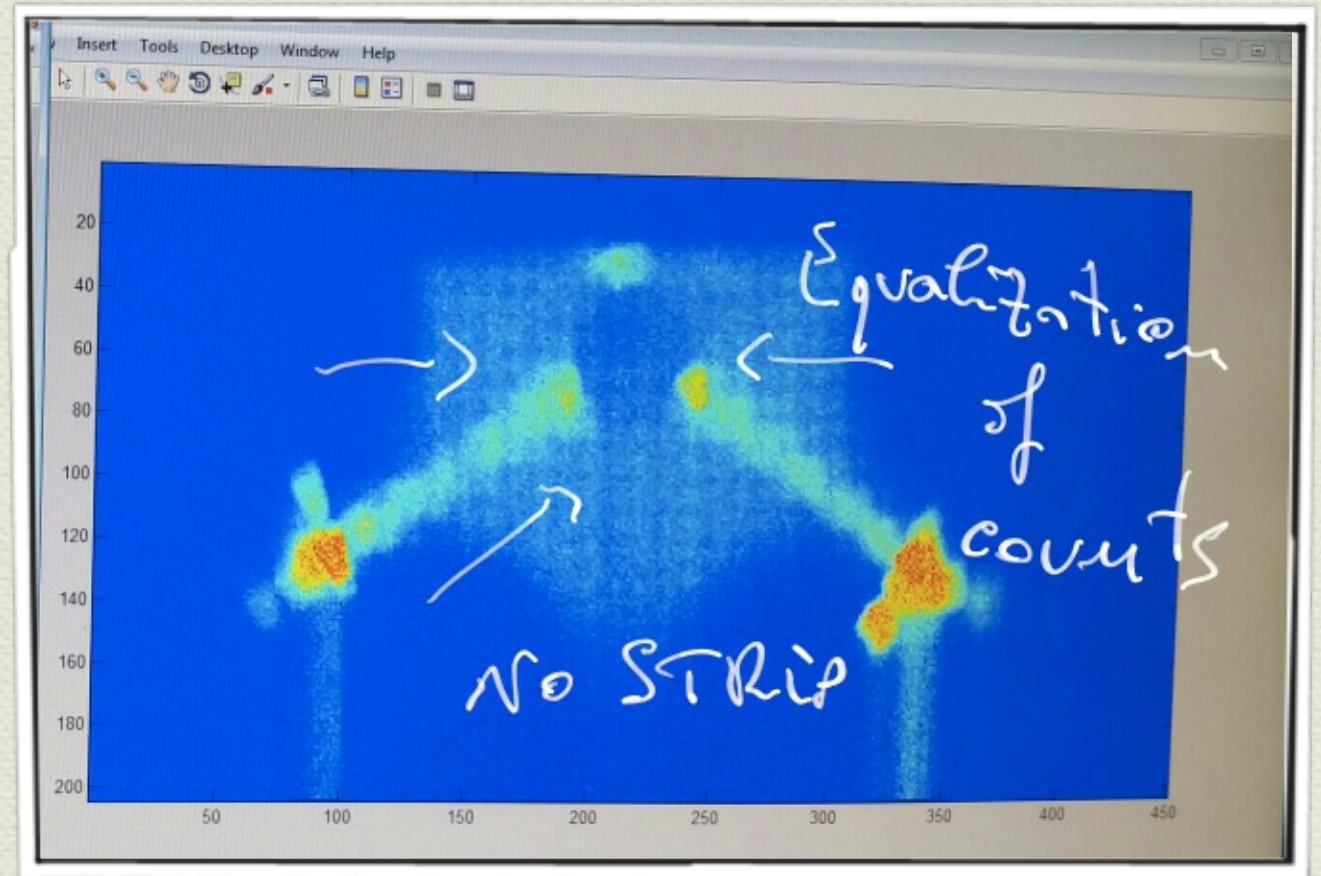
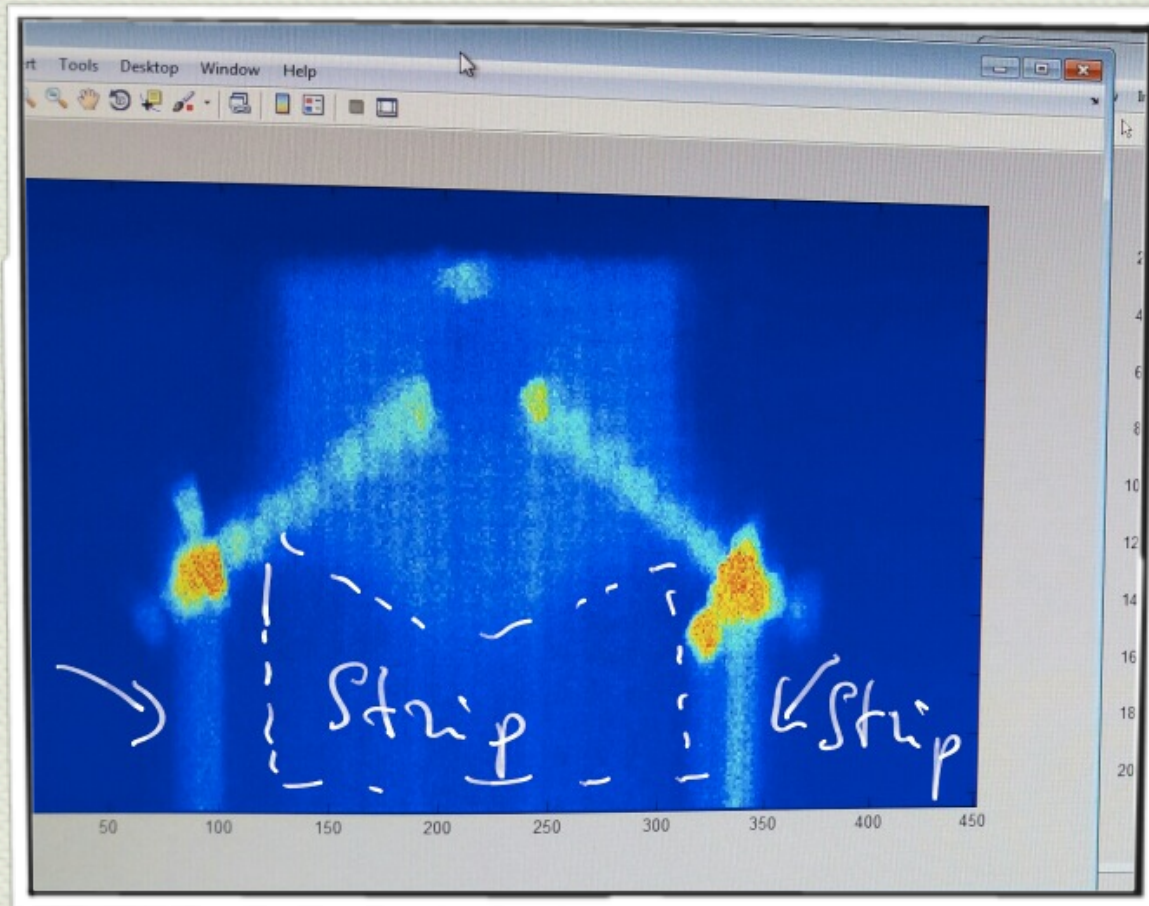
M.A. + guiding + resonator scheme



Full-wave calculation of the electric field distribution inside the new Flexible Plasma Trap at INFN-LNS



Plasma inspection after energy filtering



The image is given by the exposure time plus the CCD data transferring across the vertical registers (still active sensor). A "strip" similar to well-known astronomical photography drawbacks, appeared. Post-processing eliminated most of the unwanted counts in the photon counting images

Plasma inspection by energy filtering

Photon Counting – each picture frame is a matrix of pixels where single photons have impinged



1. A single photon can excites a group of pixels;
2. Hence, the local maximum is a 9x9 pixels submatrix is searched → in case of multi-maxima, the submatrix is not considered;
3. Each analysed frame is then summed to the others (>1000);
4. The counts frequency histogram is therefore retrieved, determining also the overall 2D image.



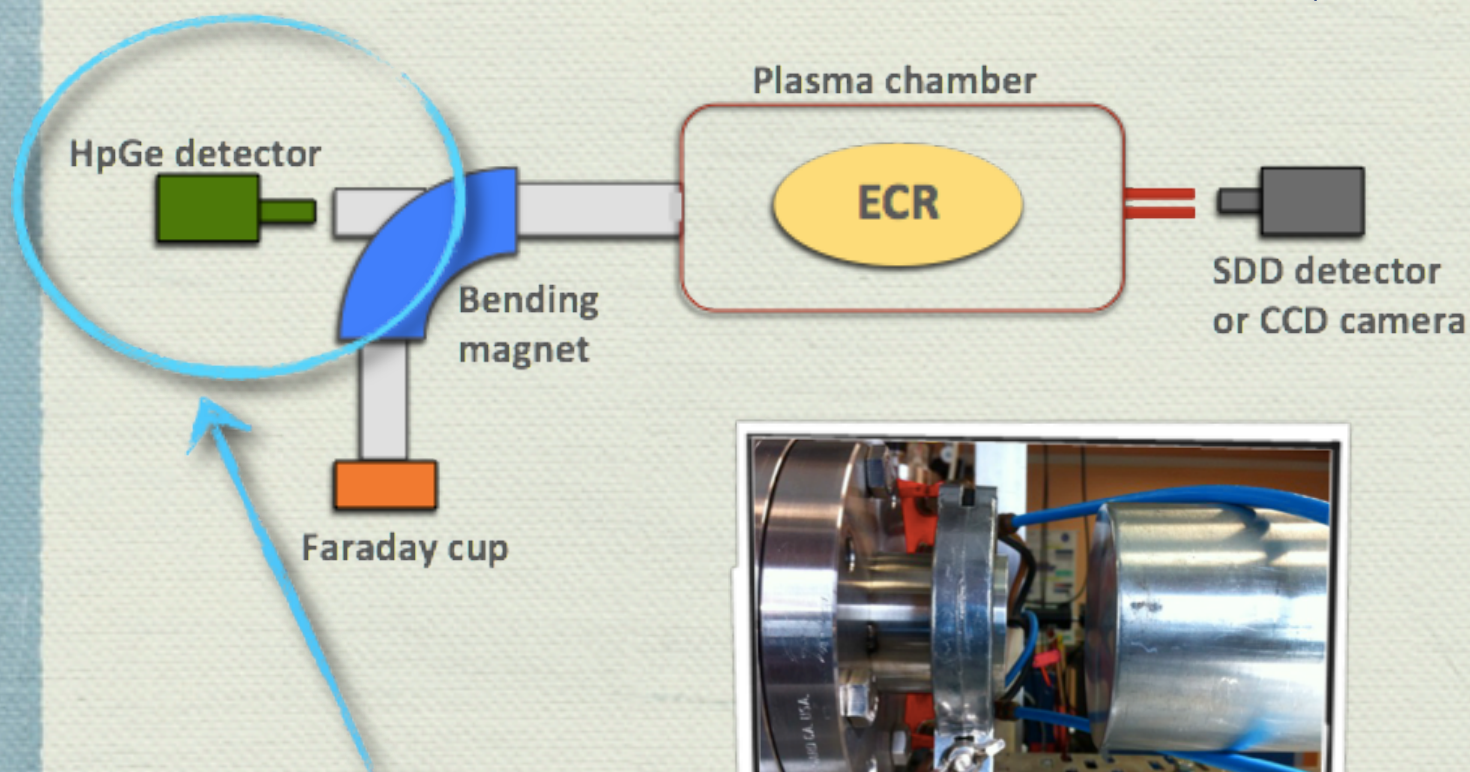
$$E(\text{eV}) = n.\text{of counts} \times E^{e-h}(\text{eV}) \times \text{sensitivity}$$

3.65 eV

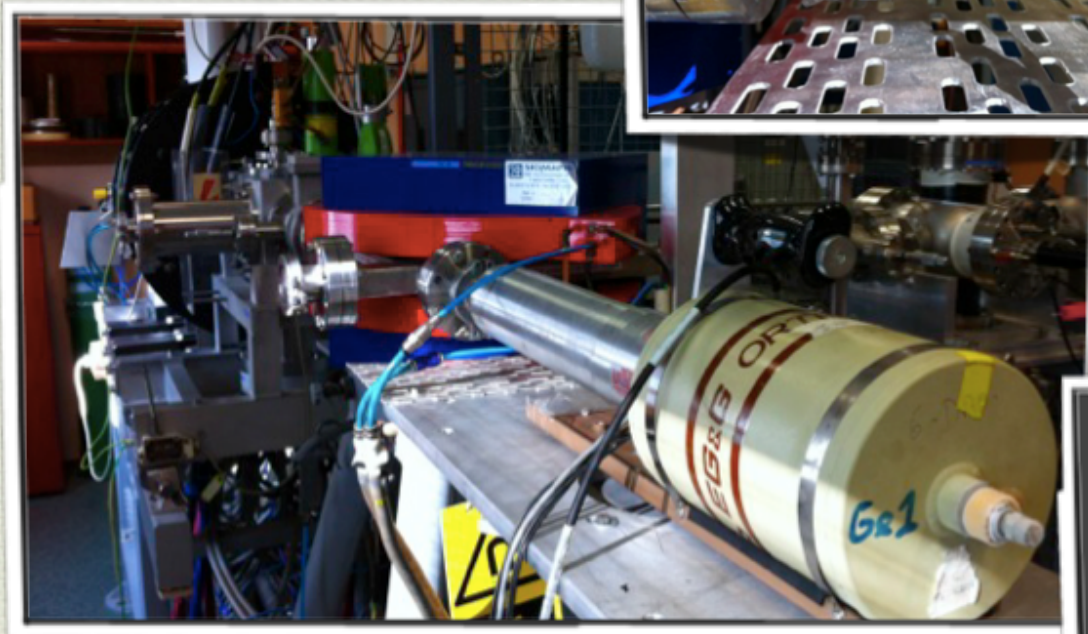
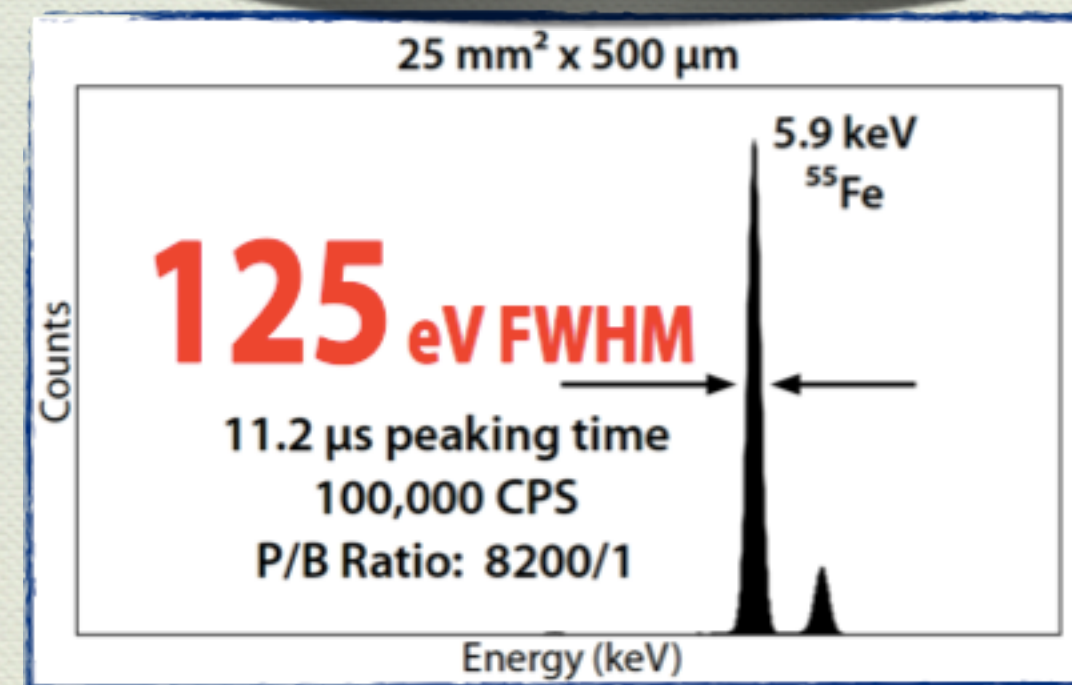
1.3

Excellent energy resolution
137 eV@Fe-K α

SDD and HpGe Set-up

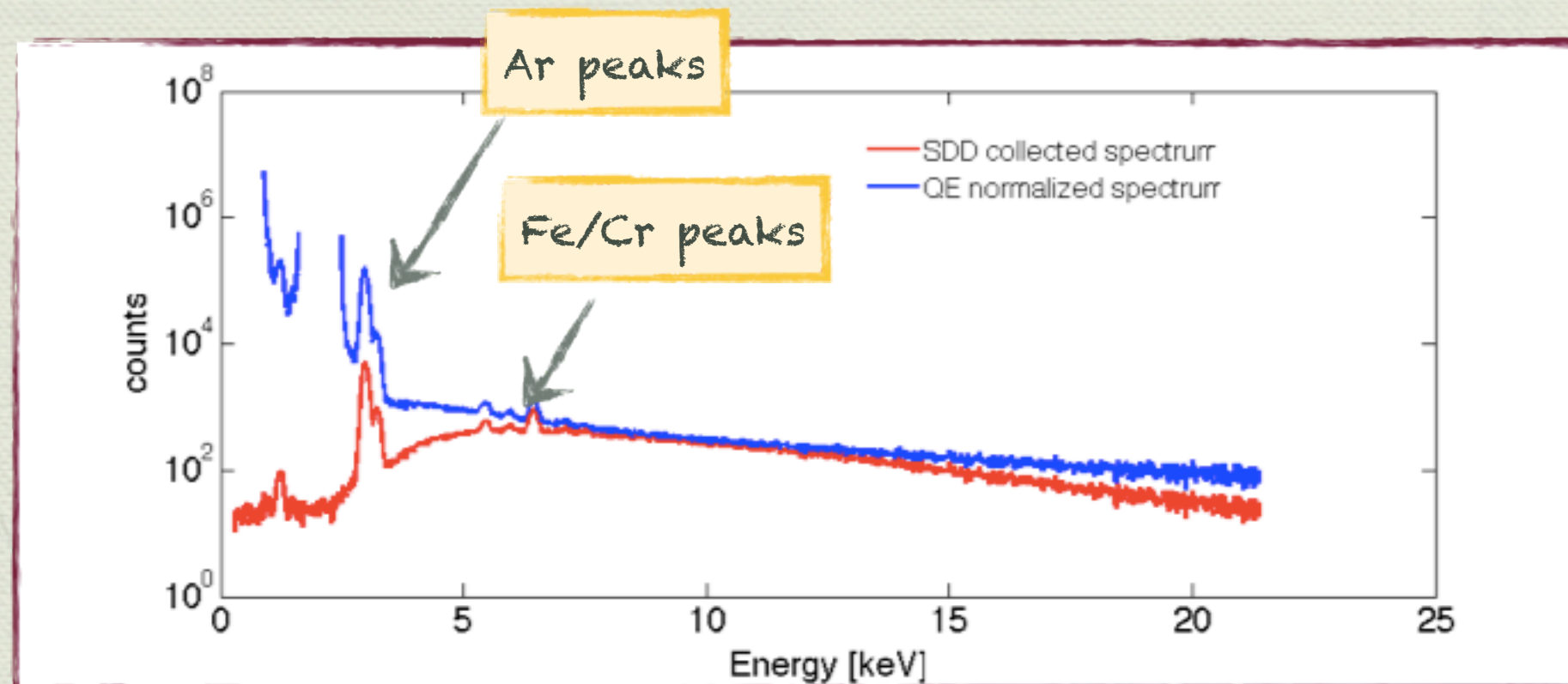
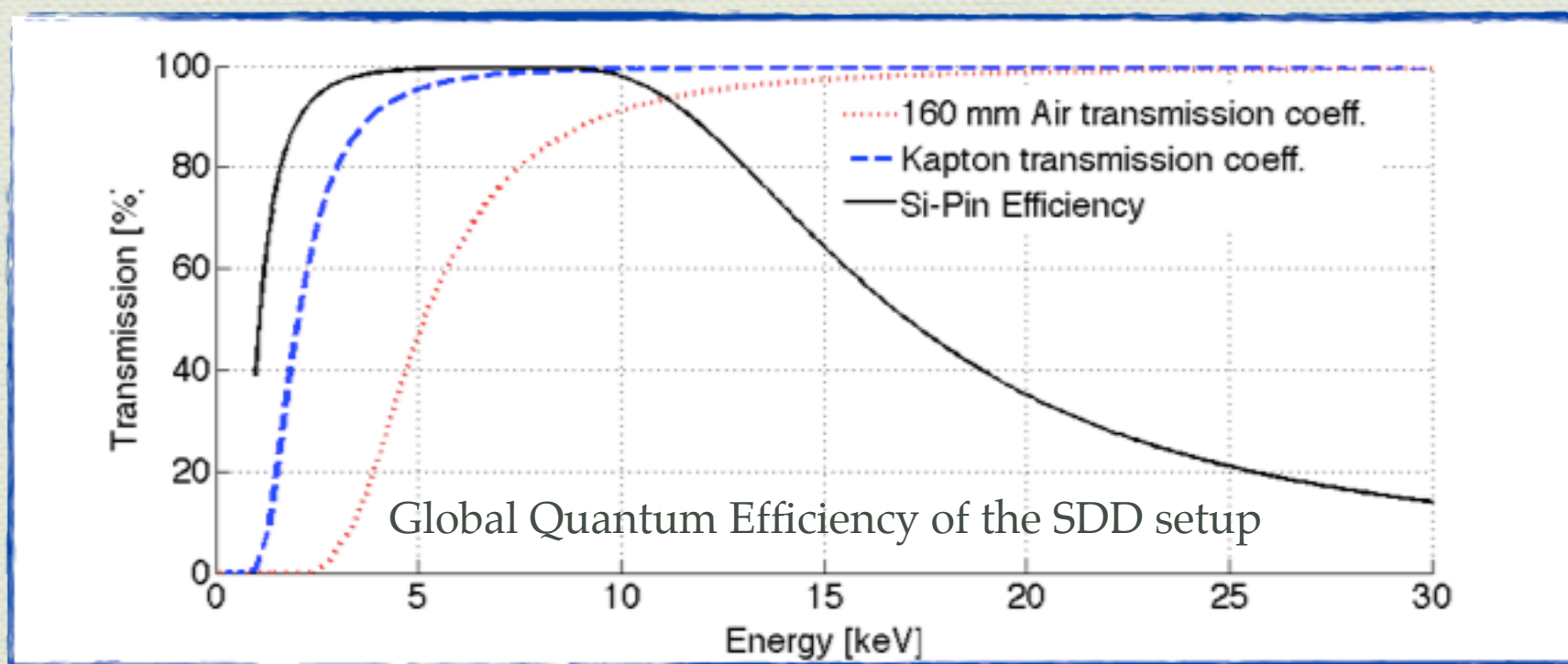


SDD - Silicon Drift Detector (SDD - 80 mm² active area) for measuring **warm X-rays** in the 2.5-30 keV domain.



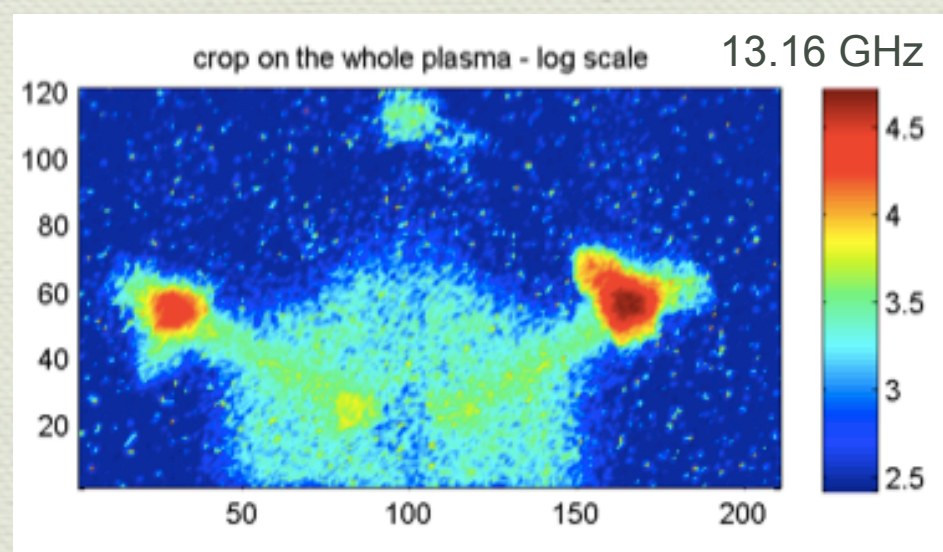
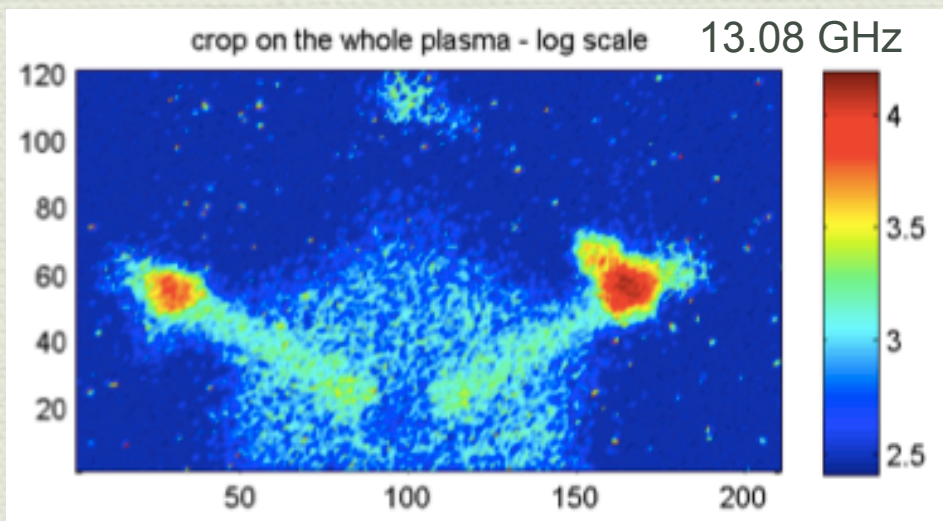
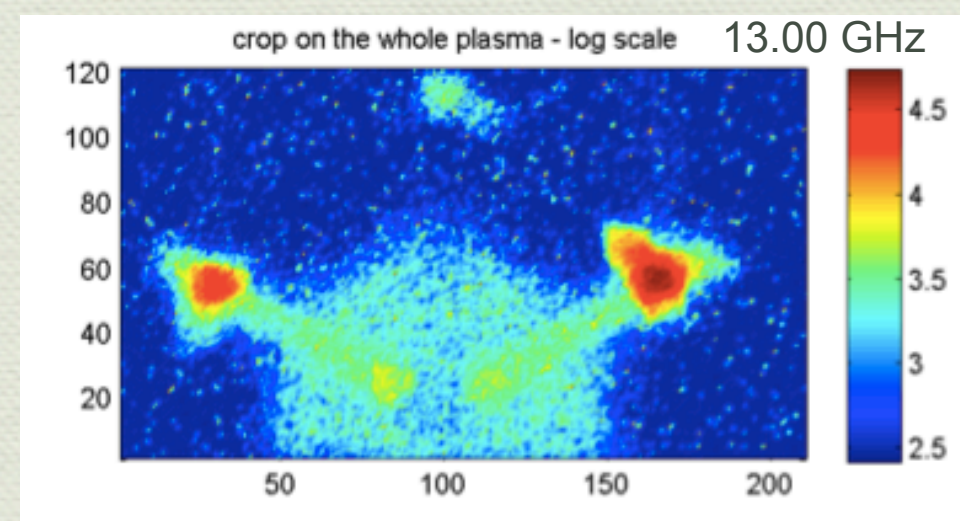
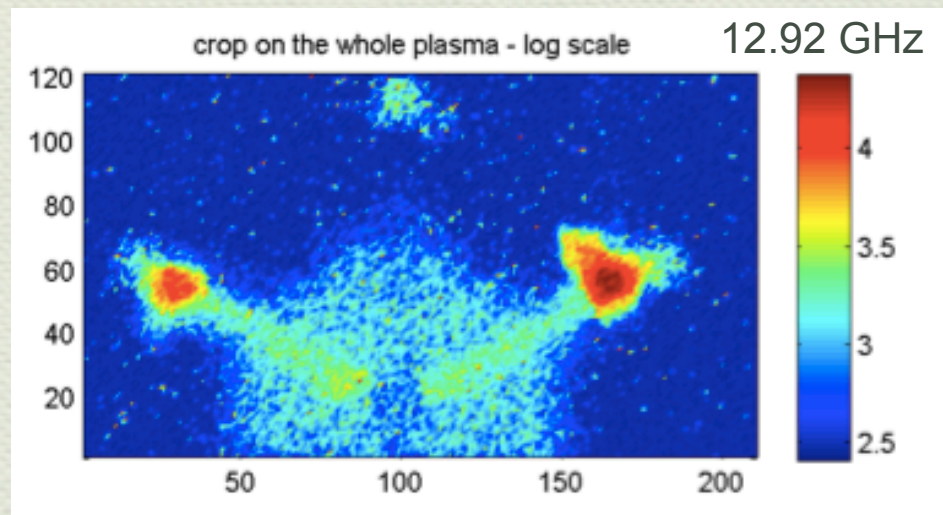
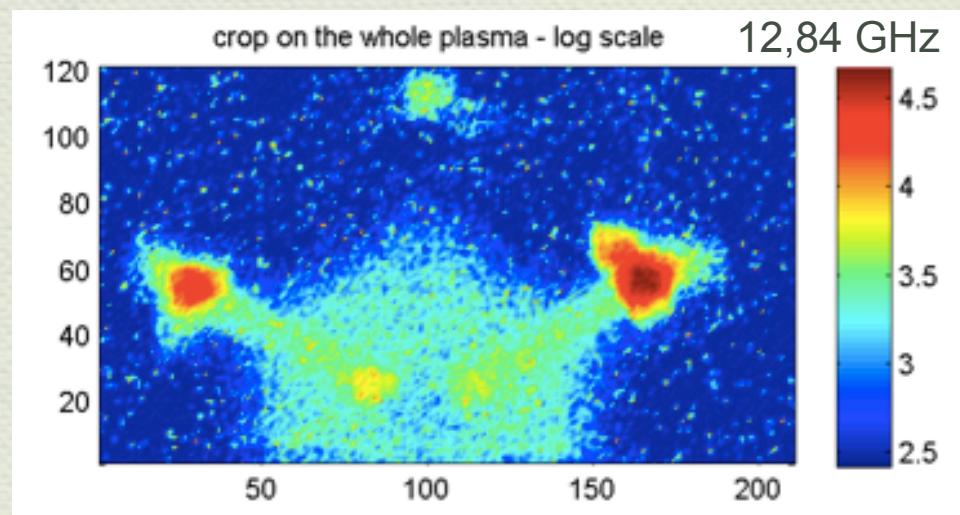
HpGe - HeGe Detector (3000 mm² active area) for measuring **hot X-rays** in the energy domain 30-400 keV

SDD/HPGe - Data Analysis



Spectral renormalization for the SDD setup

X-ray imaging



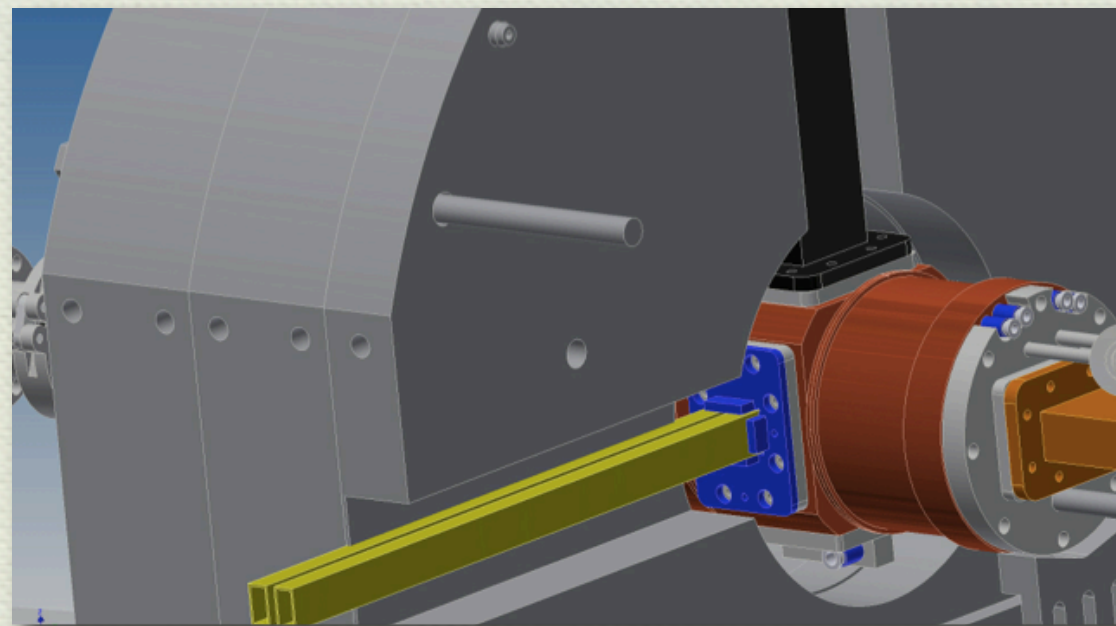
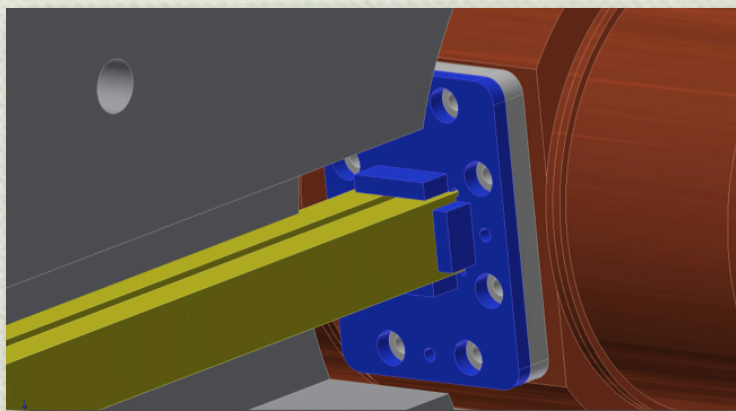
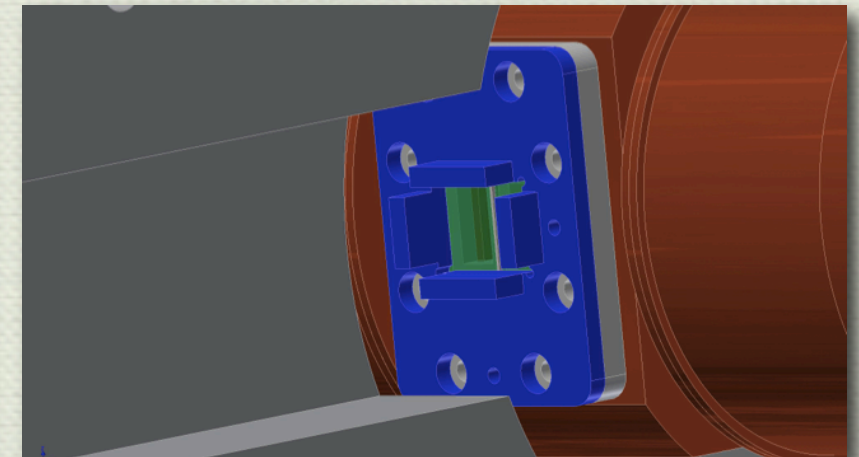
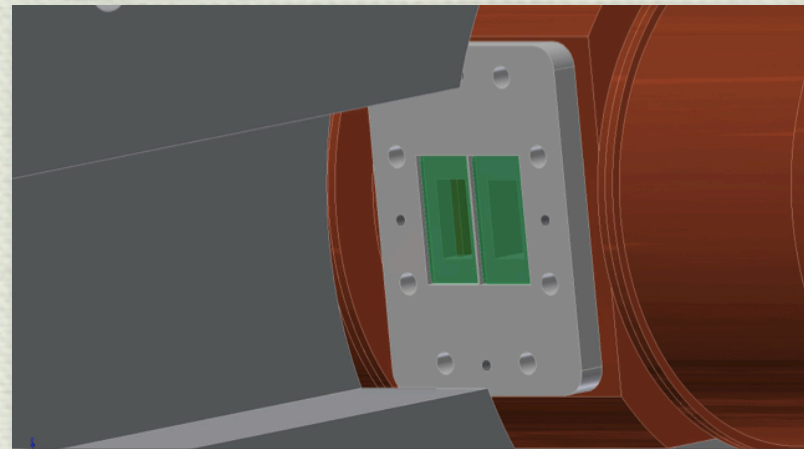
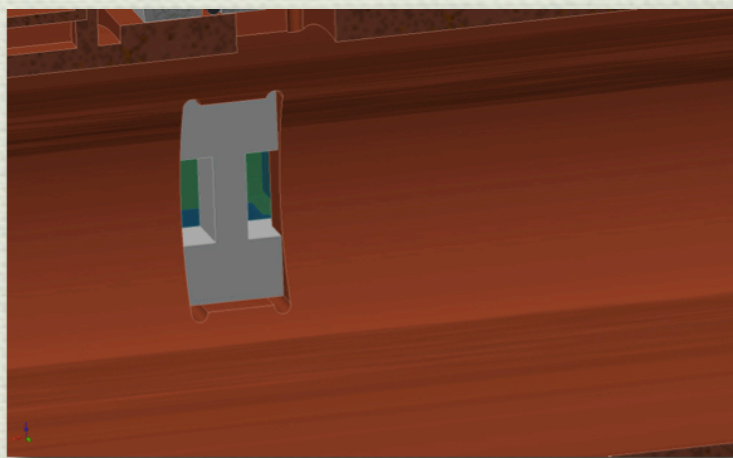
a first rough
characterization
was done with a
low
magnification:
Regions of
Interest were
settled and the
set of frequencies
for investigating
FTE was
restricted to 12.84
12.92
13.24
Gigahertz

X-ray Imaging

Preliminary results

- ✓ Magnification= 0,09
- ✓ Al-window= 6 μm

Mechanical Implementation at LNS



Parallel and Perpendicular access to the plasma chamber in order to operate in double frequency/double heating mode: **axial** ---> **ECR**, **radial** ---> **EBW-heating**